METALLOGRAPHY PRINCIPLES AND PROCEDURES

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METALLOGRAPHIC SAMPLE PREPARATION

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INTRODUCTION

Metallography, the study of microstructures, has been an invaluable tool to the progress of science and industry over the past three centuries. The question could be posed, 'Why Metallography?' The first, most obvious answer would be that a part or structure cannot be designed to a critical criteria if a given lot of material is not within specification. Metallography is one major valuable tool which can be a precise aid for:

- a) Quality control for material processing, material product and hardware.
- b) Determining reasons for failure.
- c) Advanced Technology.
- d) Prediction for better demands.

REQUISITES

The key to obtaining an accurate interpretation of a microstructure is a properly prepared specimen which is truly representative of the material being examined.

The definition of a properly prepared metallographic surface states that the section must:

- a) Be flat, free from scratches, stains and other imperfections which tend to mar the surface.
- b) Contain all non-metallic inclusions intact.
- Show no chipping or galling of hard and brittle intermetallic compounds.
- d) Be free from all traces of disturbed metal.

To insure achievement of such true surfaces, preparation must be carried out, not only with accuracy but also, with a clear understanding of what must be accomplished during each specific stage.

STAGES OF PREPARATION

The most straight-forward approach is to divide the entire process into a logical series of stages involved and the purpose of same.

Stage 1 — Sectioning

The removal of a representative sample from the parent piece.

Stage 2 - Coarse Grinding

Producing an initial flat surface.

Stage 3 — Mounting

Embedding the sample in a plastic medium for ease in manipulation and other factors such as fragility, edge preservation, etc. This stage is sometimes omitted for certain methods of preparation or in instances where it would serve no purpose.

Stage 4 - Fine Grinding

Remove the zone of deformation caused by Sectioning and Coarse Grinding and limit the depths of deformation during this stage by proper abrasive size sequencing.

Stage 5 - Rough Polishing

Further limitation of the deformation zone produced by Fine Grinding.

Stage 6 - Final Polishing

Removal of deformation zone produced during Rough Polishing. Any zone produced at this stage should be minimal and generally will be removed during etching.

METHODS OF PREPARATION

Any material can be prepared by MECHANICAL PREPARATION — hand or semi-automatic methods. The sequence of stages previously defined are necessary in their entirety for this particular procedure.

ELECTROLYTIC POLISHING may often be used as an alternate for the Rough and Final Polishing stages or an overall improvement after Final Polishing by other methods.

SLURRY (ETCH-ATTACK) POLISHING will supplement both Rough and Final Polishing in some instances and Final Polishing in others.

CHEMICAL POLISHING is usually employed after Final Polishing.

The choice of any method is dependent upon the material to be prepared and particularly the phase relationships and distribution within the existent microstructure.

Details on these alternate and supplementary techniques are more completely detailed later.

SURFACE DEFORMATION

During Sectioning, Coarse Grinding and to a lesser extent, during Fine Grinding, a transitional surface zone of deformed metal results from abrasion. Even though this deformation zone is transitional, abrasion has caused the material to exceed the elastic limit and accordingly, permanent plastic deformation has occured. Possible damage traceable to improper sectioning techniques, see Figure 1.

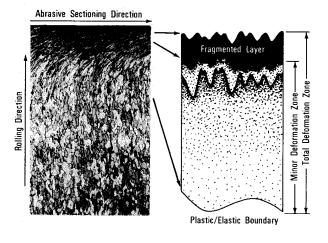


Fig. 1

According to L.E. Samuels, the abrasion effects create a fragmented layer wherein the surface grains have been broken down into sub-grains with a preferred orientation, see Figure 2. Many intermediate strains boundaries extend in rays from the "V" contours of the scratches

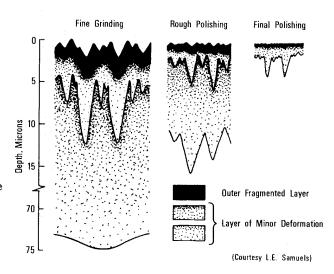


Fig. 2

The strain levels decrease as the plastic elastic boundary is approached. These strain boundaries are not uniformly distributed since the abrasive action and resultant scratch depth of each grain varies due to sizing, shape, hardness and dynamic strength. A conservative estimate would be that plastic deformation would never be less than fifty times the scratch depth.

At the conclusion of Rough and Final Polishing, the thickness of the induced fragmented layer and the accompanying zone of minor deformation have been slightly decreased. The plastic elastic boundaries will now contour the original scratches.

Scratch depths are dependent upon abrasive size and this effects the magnitude of the strain boundary levels. Scratch depth and total zone deformation can be considered inversely proportional to an increase in material hardness, see Figure 2A.

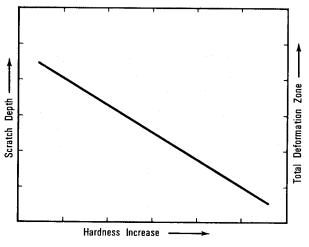


Fig. 2A

PRESSURE

There are two factors which contribute to pressure applied against a sample, the externally applied load and the adhesive pressure created by the surface tension of the vehicle (lubricant, extender). These pressures are important as they control the scratch depth and subsequently the total depth of deformation.

For the coarser abrasive sizes used in the Coarse and Fine Grinding Stages, the distance between the specimen and lap is relatively large due to the particle size. In these instances, the principle effective pressure is the specimen weight and the externally applied load.

With particle size in general use for polishing, the specimen-lap distance becomes significantly less, and this distance will approximate the particle diameter. Theoretical considerations show a sharp rise in adhesive pressure, see Figure 3.

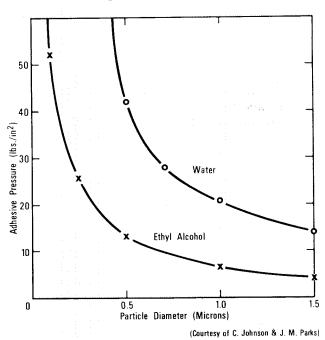
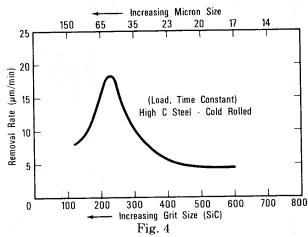


Fig.3

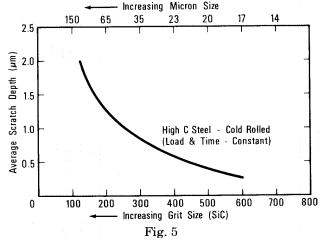
Each abrasive size and type must be considered by itself in regard to maximum feasible pressure and this pressure will show an increase with a decrease in particle size. Within reasonable pressure limitations, the depth of damage is slightly affected. Therefore, it is desirable to employ correspondingly high pressures to obtain maximum removal rates.

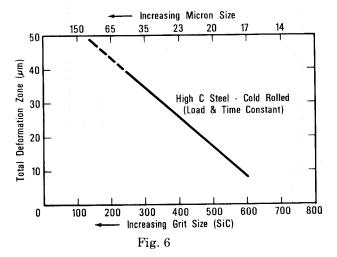
REMOVAL RATE

Material removal rate will increase linearly with pressure to a critical point and then taper off, see Figure 4.



The coarse size range (50-180 grit/350-70 microns) commonly used abrasive materials for Coarse Grinding do not have sufficient dynamic strength to prevent fracturing. When fracturing does occur due to excessive pressure, the surface may become impregnated with fragmented particles. Such fracturing can account for the low removal rates for 120 and 180 grit sizes. In normal metallographic sequencing, the use of such abrasive sizes is fortunately avoidable. One can readily start with a 240 grit which has a much higher removal rate, shallower scratch depth and consequently a decrease in total depth of deformation, see Figures 5 and 6.





ABRASIVE SIZING

The abrasive size ranges applicable to the various stages of preparation are shown in Figure 7. Comparative sizing values for the more commonly employed abrasive families appear in Table I thru IV.

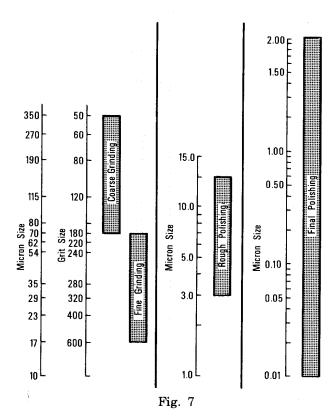


Table I
SILICON CARBIDE, ALUMINUM OXIDE, GARNET

	Partic	le Size (AV. μ	ım)	
Grit No.	USA	FEPA*		
	Sieve Series	Commercial	F-Series	P-Series
50	350	324		
60	270	274		
80	190	194		
120	115	115		
150	80	97		
180	70	81		
220	62	58		
240	54	49	49.3	58.5
280	35	41	41.5	52.2
320	29	34	34.4	46.2
400	23	29	23.0	35.0
600	17	20	14.3	22.8

^{*}Federation Europeane des Fabricants des Produits Abrasifs

Table II. EMERY

Grit No.	Particle Size (AV. μm)
3	85
2	70
1	50
1/0	33
2/0	30
3/0	28
4/0	25

Table III. DIAMOND PASTES

Micron Size* (μm)	Size Range (µm)	Mesh Equivalent (Approx.)
1/10**	0-1/0	
1/4**	0-1/2	100,000
1/2	0-1	60,000
1	0-2	14,000
3	2-4	8,000
6	4-8	3,000
9	8-12	1,800
15	12-22	1,200
30	22-36	600
45	36-54	325
60	54-80	230 - 325
90***		170 - 230

- * National Bureau Standards
- ** Ultra fine grades, not covered by NBS
- *** ANSI B 74.16 1971, not covered by NBS

Table IV. A. POLISHING POWDERS

Type	Particle Size	e Application
Gamma Alumina	0.05	Final Polishing
Alpha Alumina	0.3	Final Polishing
Alpha Alumina	1.0	Rough and/or Final Polishing
Magnesium Oxide	2.0	Final Polishing

B. POLISHING SUSPENSIONS

Type	Particle Size (µm)	Application
Levigated Alumina	5.0	Rough Polishing
Gamma Alumina	0.05	Final Polishing
Alpha Alumina	0.3	Rough and/or Final Polishing
Chrome Oxide	1.0	Rough Polishing
Chrome Oxide	0.05	Final Polishing
Chrome Oxide*	0.05	Final Polishing
Cerium Oxide**	0.05	Final Polishing

* Trade Name CRO,

Chrome Oxide / Cerium Oxide Blend

** Trade Name Finish-Pol,

Cerium Oxide / Aluminum Oxide Blend

/A\

STAGES OF PREPARATION

STAGE 1 - SECTIONING

Sectioning is the removal of a representative area from the parent piece. The microstructure must not be altered in the process. Heat or cold working are the two most likely conditions which would quickly bring about structure changes.

A. HIGH SPEED ABRASIVE SECTIONING Quite obviously operations such as sawing or shearing are not preferable due to the deformation produced. Abrasive cutting offers the best solution to eliminate or minimize heat and deformation.

To cut properly, a bonded abrasive wheel must be matched to the cut-off machine. Primary considerations are surface speed (SFM) for a given wheel diameter and the type of cooling system employed. Selection must be made from the proper family of abrasive wheels to meet the requirements for the vast variety of materials and hardness levels. The principle controlling and guiding variables for wheel selection can be classified as follows:

a) Abrasive Grain Type Al₂O₃ or SiC Grit Size e) Hardness of Bond Soft Medium Hard

b) Bond

Rubber Resinoid Resin/Rubber d) Density (Structure) Open Dense

ABRASIVE GRAIN — Aluminum Oxide is generally recommended for sectioning steels and high tensile strength materials. Silicon Carbide abrasives are used for some grades of iron, non-ferrous materials, Titanium, Zirconium, Uranium and their alloys.

Regardless of bond hardness, the coarser grit sizes will produce a harder action. However, the cutting action will be more open as the clearance of cut will be greater. Finer grits result in a softer action and a smoother surface.

BOND — The purpose of the bonding material is to hold the abrasive grains in place. In general, rubber bonded wheels are used for wet operation and are best suited for metallographic specimens. Resinoid bonds are used for dry cutting. Resin/Rubber can be used wet or dry and may offer an economy factor.

To cut clean and fast, the bond must wear away or break down rapidly enough to expose the new abrasive grains.

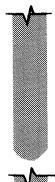
Softer bond wheels are used for sectioning hard metals and alloys whereas harder bond wheels are used for softer materials. As bond hardness increases, the wheel wear is decreased. The rate of bond breakdown is related to several factors:

- (a) Bond hardness.
- (b) Hardness and workability of sample.
- (c) Size and speed of abrasive wheel.
- (d) Power of driving motor.
- (e) Type, amount and method of coolant application.
- (f) Amount of pressure applied to wheel.

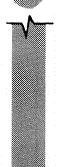
COOLING — Sufficient and proper cooling is very important. High volume jet spraying or submerged cutting are the two major techniques used. Section size, material and hardness dictate which method should be employed. Submerged cutting will tend to make a wheel bond act harder.

WHEEL SPEED — Speed (SFM) must be carefully considered both in the design of a cutter and the selection of wheels for a given cutter. In general a given wheel bond will act harder as speed is increased.

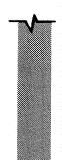
WHEEL EDGE WEAR may be used as a very good guide to indicate whether the proper wheel has been selected.



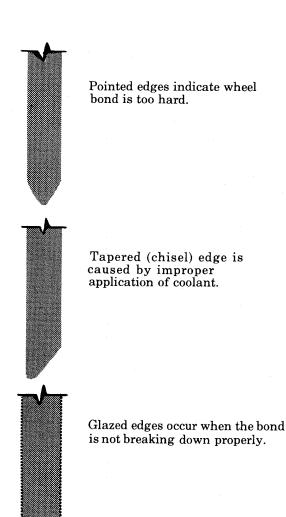
Rounded edges signify the correct wheel properly applied to the cutting of solids.



Square edges are retained on a wheel well suited to cutting both solids, sample standards and tubing of medium wall thickness.



Concave edges indicate proper wheel to section light wall tubing of thin wall sections.



B. LOW SPEED, LOW DEFORMATION, PRECISION SECTIONING

The technique of low speed sectioning for metallographic and related type specimens is patterned after principles from the precious gem industry.

Small diameter, four to six inch diamond rimmed wheels are used. The speed range is 0-1000 RPM and the load range, 0-1000 grams. The technique is applicable to many types of materials. Response is excellent to metals and non-metallics — soft, hard, brittle, ductile, porous, simple or complex configurations, composites, etc..

The resultant surfaces are extremely smooth with very little surface deformation. Tendencies toward cracking at brittle-ductile interfaces in laminated or deposited materials is nonexistent. Brittle phases within a complex microstructure do not tend to "check" or "pluck".

STAGE 2 — COARSE GRINDING

The purpose of Coarse Grinding is to remove deformation produced during Sectioning and provide the initial flat surface. A secondary purpose may often be to remove gross amounts of surface material for microsample preparation or macroetching.

The process is performed on abrasive belts or disc covered rotating wheels. The size range is 50 to 180 grit. Water is recommended as a coolant to prevent overheating of the specimen and flush away the surface removal products, thus keeping sharp abrasive grain exposed at all times.

Abrasive belts and discs are available in silicon carbide and aluminum oxide with resin bond for wet or dry operation. Garnet coated materials are only available with glue bond and can only be used dry.

The abrasive action is very aggressive with this grit range. With higher speed Coarse Grinding, i.e. increased surface feet per mirute, the resultant surface finish for a given grit size will approach that produced by a finer grit size. For example, a surface finished with 60 grit/5200 SFM would be equivalent to one produced by 120 grit/2500 SFM.

A surface which appears smooth and bright does not necessarily have the least (shallowest) amount of deformation. An apparent improved appearance can be due to rubbing or smearing of the surface by the abrasive particles not cutting cleanly. Grinding with worn or loaded abrasive surfaces will produce more extensive surface deformation.

STAGE 3 — MOUNTING (See Section B) STAGE 4 — FINE GRINDING

The abrasives used for Fine Grinding are Silicon Carbide, Emery and Aluminum Oxide. Generally, fixed type abrasives are used, i.e. the abrasive grain is bonded to a paper or cloth backing. The bonding material may be glue, resin or resin over glue. Silicon Carbide and Aluminum Oxide materials are available with either a non waterproof paper backing with glue or resin bond for dry operation; or waterproof cloth or waterproof paper backing with resin bond for wet or dry operation. Emery coatings are only fabricated with a glue bond.

Preference is for wet operation which offers a flushing action to prevent the surface from becoming

clogged with removal products. Flushing will also keep the cutting edges of the abrasive grains exposed.

Silicon Carbide abrasive grain when used wet has a removal rate twice that of a corresponding grade of Emery and provides a much shallower deformation depth.

Aluminum Oxide has a lower hardness value than Silicon Carbide which could exhibit higher dynamic strength and therefore decrease shear or fracture values; and correspondingly effect deformation depth.

STAGE 5 - ROUGH POLISHING

This stage may be considered the most important in the entire preparation sequence. The nature of the abrasive type employed should permit accurate sizing and separation by various methods into fractions of uniform particle size.

ABRASIVES

Diamond abrasives fall into the above category. Other contributing properties are high hardness, in-

ertness and low coefficient of fricton. Diamond particles retain their shape and size during abrasion and produce a uniform and high rate of material removal with minimal induced surface damage. Removal rates may often exceed those produced during the Fine Grinding sequence, see Figures 8 and 9.

SUSPENSION MEDIUM

The suspension medium for diamond powders is very important as it provides particle suspension, contributes to lubrication, and removal rate. Some adjustments in viscosity of the medium must be made for various particle sizes to compensate for possible drastic changes in heat generation.

Oil or water soluble media promote superior lubrication and removal rates in comparison to slurry suspensions. The reason being the particles are uniformly dispersed and held in a definite suspension. The paste-like material facilitates convenient charging of the polishing cloth surface and the addition of an extender contributes to even particle distribution over same.

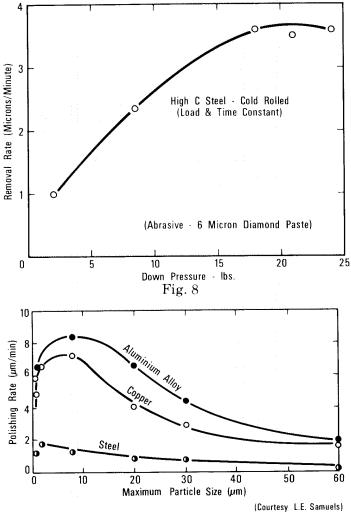


Fig. 9

ABRASIVE SELECTION

A sufficiently coarse abrasive should be selected to accomplish this stage in a minimum time. The time factor will greatly influence relief effects. However, size selection is greatly dependent upon the particle sizes and material types to be used in subsequent operations.

Particle sizes in general use are in the overall size range of 0-10 microns. The 6 micron (range 4-8) classification will produce the highest removal rates for most materials. A sharp decrease in removal rates under similar conditions is to be expected for the lower micron and sub-micron ranges, see Figure 9.

As previously stated, removal rates will increase linearly with pressure to a critical point, see Figure 4.

At the conclusion of Rough Polishing, the sample surface will naturally show scratches of visible dimensions and there will be localized deformation associated with these scratches.

POLISHING CLOTHS

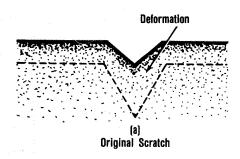
The type of cloth used for this stage has an extremely important bearing on the end result. It is imperative that relief between microconstituents of varying hardness and sample mount interfaces be held to a minimum. Napless cloths such as nylon, cotton, chemotextile materials, etc., should be used. Cloths of this nature will hold relief and undercutting at interfaces to a minimum as "pile whip" is non-existent. Selection should also be such that the cloth itself does not produce any abrasive artifacts. The hardness of the material being prepared is the guide point.

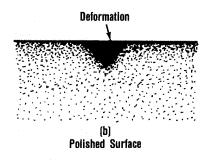
STAGE 6-FINAL POLISHING

As previously stated, the Final Polishing Stage serves to remove any deformation zone resulting from Rough Polishing. Here, a uniformly polished and scratch-free surface must be produced.

Care must be taken to insure removal of any and all surface deformation. If this is not accomplished, scratches may still be apparent in the unetched state. The same artifacts will appear and to an even greater extent if any preceding steps or stages were not properly accomplished.

Scratches may also be evident after etching. This signifies the deformed surface was not completely removed, see Figure 10. The etchant attack will be more severe and preferential along those regions of localized deformation as they possess higher surface energy levels.





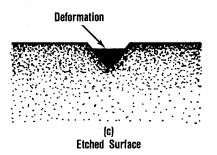


Fig. 10

A prolonged series of alternate etching and repolishing is generally discouraged as a means to remove deformation. Relief effect tendencies can accrue with an increase in number of etch-repolish cycles. Relief can also be attributable to preferential attack of the localized deformed areas or selective attack of certain phases or grain orientations.

ABRASIVES

A wide variety of abrasive materials are used for Final Polishing. The most common are Aluminum Oxide, Chrome Oxide, Magnesium Oxide, Cerium Oxide, Silicon Dioxide and Diamond.

Aluminum Oxide is the most extensively used material. Two types are available, levigated and the high purity synthetic powders. Preference is for the synthetic materials in either powder or suspension form within the one micron and sub-micron size range. Particle size and crystalline structure are dependent upon temperature. The gamma type, low temperature form, is sized 0.05 microns. The particle sizes, 1.0 and 0.3 micron, are the high temperature alpha structure. Particles are grown to size by precisely controlling the temperature range. The alpha lattice is slightly harder than the gamma form.

Ferrous, copper, titanium, zirconium based materials and super-alloys are compatible with alumina abrasives. General preference is the gamma type. However, with some materials the alpha form may be profitably used as an intermediate step.

Other commonly used media are liquid suspension of chrome oxide and chrome oxide/cerium oxide blends. In many instances, these are unsurpassed for the graphitic irons and ferrous materials containing complex inclusions or gross amounts of inclusions.

Magnesium Oxide, even though the techniques are somewhat difficult to master, is ideally suited to many materials. Aluminum, magnesium and their alloys are best prepared with this material. The powder has uniformly well shaped particles of considerable hardness and the cutting edges are well defined. Today's high temperature calcining treatments have eliminated problems formerly associated with the subsequent formation of hard carbonates. Any trace alkalis are water soluble.

Cerium Oxide slurries are a relatively new innovation as a final polishing abrasive. The blends, particularly those with small amounts of aluminum oxide, are readily adaptable to a large group of materials. The extremely fine particle size is a definite attribute. However, these solutions have not been exploited to their fullest.

Colloidal suspensions of Silicon Dioxide have been used with remarkable success in the electronic wafer industry. The material shows promise for metallography, but again, efforts have not been sufficiently concentrated for full possible applications.

Diamond abrasives have several sizing levels below the 4-10 micron range (3 micron average, 1 micron average, 0.25 micron average). The logical choice would be the sub-micron grade as this would not be too great a step from the size used in Rough Polishing. The 3 micron or 1 micron gradings would only be used if an intermediate step were desired. The finish produced by even the finest sized diamond is generally only for routine applications. Results are more satisfactory as overall hardness of the material increases.

POLISHING CLOTHS

Napped cloths are generally preferred for this operation. Unfortunately, the fibers are compressible, and therefore tend to conform to the surface of the specimen under the slightest pressure. Due to this type contact the softer phases or grains with a certain orientation have a higher removal rate than the harder phases or grains with differing orientations. Such effects can be avoided or minimized with abrasive selection to shorten the time element.

POLISHING VEHICLE

Distilled or distilled and deionized water is generally used as the suspension or extender vehicle media for those materials which are classified under the metallic oxide category.

Metallic oxides are basic by nature. Ideal polishing conditions are present when solutions are neutral pH 7. Precautions are necessary when considerable electrochemical differences are present between individual areas or phases of a specimen. Severe etching of the anodic phase may occur if the vehicle becomes ionized.

With highly reactive materials or phase relationships, it is sometimes necessary to resort to a non-polar vehicle, such as ethylene glycol. However, the polishing rate may be severely reduced. Therefore, careful observations are necessary whenever vehicles are altered to offset any chemical attack which may occur during polishing.

The problem is non-existent with diamond abrasives and oil vehicles as the particles are inert and the oil is non-ionizing.

POLISHING WHEEL WETNESS

The wetness or "trim" of the cloth with water-type extenders has a great bearing on the end result. If the cloth is too wet, the sample can show pits; if too dry, buffing and/or smearing can result.

To determine proper wetness, remove the sample from the wheel and check the time necessary for the polishing film to dry. In general, this should take no longer than five to eight seconds. To check for abrasive addition, note the color and consistency of the film. The film should not be opaque, but rather sufficiently transparent to reveal the sample shape and lustre.

When using diamond abrasives, improved removal rates are encouraged by low viscosity oil extenders. The cloth should always show a slight excess of vehicle to insure good lubricity and swarf removal.

MANIPULATION

FINE GRINDING: With manual processing, the sample is firmly held with the fingers. Movement is in a straight line across the abrading surface toward or away from the operator, see Figure 11. When manual dexterity has been achieved, motion in both directions may be employed.

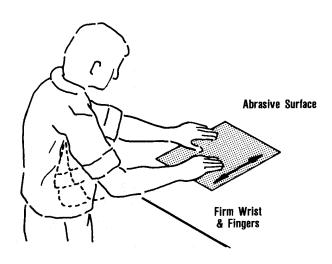


Fig. 11

The operator should be positioned to allow free passage of the elbow past the side of the body for linear coordination between the shoulder and elbow joints.

Finger and wrist joints should remain rigid and shoulder line fixed to aid in even pressure control and produce a planar surface with no faceting.

The specimen is rotated 45° between abrasive steps. The purpose is two-fold; to indicate when the abrasive scratches from the previous step have been removed and to prevent faceting, see Figure 12A.

ROUGH AND FINAL POLISHING: The rotation of the polishing wheel is normally in a counterclockwise direction. The sample should be moved in a clockwise direction around the entire polishing surface to avoid: (1) Directional traces, (2) 'Fishtailing' of certain family type inclusions, (3) "Pull-out' of phases poorly consolidated within a microstructure, such manipulation also provides equal material removal over the entire surface, see Figure 12B.

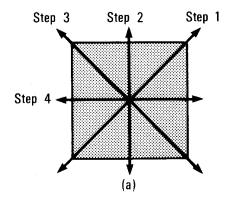


Fig. 12A

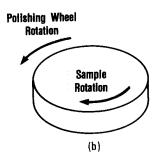


Fig. 12B

PRESSURE: Previous remarks concerning applied pressure have been made. As an overall generalization, maximum feasible pressures should be used to produce maximum removal rates.

CLEANING

GENERAL

Cleanliness is one of the most important requisites in sample preparation. Discouraging or unsatisfactory end results are more often traceable to carelessness rather than to faulty materials. Samples must be carefully cleaned between each stage of preparation to prevent contamination by coarser abrasives being carried over to a finer abrasive stage.

The role of cleanliness also includes operator's hands and equipment. The laboratory layout should be such that the extremely coarse abrasive stages are isolated from those stages involving finer abrasive material. Polishing wheels should be kept covered when not in

"A few minutes at the end of each working day should be set aside for general clean-up and monitoring of equipment. The results of the above routine practices are rewarding."

ULTRASONIC CLEANING

Ultrasonic Cleaning is the most effective system for the varying dirt problems encountered in sample preparation. The higher crystal frequencies produce better results.

There are many readily available water soluble detergents. Excellent, and sometimes more effective, commercial materials are also offered. The use of ammoniated solutions is discouraged as they exhibit etching tendencies with numerous materials.

Superior end results are obtained if more than one sample cleaning step is used. This may be very simply accomplished through use of a glass beaker and positioning cover to fit the top of the master tank. Since the glass beaker is accountically transparent, the ultrasonic energy is transmitted through the tank solution (coupling agent) to the cleaning solution in the beaker, see Figure 13.

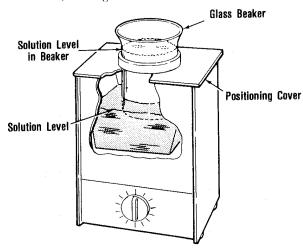


Fig. 13

EXTRACTOR-CONDENSER

The system consists of an Ehrlenmeyer flask, a siphon cup and a glass condensing coil that fits into the top of the flask. The flask is filled with solvent to a level slightly below the overflow tube of the siphon cup. The specimens are placed in the siphon cup suspended from the condensing coil which is connected to a cold water line, see Figure 14.

The flask is heated to the boiling point of the solvent. As evaporation occurs the vapors contact the chilled coil. Condensation drips the solvent into the siphon cup. As the cup fills to a predetermined level, the solvent returns to the flask carrying the oils and dirt removed from the surface and pores of the sample. Recycling continuously provides clean solvent.

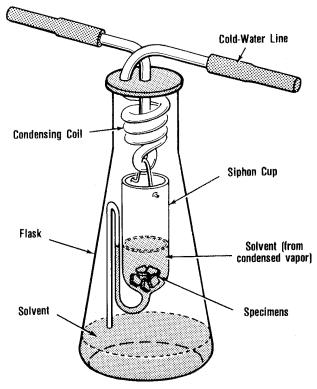


Fig. 14

DRYING

Proper drying of a surface after cleaning or etching is very important. The specimen must be dried quickly to prevent staining or corrosion. After rinsing, the sample is flooded with a high quality alcohol and dried in a stream of warm dry air. With porous materials, an additional rinse in high purity acetone after an alcohol rinse will be very beneficial.

Specimens are generally rinsed with warm water, even after Ultrasonic Cleaning. However, some materials may stain or corrode when rinsed in warm water. In such cases cooler water is recommended.

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MOUNTING PROCEDURES

SPECIMEN MOUNTING

Metallographic samples are mounted primarily for ease in manipulation and for edge protection during preparation.

COMPRESSION MOUNTING

Compression molding techniques are used to produce hard mounts in a minimum of time. The materials used are classified as: (1) Thermosetting and (2) Thermoplastic. Thermosetting media requires heat and pressure during the molding cycle and can be ejected at maximum molding temperature. Thermoplastic materials remain fluid at maximum molding temperatures and become dense and transparent with a decrease in temperature and an increase in pressure, see Figures 15 and 16.

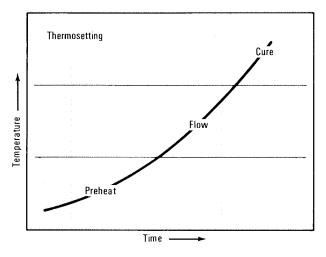


Fig. 15

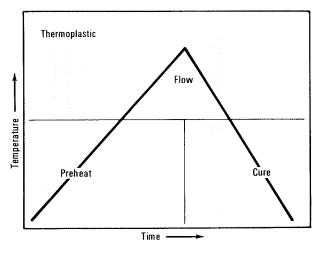


Fig. 16

The variables in compression molding are pressure, temperature and time. By mounting press design the temperature and pressure factors can be held constant.

With more fragile sections powdered material should be used. Normally powdered media should be initiated with the molds at room temperature. This practice is recommended as powdered material has an extremely large exposed surface area and consequently the individual grains, upon contact with heated molds, have a marked tendency to immediately cure without fusion.

Pre-molded thermoset preforms can be used when a section will not be damaged as it is forced into the mounting material by the initial application of pressure.

When transparency is needed for locating a particular area Lucite[®] is the best mounting medium to use. Very light pressures are used during the preheating and flow cycles. Even though high pressures are normally recommended for the cure cycle, lower pressures may be used with no undesirable effects.

The material readily flows into small areas. This factor plus the allowable pressure variances make the material very desirable for small, fragile pieces. These possibilities very often offset the longer times involved in molding transparent mounts.

Table V. Molding Temperatures and Pressures

Material	Form	Classification	Molding Temp (°F)	Molding Pressure (psi)
Bakelite®	Powder	Thermosetting	270°-300°	4200
Bakelite®	Preform	Thermosetting	270°-300°	4200
Diallyl-				
Phthalate	Powder	Thermosetting	280°-290°	2500-3000
Epoxy	Powder	Thermosetting	280°-300°	1000-3000
Lucite®				
(transparent)	Powder	Thermoplastic	280°-300°	4200*

*Cure cycle only.

THERMOSETTING MOLDING DEFECTS



Split (Radial): Section too large for mold area. Sharp corners on specimen. Use larger mold size. Reduce specimen size and eliminate sharp corners if possible.



Split (Circumferential): Material has absorbed moisture. Gases released by chemical reaction. Use preheated powders or premolds. Momentarily release pressure during flow stage.



Shrinkage (Edge): Poor adhesion to sample surface with excessive shrinkage at interface. Use lower molding temperature.





Burst (Front Surface): Insufficient pressure and/or insufficient cure time. Adjust molding pressure. Increase cure time.

Woody (Unfused): Insufficient pressure and/or insufficient cure time. Curing of powder particles prior to flow stage. Adjust pressure and/or cure time. Rapidly seal mold closure and apply pressure to eliminate localized curing.



Case Hardening & Blister: Excessive mold temperature. Decrease mold temperature. Momentarily release pressure during flow stage.

General:

If mold temperature is too high, the following difficulties may also be encountered:

- (1) Mounts sticking to mold surface regardless of finish or application of release agent.
- (2) Dull surfaces on mounts.
- (3) Case hardening of outer mount surfaces.
- (4) Excessive flash.
- (5) Mold staining..

THERMOPLASTIC MOLDING DEFECTS



Cottonball: Center portion of medium did not reach maximum temperature prior to cure stage. Increase holding time at maximum temperature.



Crazing: Inherent stresses relieved upon or after ejection of mount. Cool to a lower temperature prior to ejection. Decrease pressure during cure stage. Stress relieve mounts in boiling water.

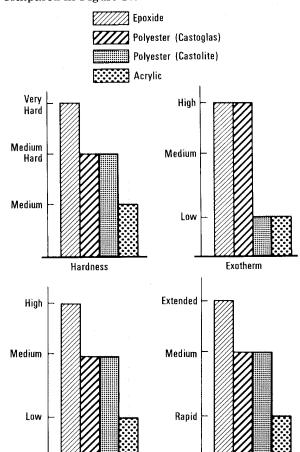
COLD MOUNTING

Cold mounting techniques offer particular advantages when a specimen may be too delicate to withstand the pressures and heat involved in compression molding. Large groups of samples may also be readily mounted when work flow can be properly

scheduled. However, the time necessary to process small groups of samples far exceeds that for compression mounting.

The three most common types of materials are: (1) Epoxides, (2) Polyesters, and (3) Acrylics. These systems are all two component types consisting of a resin and a hardener. Since an exothermic reaction during polymerization is involved, the mixing by volume or weight ratios of each system is critical. The epoxides are pale yellow and transparent. The polyesters are also transparent and available in water clear or a slight pink hue. The acrylics are opaque.

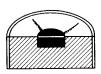
The characteristics of the common family types are compared in Figure 17.



EPOXIDE MOLDING DEFECTS

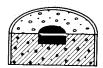
Fig. 17

Shrinkage

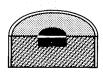


Cracking: Resin to hardener ratio incorrect. Exotherm too extreme. Correct resin to hardener ratio. Use forced cool air to control rate of exotherm.

Cure Time



Entrapped Air: Too violent agitation while blending resin and hardener mixture. Blend mixture more gently or remove air with vacuum.



Discoloring: Hardener has oxidized. Resin to hardener ratio incorrect. Keep containers tightly sealed. Correct resin to hardener ratio.



Soft Mounts: Resin to hardener ratio incorrect. Incomplete blending of resin and hardener mixture. Correct resin to hardener ratio. Completely blend mixture.

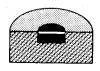
POLYESTER MOLDING DEFECTS



Cracking: Resin to hardener ratio incorrect. Exotherm too extreme. Correct resin to hardener ratio.



Discoloration: Resin has oxidized. Resin to hardener ratio incorrect. Keep container tightly sealed. Correct resin to hardener ratio.



Soft Mounts: Resin to hardener ratio incorrect. Incomplete blending of resin and hardener mixture. Correct resin to hardener ratio. Completely blend mixture.

ACRYLIC MOLDING DEFECTS



Entrapped Air: Too violent agitation while blending resin and hardener mixture. Blend mixture more gently or remove air with vacuum.

VACUUM IMPREGNATION

Many materials, both organic and inorganic, may be porous, friable, poorly consolidated, have hard and/or soft phase relationships or other extremes.

Vacuum impregnation with a suitable liquid epoxy system will produce a sample which is non-porous with excellent consolidation and rigidity. Penetration is generally sufficient for sectioning or resectioning.

The resultant high density permits preparation without plucking, tearing, fracturing or introducing other forms of sub-surface damage.

Suggested equipment is shown in Figure 18 for using Bakelite⁽ⁿ⁾ ring forms of standardized mount diameters. Aluminum or tin coated forms may be used for larger sections.

PROCEDURE

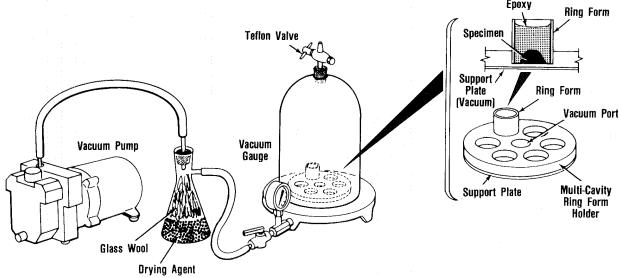
Prior to impregnation, samples should be thoroughly cleaned and if necessary, even dried.

Applying a thin film of release agent to the epoxy contacting surfaces of the specimen forms will be helpful in removing finished mounts from same. Do not coat inside diameter of Bakelite® ring forms as adhesion of epoxy is highly desirable and necessary.

The sample is placed in the ring form and the resinhardener mixture poured to a level slightly below the top surface. With bell jar in place the system is evacuated to 22 inches of mercury for at least ten minutes total holding time. Active bubbling will occur as air is removed from both epoxy and sample. Intermittent release and reactivation of vacuum will indicate when all air has been removed. Releasing the vacuum will force the epoxy into any continuous void areas. Evacuation below 22 inches of mercury may produce vaporization in an epoxy system due to exceeding the boiling point of the mixture.

CURING

The ratio of epoxy resin to hardener is extremely critical to promote proper curing as this is dependent upon the necessary exothermic reaction for proper



polymerization. The supplier's recommendation should be strictly followed and never varied.

The choice of system is closely related to the volume of material being cast. Mounts for generalized metallographic sample preparation have dimensions of 1.0, 1.25, 1.50 inches in diameter and are ½ to 3/4 inches high. With these dimensions, a low exotherm system with an air cure can be successfully used.

With larger sections higher polymerization exothermic reactions are involved to promote proper curing. A controlled curing cycle which may be programmed with an automatic timer is shown in Figure 19.

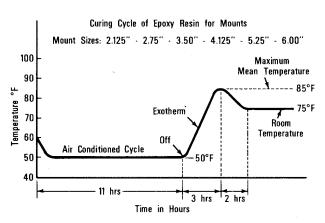


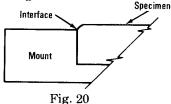
Fig. 19

The cast samples are placed in front of a small air conditioner. The reduction in temperature retards the surface exothermic reaction, preventing shrinkage and stress formation.

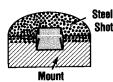
A post cure of $1\frac{1}{2}$ to 2 hours at 150° F. will fully develop the physical properties of epoxy. This is applicable to either air or force-cure mounts.

EDGE PROTECTION

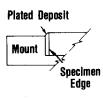
Specimen surfaces must be flat to the very edges for microscopic observation and proper photomicrography. Unless special techniques are used prior to mounting or in mounting media selection edge, rounding will occur at the sample-mount interface, see Figure 20.



The degree of rounding is dependent upon the hardness and abrasion differential between the specimen and the mounting material.



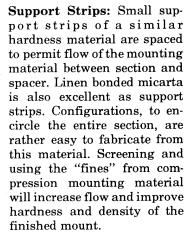
Steel Shot: This technique serves the same purpose as the following suggestion.

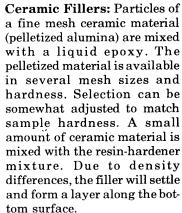


Electro or Electroless Deposition: The section is plated with a coating sufficiently thick to compensate for edge rounding during preparation. The more common materials are Ni and Cu. Nickel will sometimes peel away from a surface due to its stressed condition. Copper is generally used for post-plating electronic gear to preserve edges on single or multi-coated depositions.

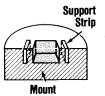
Commercially available electroless coatings are generally stress free. Selection of plating material should be given prior thought regarding etchant rate and reaction with the different metals involved.

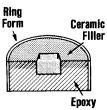
Glass Filled Mounting Media: Thermosetting mounting media with special filler additives will often offer sufficient edge support to prevent rounding. Straight mineral filled epoxies are also helpful if allowed to post cure at room temperature to increase the hardness level.

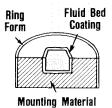








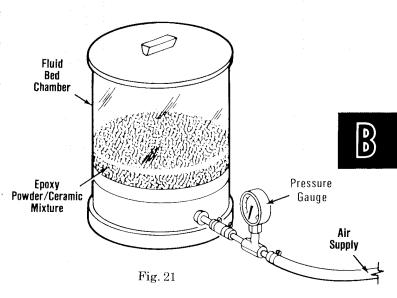




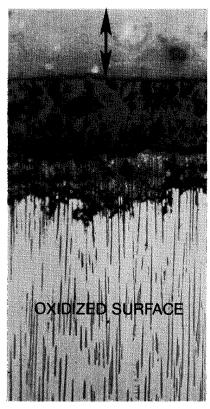
Fluid Bed Coating: A process wherein a fine epoxy powder mixed with a ceramic filler (pelletized alumina) is used to coat a sample. The coating will adhere to practically all surfaces and there is no necessity to electroclean or etch for adherence. Suggested equipment is shown in Figure 21.

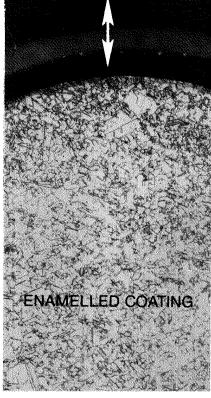
The sample is oven pre-heated to 300° F. for 20 minutes. Next, it is quickly immersed in afluid bed apparatus which contains the epoxy-filler mixture. As the system is aerated the mixture will deposit a coating as long as the specimen surface temperature remains at 300° F. Replacement in the oven at the 300° F. temperature level will bake and harden the coating. Standard compression mounting procedures of 285° F. do not effect the coating.

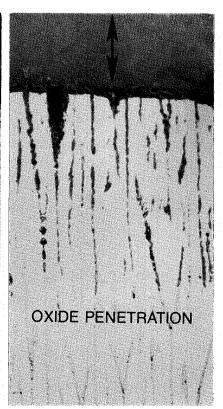
If it is desirable to coat a material which will not maintain a 300° F. surface temperature, a dip or spray with high temperature aluminum paint will permit fluid bed coating.



FLUID BED COATING







X 150 Co-Ta-Carbide X 150

Cu Wire

X 400

Co-Ta-Carbide

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I. POLISHING PROCEDURES FOR FERROUS MATERIALS

FINE GRINDING

	I III GIVII	
Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit SiC 400 grit SiC 600 grit	Paper or Disc (waterproof) Paper or Disc (waterproof) Paper or Disc (waterproof)	Water Water Water

REMARKS:

- (a) Al₂0₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action is less severe on some materials.
- (b) Emery-Coated Products Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. These materials are for dry operation. Material removal rates are much less than either SiC or Al₂0₃.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste 6 (µm)	Nylon Cloth	Lapping Oil
	FINAL-POLISHING	
Abrasive & Size	Lap or Wheel Covering	Lubricant
		Distilled or

SUGGESTED DEVIATIONS:

GRAPHITIC CAST IRONS (Courtesy J. C. Moore, LECO CORPORATION.)

FINE GRINDING:

- (a) 240, 320, 400, 600 grit SicC or Al₂0₃ paper or disc with water as lubricant. Clean thoroughly and dry.
- (b) Etch rather heavily. Use 4% Picric Acid Solution for pearlitic matrix materials and 4% Nital Solution for ferritic matrix materials.
- (c) Abrade on 4/0 Emery Coated paper dry. After a short period of abrasion clean abrasive surface with cotton swab saturated with alcohol. Repeat etching, abrasion and cleaning until the graphite flakes, nodules or temper carbon show definite retention and uniform matrix finish. Clean samples thoroughly.

ROUGH POLISHING: Etch sample lightly as recommended above. Precondition synthetic velvet cloth with one micron diamond paste. A water soluble extender is recommended as oils may penetrate and stain graphite particles. Carefully observe condition of graphite. Use alternate etch and repolish if necessary. Clean sample thoroughly.

FINAL POLISHING: Etch sample lightly. Precondition synthetic velvet cloth with 0.25 micron diamond paste, use water soluble extender. Repeat alternate etch and repolish as necessary. Polarized light will clearly reveal the condition of the graphite as it is anisotropic. Staining can occur during etching as graphite can absorb Nital.

GALVANIZED COATINGS

- (a) Water should not be used as a lubricant at any stage due to staining effect or corrosion effect of the coating. Kerosene or lapping oil are good alternates.
- (b) Rough Polishing: Silk cloth as lap covering, 0.3 micron Alpha Alumina as abrasive and filtered kerosene as lubricant.
- (c) Final Polishing: Synthetic Velvet as lap covering, 0.05 micron Gamma Alumina as abrasive and a mixture of alcohol and glycerine as lubricant.

STAINLESS STEELS, STAINLESS STEEL CASTING ALLOYS, HEAT RESISTING ALLOYS

- (a) Rough Polishing: Superior results can often be obtained by sequencing through 9 micron and 3 micron diamond paste with nylon cloth as lap covering and lapping oil as lubricant.
- (b) Final Polishing: Sequencing through 0.3 micron Alpha Alumina and 0.05 Gamma Alumina, Lecloth® as lap covering and distilled or deionized water as lubricant.
- (c) Check the possibilities of Electropolishing, particularly with solid solution alloys and transformed structures.
- (d) Check the possibilities of Slurry (Etch-Attack) Polishing particularly with wrought heat resisting alloys.

II. POLISHING PROCEDURES FOR COPPER BASED MATERIALS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂0₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action is less severe on some materials.
- (b) Emery-Coated Products. Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. These materials are for dry operation. Material removal rates are much less than either SiC or Al₂0₃.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste 6 (µm)	Nylon Cloth	Lapping Oil
	FINAL POLISHING	
Abrasive & Size	FINAL POLISHING Lap or Wheel Covering	Lubricant

SUGGESTED DEVIATIONS

- (a) Check the possibilities of Electropolishing particularly with microstructure amenable to same.
- (b) Electropolishing may also be used to distinct advantages with many materials which may have been processed through the Rough and Final Polishing Stages by Mechanical Methods. Response to extremely short cycles is many times advantageous even with those structures containing finely dispersed intermetallic compounds and complex phase relationships.
- (c) Check the possibilities of Slurry (Etch-Attack)
 Polishing as a means to remove deformation or to
 process multi-material sections.

III. POLISHING PROCEDURES FOR ALUMINUM AND MAGNESIUM BASED MATERIALS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂O₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action is less severe on some materials.
- (b) Emery-Coated Products. Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. These materials are for dry operation, however, kerosene may be used for lubricant with resultant decreased paper life. Material removal rates are much less than either SiC or Al_20_3 .

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste 6 (µm)	Nylon Cloth	Lapping Oil
		<u> </u>

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Magnesium Oxide 2.0 (μm)	Lecloth® (flocked cotton sateen)	Distilled or Deionized Water

REMARKS:

- (a) Aluminum polishing wheels are recommended to eliminate electrochemical reaction between the sample and wheel. A thin insulating plastic material or aluminum foil between the bronze wheel and wheel covering would accomplish the same.
- (b) The conditioning of wheel covering differs from standard procedures. The entire surface should be premoistened with distilled or deionized water. The MgO powder is dispensed in the center of the wheel, moistened and worked into a heavy, creamy consistency.

- (c) The sample is skidded over the surface and the abrasive is moved outward. The sample edges are slightly beveled to aid hand manipulation.
- (d) Light pressure must be used as many optical identifications of intermetallic compounds are dependent on standardized oxide film colors. These colors are not reproducible under heavy pressure.

IV. POLISHING PROCEDURES FOR TITANIUM, ZIRCONIUM, HAFNIUM AND ALLOYS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂O₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action is less severe on some materials.
- (b) Emery-Coated Products. Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. Material removal rates are much less than either SiC or A1₂O₃.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste 9 (um)	Nylon Cloth	Lapping Oil
Market Art and Art are	FINAL POLISHING	
Abrasive & Size	Lap or Wheel Covering	Lubricant
Alpha Alumina 0.3 (um)	Lecloth® (flocked cotton sateen)	Distilled or Deionized Water

REMARKS:

(a) This family of materials is extremely susceptible to surface deformation.

The following etchant also functions as a Chemical Polish.

COMPOSITION:

60 cc Glycerine

20 cc Nitric Acid

20 cc Hydrofluoric Acid (48%)

TECHNIQUE:

Swab vigorously with saturated cotton. Reaction is very active at outset, but diminishes as deformation is removed. Staining effects on various phases are time dependent. Reaction rate may be varied by heating (increase) or chilling (decrease) the sample or etchant.

CAUTION:

Etchant must be fresh each time, stability decreases in a few hours. Protect hands.

SUGGESTED DEVIATIONS

(a) Check the possibilities of Electropolishing, Slurry (Etch-Attack) Polishing or Chemical Polishing.

V. POLISHING PROCEDURES FOR CEMENTED CARBIDES

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond 5 (µm) (280 mesh)	Resin-Bonded Diamond Disc	Water
Diamond 15 (µm)	Resin-Bonded Diamond Disc	Water

REMARKS:

For gross surface removal, employ a 63-74 μ m(220 Mesh) Resin-Bonded Diamond Disc to decrease wear on 45 (μ m) (280 Mesh) Disc.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant	
Diamond Paste	Pan K	Lapping Oil	
6 (µm)	(PVC Chemotextile)		
Diamond Paste	Pan K	Lapping Oil	
$3 (\mu m)$	(PVC Chemotextile)		

REMARKS:

Very often the 3 micron Diamond Paste step may be omitted.

FINAL	POL	ISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Pan K	Lapping Oil
0.1 (μm)	(PVC Chemotextile)	

REMARKS:

If extremely fine scratches are visible in the binder material, a short cycle on Lecloth^(R) with Gamma Alumina (0.05 Micron) will remove same.

VI. POLISHING PROCEDURES FOR LEAD ALLOYS, TIN ALLOYS AND ZINC BASED DIE CASTINGS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂O₃ Coated Products (waterproof) Same abrasive sequence and lubricant may be used. Abrasive action is less severe.
- (b) Emery Coated Products Abrasive sequence would be 1/0, 2/0, 3/0. These materials are for dry operation, however kerosene may be used for lubricant with resultant decreased paper life. Material removal rates are much less than either SiC or Al₂O₃.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Nylon Cloth	Lapping Oil
6 Micron		

REMARKS:

There may be some advantage to extend Rough Polishing into two steps by incorporating a 0.5 Micron Diamond with Lecloth® step. If Lapping Oil should attack any micronconstituents alcohol or ethylene-glycol may be substituted.

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Gamma Alumina	Lecloth®	Distilled or
0.05 Micron	(flocked cotton sateen)	Deionized water

REMARKS:

- (a) The lead alloys lend themselves to mechanical preparation rather than electrolytic polishing since many lead alloys undergo Eutectic formation during solidification. Very often Eutectic structures will show supercooling tendencies and instability in the solid solution zones.
- (b) Both tin and lead alloys are inherently soft and very susceptible to gross surface flow and accompanying deformation during preparation. Careful etching and repolishing will remove the disturbed metal.
- (c) One should be careful to observe the melting point of the material being prepared and select mounting methods accordingly.

VII. POLISHING PROCEDURES FOR REFRACTORY ALLOYS AND METALS (Nb, Mo, W, V, Ta)

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Nylon Cloth	Lapping Oil
6 (μm)		

REMARKS:

- (a) Extreme caution should be exercised in all preceding stages to avoid or, at least, certainly minimize surface deformation.
- (b) In the early portion of Rough Polishing more scratches seem to appear than are being removed. The scratches from Fine Grinding are being "opened-up." Extending the polishing time will remove these effects.

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Gamma Alumina	Lecloth® (flocked	Distilled or
$0.05~(\mu m)$	cotton sateen)	Deionized water

SUGGESTED DEVIATIONS:

- (a) Check the possibility of Electropolishing
- (b) Check the possibility of Slurry (Etch-Attack) Polishing.

VIII. POLISHING PROCEDURES FOR PLATED SECTIONS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂0₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action may be less severe.
- (b) Emery-Coated Products. Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. Material removal rates are much less than either SiC or Al_2O_3 .

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Nylon Cloth	Lapping Oil
6 (μm)		

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Gamma Alumina	Lecloth® (flocked	Distilled or
0.05 (µm)	cotton sateen)	Deionezed water

REMARKS:

- (a) During preparation softer electrodeposits may tend to flow and the interfaces between the various layers will not be clearly delineated.
- (b) Edge Protection Suggestions for Post Plating and Fluid Bedding are described under Mounting Procedures.
- (c) Etching The interfaces can be clearly delineated by etching. Specific details are given in Table 4 under Microetching.

IX. POLISHING PROCEDURES FOR POWDER METALS AND ALLOYS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
SiC 320 grit	Paper or Disc (waterproof)	Water
SiC 400 grit	Paper or Disc (waterproof)	Water
SiC 600 grit	Paper or Disc (waterproof)	Water

REMARKS:

- (a) Al₂0₃-Coated Products (waterproof). Same abrasive sequence and lubricant may be used. Abrasive action is less severe on some materials.
- (b) Emery-Coated Products. Abrasive sequence would be 1/0, 2/0, 3/0, 4/0. These materials are for dry operation only. Material removal rates are much less than either SiC or Al₂O₃.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Nylon Cloth	Lapping Oil
6 (µm)		

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Gamma Alumina 0.05 (µm)	Lecloth® (flocked cotton sateen)	Distilled or Deionized water

GENERAL:

(a) Cleaning: Porosity is generally associated with powder metal sections. The porous area can become filled with foreign products during sectioning and preparation.

The samples should be very thoroughly cleaned in either an Extractor-Condenser Apparatus or several stages in an Ultrasonic Cleaner.

(b) Impregnation: Porous sections should be either impregnated with a high temperature wax (350° F.) or vacuum impregnated with epoxy. Such practice will prevent contamination during preparation and also improve consolidation for mounting and preparation.

Procedures for both Cleaning and Impregnation are detailed under Mounting Procedures.

X. POLISHING PROCEDURES FOR CERAMICS

FINE GRINDING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond	Resin-Bonded Diamond Disc:	Water
45 (μm) (280 Mesh) Diamond 15 (μm)	Resin-Bonded Diamond Disc	Water

REMARKS: For gross surface removal, employ a 63-74 micron (220 Mesh) Resin Bonded Diamond Disc to decrease wear on 45 micron (280 Mesh) Disc.

ROUGH POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Pan K	Lapping Oil
9 (μm)	(PVC Chemotextile)	
Diamond Paste	Pan K	Lapping Oil
6 (µm)	(PVC Chemotextile)	

REMARKS:

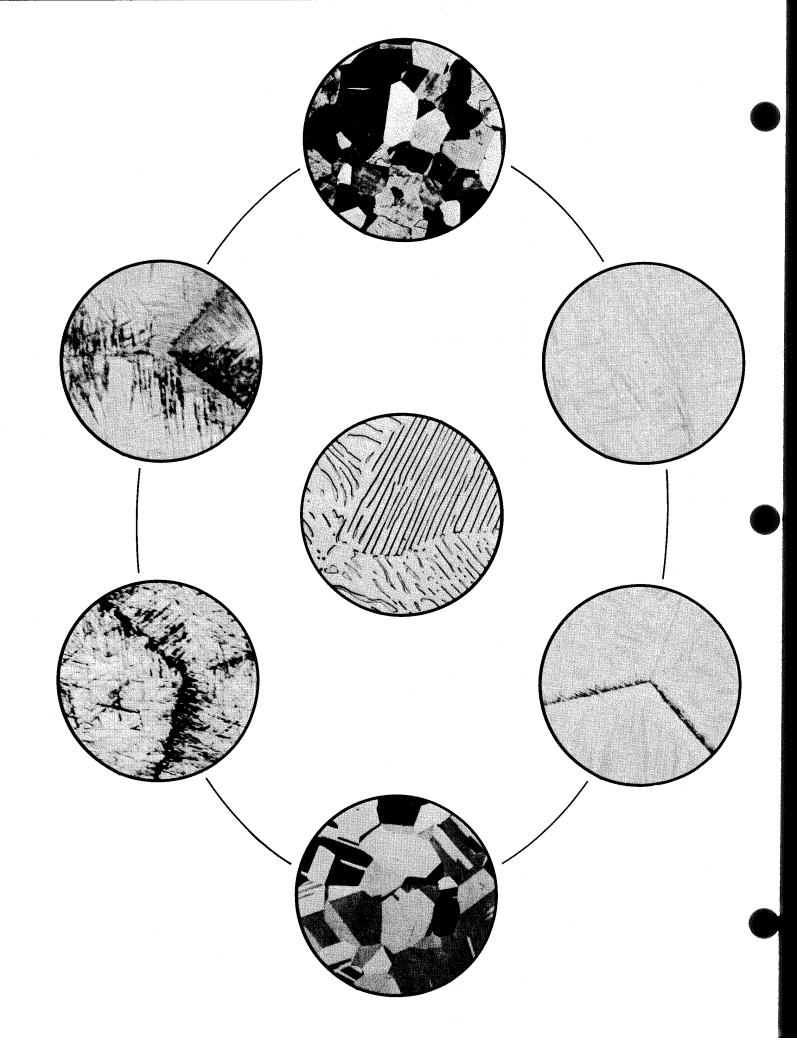
With some materials the 9 micron Diamond Paste Step may be omitted. If any microconstituents or the mounting media are stained or attacked by an oil extender, ethylene-glycol or alcohol may be used as a lubricant.

FINAL POLISHING

Abrasive & Size	Lap or Wheel Covering	Lubricant
Diamond Paste	Pan K	Lapping Oil
3 (µm)	(PVC Chemotextile)	
Alpha Alumina	Silk	Distilled
0.3 (µm)		Deionized Water

REMARKS: Polishing times should be as short as possible to avoid relief polishing.

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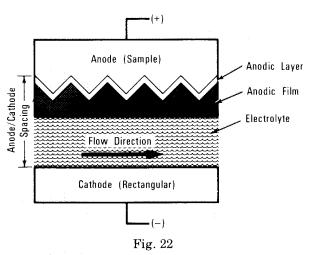
ELECTROLYTIC POLISHING

Electrolytic Polishing is a process wherein a metal sample is made the anode in an electrolytic cell. Material is removed by electrolytic action in such a manner that surface irregularities are removed and the finish becomes smooth and bright. Dependent upon solutions and electrolysis conditions the metal anode may be either etched, polished, completely or partially passivated.

The use of anodic polishing in sample preparation demands the selectivity of attack on the existent phases within a microstructure remains within certain limitations. This is necessary to prevent exaggerated artifacts in the overall structure which might preclude proper interpretation.

With electropolishing, a potential difference is existent between the matrix and secondary phases. Should the second phase be anodic or less noble, it will be preferentially attacked. If it is cathodic or more noble, the matrix will be attacked in the areas adjacent to the second phase.

The anode film (see Fig. 22) controls the rate at which the dissolution products can diffuse away from the anode. Since there is a difference in concentration gradient, (i.e. a thin film with a high concentration gradient existent at a depression), preferential dissolution occurs at the asperity and the surface becomes "smoothed."



There must be another factor present in the electrolytic process responsible for the "brightening." Strong evidence supports the formation of some type layer between the anodic film and anodic surface as the contributing factor, see Figure 22. Perhaps in explanation this anodic layer follows the contour of the anodic surface and is uniformly attacked by the electrolyte. The passage of ions across the anodic layer interface must occur at the same rate at all points to maintain this layer and cause "brightening."

The existence of such a surface layer could also explain the difference between etching and polishing conditions. Etching will occur if the electrolyte has free access to the anode surface since anodic dissolution occurs preferentially at the sites of high energy.

Anodic dissolution of a metal under polishing conditions involves both electrical and chemical phenomena. The existence of a viscous anodic film can actually be observed during polishing.

Observations have shown (see Figure 22):

- (1) The anodic film thickness remains approximately constant during the preparation cycle.
- (2) The same film is also relatively thick in comparison to the depth of the surface irregularities.
- (3) A planar surface exists between the anodic film and the electrolyte.

There are basically two shapes of Voltage-Current Density Curves inherent to electrolytes, Figure 23 is typical of Low Resistance Electrical Solutions whereas Figure 24 is representative of High Resistance Solutions.

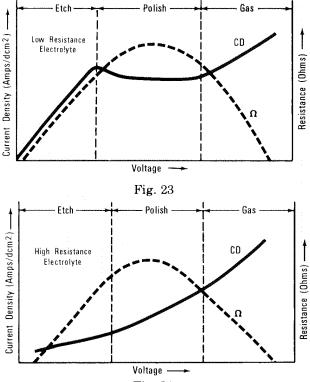


Fig. 24

There are three distinct areas in the above Voltage-Current Density Curves. At relatively low current densities electrolytic etching will occur as the anodic film is either nonexistent or has not reached stability. At increased current densities, polishing will occur. At higher current densities, hydrogen evolution occurs at the cathode. This rapid gas evolution may produce a polished surface, but "pitting" imperfections will be evident due to adherent gas bubbles.

Proper electropolishing conditions exist when the anodic film has maximum resistance.

For idealized electropolishing conditions, it is important to: (a) Closely control or minimize heating of the electrolyte and anode, (b) Operate under conditions to produce maximum resistance in the anodic film, (c) Operate at minimal Current Densities.

Should too much heat be generated, the polished surface may become etched by direct chemical attack and/or show evidence of pitting. These undesirable results may be attributed to the fact that the viscous anodic film is a poor conductor and the anode having higher conductivity than the electrolyte, will absorb most of the heat generated.

The effects of temperature control at various levels of Current Density demands and Anodic Film Resistance for a typical high resistance electrolyte are shown in Figures 25 and 26.

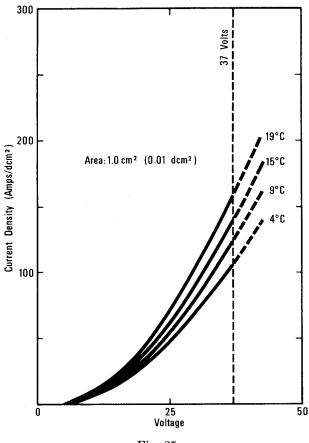


Fig. 25

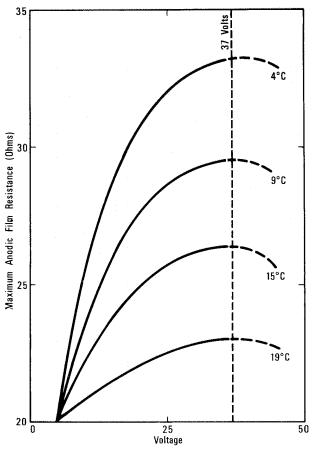


Fig. 26

A specific time is necessary to produce a polished surface with any current density. The time of polishing should be no longer than necessary; or the secondary effects, such as nobility factor, etc., may be intensified. Time is also dependent upon the preparation of the sample prior to electrolytic treatment.

During polishing the metallic content of the electrolyte continually increases due to the dissolution products from the anode. An increase in metallic content increases the conductivity of the solution, as well as the electrolyte life within certain limitations.

The degree of stirring or electrolyte flow is dependent upon cell design. Care must be taken so as not to modify the current paths. The disruption may cause locally etched or unpolished areas.

Recommended Electrolytes for Various Materials: L1 Electrolyte Plain Carbon Steels High Speed Steels Allov Steels Stainless Steels Aluminum Aluminum Alloys Nickel Tin L2 Electrolyte Molybdenum Vanadium L3 Electrolyte Lead (Some Pb/Sn Alloys) Aluminum-Copper-Magnesium L5 Electrolyte Cast Iron: Gray, Malleable, Nodular L7 Electrolyte Zinc (Some Zn Alloys) Magnesium L8 Electrolyte Copper Copper-Nickel Brasses (red) Brasses (yellow) Bronzes (Al) L9 Electrolyte Copper Bronzes (Mn) Bronzes (P) Aluminum-Copper L10 Electrolyte Materials with disturbing inclusions, such as Low C Steels, Irons, Cast Irons, Brasses and Bronzes.

L11 Electrolyte
Tungsten
Cemented Tungsten Carbides

L12 Electrolyte

Titanium
Zirconium
Hafnium
Molybdenum
Vanadium
Plain C Steels
High Temperature Alloys

L13 Electrolyte

Cast Irons: Gray, Malleable, Nodular

ELECTROLYTE	COMPOSITIONS	MIXING PROCEDURE
L1	Perchloric Acid 62cc Ethanol 700cc Butyl Cellusolve 100cc Distilled Water 137cc	Cautiously add perchloric acid to previously prepared mixtures of other components.
L2	Perchloric Acid 47cc Methanol 600cc Butyl Cellusolve 360cc Distilled Water 13cc	Same as for Electrolyte No. L1
L3	Perchloric Acid 90cc Ethanol 600cc Acetic Acid 180cc Sodium Hydroxide . 32g Sodium Acetate . 45g	Mix acetic acid and ethanol. Dissolve sodium hydroxide in this mixture. Add sodium acetate to this mixture. Sodium acetate will dissolve as the perchloric acid is added to mixture.
L4	Perchloric Acid 78cc Ethanol 700cc Butyl Cellusolve 100cc Distilled Water 120cc Tartaric Acid 50g	Mix distilled water and ethanol. Dissolve tartaric acid in this mixture. Add butyl cellusolve and then the perchloric acid.
L5	Perchloric Acid	Dissolve citric acid, quinolinol and sodium thiocycanate in the ethanol and propanol alcohol mixture, heating may be required. Add perchloric acid after solution has cooled.
L6	Hydrochloric Acid 10cc Methanol 1000cc	Add the hydrochloric acid to the methanol.
L7	Ethanol 800cc Butyl Cellusolve 80cc Distilled Water 20cc Sodium Thiocycanate 160g	Dissolve sodium thiocycanate in mixture of ethanol and distilled water. When completely in solution, add butyl cellusolve.
L8	Phosphoric Acid 250cc Distilled Water 500cc Ethanol 250cc Propanol 50cc Urea 5g	Mix in order listed.
L9	Nitric Acid30ccMethanol900ccCupric Nitrate300g	Dissolve cupric nitrate in methanol by slowly heating. Allow to cool and carefully add nitric acid immediately before use. DO NOT STORE — DISPOSE OF ELECTROLYTE AFTER USE.
L10	Acetic Acid 120cc Methanol (pure) 900cc Propanol 140cc Butyl Cellusolve 200cc Cobalt Nitrate 400g Ferric Nitrate 40g Tartaric Acid 140g Urea 4g	Mix methanol and propanol. Dissolve the four (4) dry chemicals in this mixture. NOTE: Tartaric acid will dissolve slowly. Add acetic acid and finally the butyl cellusolve to this mixture.
L11	Sodium Hydroxide 20g Distilled Water 1000cc	Dissolve sodium hydroxide in water.
L12	Perchloric Acid 60cc Methanol 590cc Butyl Cellusolve 350cc	Cautiously add perchloric acid to previously prepared mixture of other components.
L13	Perchloric Acid 50cc Ethanol 750cc Distilled Water 140cc	Cautiously add perchloric acid to previously prepared mixture of other components.
		and the

CHEMICAL REAGENT SPECIFICATIONS:

Acetic Acid (glacial) 99% CH₃COOH

Butyl Cellusolve Ethylene Glycol Monobutyl Ether, CH₃(CH₂)₂ CH₂OCH₂CH₂OH

Citric Acid [(COOH) CH₂]₂ COH COOH•H₂O

Cobalt Nitrate $Co(NO_3)_2 \bullet 6H_2O$ Cupric Nitrate $Cu(NO_3)_2 \bullet 3H_2O$

Ethanol (Ethanol - 96% vol.), CH₃CH₂OH

Ferric Nitrate Fe(NO₃)₃•9H₂O

Hydrochloric Acid 37% HCI

Manganese Nitrate Mn(NO₃)₂•6H₂O

Phosphoric Acid 85% H₃PO₄ (ortho phosphoric)

Propanol n•propanol Quinolinol C_9H_7NO

Sodium Acetate C₂H₃O₂Na•3H₂O Sodium Hydroxide NaOH (pellets)

Urea $CO(NH_2)_2$ (carbomide)

NOTE: All chemicals should be analytical grade.

Electrolyte Hazards

We warn against solutions containing high percentages of perchloric acid in acetic acid or acetic anhydride and those with obnoxious and toxic fumes.

There are other solutions which are strong oxidizing agents, particularly chromic acid or nitric acid. When these are mixed with organic chemicals, such as acetic anhydride or methyl alcohol, any acceleration of the exothermic oxidation could cause explosion.

The following reference sources are cited for available literature in handling such materials.

Perchloric Acid

(1) ASTM Standard E50-73

"Recommended Practices for Apparatus, Reagents and Safety Precautions for Chemical Analysis of Metals", American Society for Testing Materials",

1916 Race Street. Philadelphia, Pa. 19103

(2) "Bulletin SD11"

Manufacturing Chemists Association 1825 Connecticut Avenue, N.W. Washington, D.C. 20009

Chromium Trioxide

"Bulletin SD44"
Manufacturing Chemists Association
1825 Connecticut Avenue, N.W.
Washington, D.C. 20009

Nitric Acid

"Bulletin SD 5" Manufacturing Chemists Association 1825 Connecticut Avenue, N.W. Washington, D.C. 20009

CAUSES AND SUGGESTED CURES FOR UNSATISFACTORY SURFACES

The use of an electrolyte is the most important source of deterioration. Impurities and too great a metallic ion content act as catalysts in deteriorating a solution. This may cause artifacts and lead to misinterpretation of a microstructure.

Surface Condition	Probable Cause	Suggested Correction
Edge of specimen pitted or etched.	Film too viscous or too thin.	Increase flowrate. Use less viscous electrolyte. Decrease voltage.
Center of specimen etched.	No film formed at center of specimen.	Increase voltage. Reduce flowrate.
Deposits on specimen.	Insoluble anode reaction product.	Use fresh electrolyte. Use different electrolyte. Increase voltage.
Etching or staining of specimen.	Chemical attack after current is "OFF".	(1)Remove specimen immediately after current is off.(2) Use a less corrosive electrolyte.
Relief effects.	(1) Polishing film inadequate. (2) Nobility relationship of phases present.	(1) Increase voltage. (2) Improve pre- preparation of sample and reduce polishing time.
Waviness on polished surface.	(1) Insufficient time.(2) Flowrate too high or low.(3) Unsuitable preparation.	(1) Increase voltage. (2) Increase or decrease flowrate (3) Improve preparation. (4) Decrease time.
Unpolished spots.	Gas bubbles.	(1) Increase flowrate.(2) Too high electrolyte temperature.(3) Decrease voltage.
Roughness or matte surface.	Insufficient or no polishing film.	(1) Increase voltage. (2)Use more viscous electrolyte.
Pitting.	Too long polishing time. Too high voltage.	 (1) Improve pre-preparation. (2) Decrease voltage. (3) Decrease time. (4) Determine if the pits are inclusions or phases attacked due to nobility factor.

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SLURRY (ETCH-ATTACK) POLISHING

Slurry Polishing is a process wherein an etching Relief polishing and etch pit tendencies are greatly reagent is added to the polishing compound to increase removal rate. The techniques are generally restricted to the Rough & Final Polishing Stages.

reduced. Some additions are not reactive with the sample material, but continually function to remove any passivating film.

Concentration of the additive etchant must be adjusted so the mechanical removal rate slightly exceeds the chemical removal rate.

Solutions which may be helpful are listed in Table

TABLE VI-SLURRY (ETCH-ATTACK) SOLUTIONS

Metal	Reagent	Abrasive	Remarks
Beryllium	Oxalic Acid 10g Water 100g Abrasive 5-8g	A1 ₂ O ₃	Rough polishing: 0.3 (μm)-grade alumina on a silk cloth. Final polishing: 0.05 (μm)-grade alumina on a napped cloth.
Chromium	Acetic acid 15g Water 150ml	Al_2O_3	
	1% oxalic acid in 1:1 ethyl alcohol, water solution.	A1 ₂ O ₃	Final polishing: Chemical resistant cloth necessary.
Columbium (Niobium)	Ammonium Hydroxide 200ml	A1 ₂ O ₃	Rough polishing: $0.3(\mu m)$ -grade on a nylon cloth necessary.
& Columbium Alloys	Copper Sulfate 40g Water 300ml		Final polishing: $0.05 (\mu m)$ -grade on a napped cloth. *PVC or polyethylene polishing laps recommended.
	Sodium Hydroxide 2g Potassium Ferricyanide 35g Water 150ml	Al ₂ O ₃	Final polishing: $0.05 (\mu m)$ -grade on a napped cloth. *PVC or polyethylene laps recommended.
Copper	Up to 3% ammonium persulphate solutions.	MgO	Final polishing: by skidding technique.
	Ammonia, ammonium persulphate, cupric ammonium persulphate.	A1 ₂ O ₃	Added to polishing pad.
	2-10% chromic acid solution	Al ₂ O ₃	Abrasive suspended in reagent and used on a napped cloth.
Gold	5-10% chromic acid solution	A1 ₂ O ₃	Abrasive suspended in reagent and used on a napped cloth.
· · · · · · · · · · · · · · · · · · ·	Pot. Iodide . 12.5g Water 100ml	A1 ₂ O ₃	Drops of reagent added to normal polishing pad.
Magnesium	2% Pot. Dichromate solution 20ml Sat. solution boric acid 150ml Nitric acid (concentrated) 15 drops	A1 ₂ O ₃	Suitable for pure magnesium, slight variations being desirable for alloys.
	Ammonium hydroxide	CeO	Final polishing on napped cloth. Magnesium-lithium alloys when corrosion is encountered.

TABLE VI — SLURRY (ETCH - ATTACK) SOLUTIONS, continued

Metal	Reagent	Abrasive	Remarks
Silver	Chromic acid, solution 100ml Hydrochloric acid, (10% soln.)45ml Water 800ml	nil	Nylon cloth necessary. Specimen should only lightly contact the cloth. Suitable for removing large thicknesses, the removal rate being about 25 μ m/min. After polishing, surface must be swabbed lightly in the polishing solution for 30 seconds while being rinsed under water; otherwise a thin adherent film of chromate will form.
Tantalum & Tantalum Alloys	See solution Columbi & Columbium Alloys		n)
Thorium	10% oxalic acid	A1 ₂ O ₃	Rough polishing: Abrasive suspended in reagent.
	Nitric acid10ml Hydrofluoric acid1ml Water98ml	A1 ₂ O ₃	Final polishing: Reagent added to normal polishing pad.
Titanium	20% chromic acid solution30ml Water200ml Abrasive15g	A1 ₂ O ₃	Rough polishing on a high-speed wheel. Surface produced is passive, but passivity can be removed by a further treatment on a normal pad.
	Hydrofluoric acid 1.5ml Nitric acid 3.5ml Water 95ml	A1 ₂ O ₃	Final polishing: Add few drops to a normal pad at the end of the treatment.
	5% oxalic acid solution	Al ₂ O ₃	Final polishing: Suspend abrasive in reagent.
	Hydrofluoric acid 1.5ml Nitric acid 1.5ml Water 100ml Abrasive 10g	Al ₂ O ₃	Final polishing.
	1% Hydrofluoric acid solution	A1 ₂ O ₃	Final polishing: Suspend abrasive in reagent.
	See solution (2) Colu	mbium (Niob	ium) & Columbium Alloys above.
Tungsten	Potassium Ferricyanide 3.5g Sod. hydroxide . 1g Water 100ml Abrasive 10g	A1 ₂ O ₃	Final polishing: Develops some grain structure.
	Copper sulphate 1g Amm. Hydroxide 5-10ml Water 1,000ml	A1 ₂ O ₃	Final polishing: Suspend abrasive in reagent. Give alternate treatments on a normal polishing pad.

 ${\tt TABLE~VI-SLURRY~(ETCH-ATTACK)~SOLUTIONS,~continued}$

Metal	Reagent	Abrasive	Remarks
Uranium	Chromic acid . 10g Nitric acid 10ml Water 1,000ml	Al ₂ O ₃	Rough polishing: Suspend abrasive in reagent. Polythene or PVC apparatus and chemical resistant cloth necessary.
	Hydrofluoric acid30ml Nitric acid30ml Water60ml Alumina5-8g	Al_2O_3	Final polishing: Swab surface with concentrated nitric acid immediately after polishing.
	5% suspension of abrasive in hydrogen peroxide (30 wt.%)	A1 ₂ O ₃	Final polishing: Polyethylene or PVC apparatus and chemical resistant cloth necessary.
Zirconium	Hydrofluoric acid 4-30 drops Water 10ml Abrasive 5-6g	A1 ₂ O ₃	Final polishing: Polyethene or PVC apparatus and chemical resistant cloth necessary.

 $(Courtesy\,Samuels,Coons,Gerardi,et\,al)$

CHEMICAL POLISHING

These techniques are usually employed after the Final Polishing Stage to aid in the removal of any remnant surface deformation.

The specimen surface is polished by immersion in a suitable solution without applying an external potential.

An explanation of the theory involves the selective dissolution of a surface by setting up local voltaic cells between those regions where the anodic film is easily removed and the depressions where the film is more stable.

Suggested solutions are given in Table VII.

Unless otherwise specified, the acids in the solutions are concentrated reagent grades.

Orthophosphoric Acid	Sp. gr. 1.70
Sulphuric Acid	Sp. gr. 1.84
Nitric Acid	Sp. gr. 1.40
Hydrochloric Acid	Sp. gr. 1.75
Glacial Acetic Acid	Sp. gr. 1.065

TABLE VII — CHEMICAL POLISHING SOLUTIONS¹

Metal	Solution	Time	Temp	.(°C) Remarks
Aluminium and Alloys	25 ml sulphuric acid 70 ml orthophosphoric acid 5 ml nitric acid	30 sec. 2 min.	85	Very useful for studying alloys containing intermetallic compounds e.g. Al-Cu, Al-Fe and Al-Si alloys.
Beryllium	5 wt per cent sulphuric acid 75 wt per cent orthophosphoric acid 7 wt per cent chromic acid Remainder water	Several min.	49-50	Rate of metal removal is approx. 1 micron/min. Passive film formed may be removed by immersion in 10 percent sulphuric acid.
Cadmium	75 ml fuming nitric acid 25 ml water	5-10 sec.	20	Cycles of dipping for a few seconds followed immediately by washing in a rapid stream of water are used until a bright surface is obtained. A suitable etching procedure uses 70 ml glacial acetic acid, 30 ml fuming nitric acid for 30 sec. to 1 min. Can also be used for zinc.
Copper	33 ml nitric acid 33 ml orthophosphoric acid 33 ml glacial acetic acid	1-2 min.	60-70	Finish is better when copper oxide is absent. A modified solution namely, 20 ml nitric acid, 55 ml orthophosphoric acid, 25 ml glacial acetic acid, appears to give a better polish than the original.
Copper Alloys	30 ml nitric acid 10 ml hydrochloric acid 10 ml orthophosphoric acid 50 ml glacial acetic acid	1-2 min.	70-80	Specimen should be agitated.
Copper-zinc Alloys	80 ml fuming nitric acid 20 ml water	5 sec.	40	Use periods of 5 sec. immersion followed immediately by washing in a rapid stream of water. Slight variations in composition are needed for α - β and β - γ brasses to prevent differential attack. With β - γ alloys, a dull film forms and this can be removed by immersion in a saturated solution of chromic acid in fuming nitric acid for a few seconds followed by washing.
Germanium	15 ml hydrofluoric acid 25 ml nitric acid 15 ml glacial acetic acid 3-4 drops bromine	5-10 sec.	20	
Iron	3 ml nitric acid 7 ml hydrofluoric acid (comm.) 30 ml water	2-3 min.	60-70	Dense brown viscous layer forms on surface; layer is soluble in solution. Low carbon steels can also be polished, but the cementite is attacked preferentially.

¹Tegart, W. J., *The Electrolytic & Chemical Polishing of Metals*, Headington Hill Hall, Oxford, England: Pergamon Press Ltd. pages 99, 100, 101, 102 (Reprinted with permission)

TABLE VII — CHEMICAL POLISHING SOLUTIONS continued

Metal	Solution	Time	Temp.	(°C) Remarks
Iron and Steels	80 ml distilled water 28 ml oxalic acid (100 g/l) 4 ml hydrogen peroxide (30 per cent)	15 min.	35	The solution must be prepared freshly before use. Careful washing is necessary before treatment. A microstructure is obtained similar to that produced by mechanical polishing, followed by etching with Nital.
Lead	20 ml hydrogen peroxide (30 per cent) 80 ml glacial acetic acid	Periods of 5-10 sec.	20	McAFEE recommends using alternate immersions in this solution of 10 g molybdic acid and 140 ml ammonium hydroxide in 240 ml water to which 60 ml nitric acid is finally added.
Magnesium	75 ml fuming nitric acid 25 ml water	Periods of 3 sec.		The reaction reaches almost explosive violence after about a minute but if allowed to continue it ceases after several minutes leaving a polished surface ready for examination. Specimen should be washed immediately after removal from solution.
Nickel	30 ml nitric acid 10 ml sulphuric acid 10 ml orthophosphoric acid 50 ml glacial acetic acid	1/2-1 min.	85-95	This solution gives a very good polish.
Silicon	20 ml nitric acid 5 ml hydrofluoric acid (comm.)	5-10 sec.	20	
Tantalum	50 ml sulphuric acid 20 ml nitric acid 20 ml hydrofluoric acid (comm.)	5-10 sec.	20	Solution is useful for preparing surfaces prior to anodizing.
Zinc	200 g chromic acid 15 g sodium sulphate 50 ml nitric acid 950 ml water	Several min. to 1/2 hr.	20	Dense layer formed during treatment is soluble in water. Rate of dissolution is approximately 7 microns/min.
Zirconium	45 ml nitric acid 8-10 ml hydrofluroic acid (comm.) 45 ml water or hydrogen perioxide (30 per cent)	5-10 sec.	20	Specimen is swabbed with solution. After a few seconds, a brownish - yellow vapour is evolved on the surface. Swabbing is continued for 5-10 sec. and then specimen is rinsed in running water. Similar solution can be used for Titanium and Hafnium

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,	VI Floatrolytes for Polishing and Etching	

MICROETCHING

A metallographic specimen in the "as polished and unetched" state will reveal inclusions, porosity, cracks, intergranular corrosion, surface conditions, etc.

Etching is defined as the process to reveal structural details by preferential attack of a metal surface with an acid or basic chemical solution.

The most commonly used etching technique is termed Solution Etching. This may be further classified into two categories:

- A. Acid and Basic Reagents
 - 1. Immersion
 - 2. Swabbing
- B. Electrolytic
 - 1. Direct Current
 - 2. Alternating Current

For Immersion Etching, the sample is held with tongs and immersed in a suitable etching solution. The specimen is gently agitated to eliminate adherent air bubbles and continually supply fresh reagent to the surface. Swab etching implies the surface is gently wiped with a soft cotton swab saturated with etchant. The swab should be replenished with fresh reagent if etching times are comparatively long.

With Electrolytic Etching, direct current electrolysis is usually used. The specimen is made the anode and a suitable insoluble material is the cathode. For a few materials (platinum, palladium and their alloys) alternating current electrolysis is used.

STANDARD METHOD FOR MICROETCHING METALS & ALLOYS²

1. Scope

1.1 These methods cover chemical solutions and procedures to be used in etching metals and alloys for microscopical examination. Safety precautions and miscellaneous information are also included.

2. Summary of Methods

2.1 Table 1 is an alphabetical listing of the metals (including rare earths) and their alloys for which etching information is available. For each metal and alloy, one or more etchant numbers and their corresponding use is indicated. Alloys are listed as a group or series when one or more etchants are common to the group or series. Specific alloys are listed only when necessary. When more than one etchant number is given for a particular use, they are usually given in order of preference. The numbers of electrolytic etchants are under-

lined to differentiate them from nonelectrolytic etchants.

- 2.2 Table 2 is a numerical listing of all the etchants referenced in Table 1 and includes the composition and general procedure to be followed for each etchant.
- 2.3 To use the tables, look up the metal or alloy of interest in Table 1 and note the etchant numbers corresponding to the results desired. The etchant composition and procedure is then located in Table 2 corresponding to the etchant number.
- 2.4 If the common name of an etchant is known (Marble's, Vilella's, etc.), and it is desired to know the composition, Table 3 contains an alphabetical listing of etchant names, each coded with a number corresponding to the same etchant given in Table 2.

3. Safety Precautions

- 3.1 Special safety precautions are mentioned in Table 2 only for extremely hazardous mixtures such as the cyanides and those that can form nitrogen dioxide gas. However, ALL CHEMICALS ARE POTENTIALLY DANGEROUS and it is assumed that the person using any of the etchants is thoroughly familiar with all of the chemicals involved and the proper procedure for handling and mixing these chemicals.
- 3.2 Some basic suggestions for the handling of etching chemicals are as follows:
 - 3.2.1 When pouring, mixing, or etching, always use the proper protective garb (glasses, gloves, apron, etc.).
 - 3.2.2 Use proper devices (glass or plastic) for weighing, mixing, containing, and storage of solutions.
 - 3.2.3 Wipe or flush any and all spills, no matter how minute in nature.
 - 3.2.4 Dispose of any and all solutions that are not properly identified by composition and concentration (when in doubt, throw it out).
 - 3.2.5 Store and handle chemicals, according to the manufacturer's recommendations. Observe printed cautions on reagent bottles.
 - 3.2.6 If not sure about a chemical or its proper use, contact your Chemical or Safety Department.

²American Society for Testing & Materials. Designation: E 407-70 (Reprinted with Permission)

3.2.7 Have available and use quick references as to toxicity and working precautions of various chemicals. Some of the many excellent references are (1) "Handbook of Dangerous Materials" by N. Irving Sax, (2) "The Chemistry of Industrial Toxicology" by H. B. Elkins, and (3) "Safety in the Metallography Laboratory" by R. L. Anderson, Scientific Paper 65-1P30-METLL-P2, Westinghouse Research Lab., Pittsburgh, PA.

4. Miscellaneous information

- 4.1 If you know the trade name of an alloy and need to know the composition to facilitate the use of Table 1, refer to "Engineering Alloys" by Norman E. Woldman (Reinhold Publishing Corp.).
- 4.2 Chemicals used should meet USP and NF specifications or better.
- 4.3 When mixing etchants, always add reagents to the solvent unless specific instructions indicate otherwise.
- 4.4 Where water is given as the solvent, distilled water is preferred because of the great variance of the purity of tap water.
- 4.5 Methanol is usually available only as absolute methanol. When using this alcohol it is imperative that approximately 5 volume percent of water is added whenever an etchant composition calls for 95 percent methanol. Most of these etchants will not work at all if water is not present.

- 4.6 For conversion of small liquid measurements, there are approximately 20 drops/ml.
- 4.7 Etching should be carried out on a freshly polished specimen.
- 4.8 Gentle agitation of the specimen or solution during etching will result in a more uniform etch.
- 4.9 The etching times given are only suggested starting ranges and not absolute limits.
- 4.10 In electrolytic etching, d-c current is implied unless indicated otherwise.
- 4.11 A good economical source of d-c current for small-scale electrolytic etching is the standard 6-V lantern battery.
- 4.12 In electrolytic etching, the specimen is the anode unless indicated otherwise.
- 4.13 Do not overlook the possibility of multiple etching, that is, etching with more than one solution in order to fully develop the structure of the specimen.
- 4.14 Microscope objectives can be ruined by exposure to hydrofluoric acid fumes from etchant residue inadvertently left on the specimen. This problem is very common when the specimen or mounting media contain porosity and when the mounting material (such as bakelite) does not bond tightly to the specimen resulting in seepage along the edges of the sample. In all cases, extreme care should be taken to remove all traces of the etchant by thorough washing and complete drying of the specimen before placing it on a microscope stage.

TABLE I — ETCHANTS FOR METALS & ALLOYS*

NOTE - Electrolytic etchants are underlined

Metal	Etchants	Uses
Aluminum base:		
Pure Al	1a, 2, 3	general structure
	<u>4, 5</u>	grain structure under polarized light
	1b	grain boundaries and slip lines
1000 series	1a, 3, 2	general structure
	4, 5 6, 7	grain structure under polarized light
	6, 7	phase identifications
2000 series	3, 2, 1a	general structure
	8a, 6, 7	phase identifications
3000 series	3, 1a	general structure
	4, 5	grain structure under polarized light
	8a, 6, 7	phase identifications
4000 series	3, 1a	general structure
5000 series	3, 1a, 2, 6, 8a	general structure
	4. 5	grain structure under polarized light
6000 series	$\frac{4}{3}, \frac{5}{1}$ a, 2, 6, 8a	general structure
	4, 5	grain structure under polarized light
	īa, 2, 7, 6, 8a	phase identifications
7000 series	3, 1a, 2	general structure
	4 5	grain structure under polarized light
	4, 5 3b, 6	phase identifications

^{*} Etchants are listed in order of preference when more than one is given for a specific use. Table II gives composition and procedure for individual etchants

Metal	Etchants	Uses
Metal	Etenants	0.608
Beryllium base:	0.10	general standard via nalamized light
Pure Be	9, 10	general structure via polarized light
Be alloys	11	general structure general structure
Chromium base:	12, <u>13c</u>	general structure
Cobalt base:	14, 15, 1 <u>6</u> , <u>17</u> ,	general structure
Pure Co Hard facing and tool metals	14, 15, <u>16, 17,</u> 18, 19, 20	general structure
High-temperature alloys	20, 18, 16, 21, 22b, 24, 25	general structure
High-temperature alloys	19	phase identification
Columbium base (see niobium base)	<u>10</u>	phase menumeation
Copper base:		
Pure Cu	26, 27, 28, 29, 30, 31d, 32, 33 34b, 35, 36, 37, 38, 39, 40, 41,	general structure
	42, 8b	
	43, 28	chemical polish and etch
Cu-Al (Aluminum bronze)	44, 31d, 34b, 35, 36, 37, 38, 39,	general structure
O 10	40, <u>45</u> , 28	gan anal structura
Cu-Be	46, 41, <u>45</u>	general structure
Cu-Cr	41	general structure
Cu-Mn	41	general structure
Cu-Ni	34, 47, <u>48</u> , 40, <u>49</u> , <u>50</u>	general structure
Cu-Si	41	general structure
Cu-Sn (tin bronze)	51, 52	general structure
Admiralty metal	<u>8b</u>	general structure
Gilding metal		
Cartridge brass		
Free-cutting brass		
Nickel silver	31d, 32, 33, 41, 42, <u>49</u>	general structure
Cu alloys	26, 27, 28, 29, 30, 44, 41, 31d,	general structure
	32, 33, 34b, 35, 36, 37, 38, 39	1 1 1 1 1 1 1 1 1 1
	53, 43, 28, <u>49</u>	chemical polish and etch
	42, <u>49</u>	darkens beta in alpha-beta brass
	$\underline{54}$	etching of cold worked brass
Dysprosium base:	55, 56	general structure
Erbium base:	55, 56	general structure
Gadolinium base:	55, 56, 57	general structure
Germanium base:	58, 59, 60	general structure
Gold base:		
Donne An	61, 62	general structure
Pure Au	63	chemical polish and etch
A 11		general structure
Au alloys	64b, 62	chemical polish and etch
> 0007 1-11-	63	general structure
> 90% noble metals	61 65	general structure
< 90% noble metals		-
Hafnium base:	66, <u>67</u> , <u>68</u> , <u>69</u> , 70	general structure
	$\frac{71}{2}$	grain structure under polarized light
	72	chemical polish and etch
Holmium base:	55, 56	general structure
Iridium base:	<u>73c</u>	general structure
Iron base:	7.4	grain haundaries
Pure Fe	74a	grain boundaries
70	75	substructure
Fe + C	76, 74a, 77, 78, 79	general structure
and	74a, 77, 31a	ferrite grain boundaries prior austenite grain boundaries in
Fe + $< 1C + < 4\%$ additions	80, 81, 82	martensitic and bainitic steels
	78	untempered martensite
	31b, 78	carbides and phosphides (matrix darkene
	010, 10	carbides and phosphides remain
		bright)
	<u>83</u>	cementite attacked rapidly, austenite less
	<u> </u>	ferrite and iron phosphide least
	84	overheating and burning
	85	stains carbides
	86	chemical polish — etch
En + 4.19 Cm	80, 87, 88, 89, 90, 91, 79	general structure
Fe + 4-12 Cr	86	chemical polish — etch
		OLIGINION POINT

	TABLE I — continued	
Metal	Etchants	Uses
Fe + 12-30 Cr + < 6 Ni	80, 87, 88, 89, 34, 40, 92, <u>93,</u>	general structure
(400 Series)	94, 95, 91	general structure
(100 20100)	<u>96, 97, 98</u>	sigma phase
	31c	carbides
77 . 10.00 CL 110 NT . < 70	86	chemical polish — etch
Fe + 12-20 Cr + 4-10 Ni + < 7% other elements (controlled	80, <u>31c</u> , 89, 99, 100, 91 31c	general structure carbides
transformation, precipita- tion hardening, stainless	.86	chemical polish — etch
maraging alloys) Fe + 15-30 Cr + 6-40 Ni + < 5% other elements (300 Series)	13b, 89, 87, 88, <u>83a</u> , 80, 94, 95, 91, 101	general structure
other elements (505 Series)	13a, 102	carbides and sensitization
and	48, 96, 97, 98	stains sigma phase
Fe + 16-25 Cr + 3-6 Ni + 5-10	103, 104, 98	delineates sigma phase and ferrite
Mn (200 Series)	103, 104 86	welds of dissimilar metals chemical polish — etch
High temperature	89, 25, 105, 106, 97	general structure
ing. tomperature	107, 108	γ' precipitate
	86	chemical polish — etch
Nonstainless maraging steels	109, 89, 99, 100	general structure
	83b 86	grain boundaries chemical polish — etch
Tool steels	74a, 80, 14	general structure
Tool Seccio	110	grain boundaries in tempered tool steel
	86	chemical polish — etch
Superalloys	111	general structure
Lead base:	<u>111</u>	γ' depletion
Pure Pb	57, 112	general structure
1 die 15	113	for alternate polishing and etching
$Pb + \le 2 Sb$	114, 115, 57, 74b	general structure
771	113	for alternate polishing and etching
Pb + > 2 Sb	114, 57, 74b 113	general structure for alternate polishing and etching
Pb + Ca	112	general structure
	113	for alternate polishing and etching
Pb alloys	116, 117b	general structure
Babbitt	74b	general structure
Magnesium base: Pure Mg	118, 119, 74a, 120, 121, 122	general structure
i die Wig	123	strain-free polish — etch
Mg-Mn	119, 74a, 124, 122	general structure
Mg-Al, Mg-Al-Zn (Al + Zn < 5%)	118, 119, 74a, 125, 124, 123, 122	general structure
,	120, 125, 126, 127	phase identification
BA A1 BA A1 72 / A1 1 72 > FOO	124, 126, 127	grain structure
Mg-Al, Mg-Al-Zn (Al + Zn $>$ 5%)	118, 119, 74a, 125, 124, 121, 122 120, 125, 126, 127	general structure phase identification
Mg-Zn-Zr	118, 119, 74a, 1d, 128, 124, 126	general structure
and	127, 121, 122	gonoral structure
Mg-Zn-Th-Zr	120, 121	phase identification
Mg-Th-Zr	118, 119, 74a, 1d, 124, 127, 121,	general structure
and Mg-Rare Earth-Zr	122 120, 121	phase identification
Molybdenum base:	98c, 129, 130, 131	general structure
As cast	132a	chemical polish prior to etching
Nickel base:		
Pure Ni and high Ni alloys	$133, \frac{134}{210}, 47, 135, \frac{136}{25}, \frac{25}{108}$	general structure
	31 <u>c</u> 137	grain boundary sulfidation
Ni-Ag	38, 138, <u>50,</u> 139	general structure
Ni-Al	<u>50,</u> 140, 141, <u>142,</u> 89, 143	general structure
Ni-Cr	<u>144, 50, 83, 134, 145,</u> 98, 146,	general structure
Ni-Cu	147, <u>13a</u> 38 138 50 133 140 25 134 47	ganaral atmixtura
MFOU	38, 138, <u>50,</u> 133, 140, 25, <u>134,</u> 47, 48b, 94, 108, 34	general structure
Ni-Fe	50, 140, 141, 83, 134, 148, 40,	general structure
	<u>107,</u> 149	
	74e, 25, 150	orientation pitting

Metal	Etchants	Uses
**************************************	7.4-	general structure
Ni-Mn	74e	general structure
Ni-Mo	143	general structure
Ni-Ti	$143, 151, \underline{50}, 133$	general structure
Ni-Zn	152 94, 105, 138, 153, 12	general structure
Superalloys		grain size
	25	reveals microstructural inhomogeneity
	107, 111, 13a 133	grain boundary sulfidation
	154	fine precipitation structure
	19b, 155, 156	differential matrix and nonmetallic
	<u>190, 155, 156</u>	staining
	22a	for passive alloys
	224	(for example Inconel 625)
	157	specific for Hastelloy W
	107	submicroscopic structure in aged super-
	101	alloys particularly for electron micros-
		copy. Stains the matrix when γ' precip
		tates are present
	154	γ' banding
	18	pre-etch activation for passive samples
Niobium (Columbium) base:	$\overline{129}$, 66, 158, 159, 160, 161, 162,	general structure
Tittomani (Commorani) base.	163	Boundary Straws
	164, 129, 160	grain boundaries
Osmium base:	165a	general structure
Osmium oase.	165a	etch — polishing for viewing grains
	1000	with polarized light
Palladium base:		F
Pure Pd	61, 166, 62, 165a	general structure
Pd alloys	166, 64a, 62, 165a	general structure
> 90% noble metals	61	general structure
< 90% noble metals	65	general structure
Platinum base:	. 00	gonoras ser acres o
Pure Pt	64a, 73a	general structure
1 die 1 t	167	electrolytic polish and etch
Pt alloys	64b, 73a	general structure
t t anoys	167	electrolytic polish and etch
> 90% noble metals	61	general structure
< 90% noble metals	65	general structure
Pt-10% Rh	168	general structure
Plutonium base:	169	general structure
Rhenium base:	13b, 98c, 132b, 170a	general structure
Rhodium base:	171 171	general structure
Ruthenium base:	$\frac{73b}{73b}$	general structure
Article (1997)	$\overline{73}$	etch — polishing for viewing grains
	<u></u>	with polarized light
Silver base:		
Pure Ag	172, 173, 62	general structure
Ag alloys	65, 61, 174, 175, 62	general structure
Ag-Cu	30	general structure
Ag-Pd alloys	173	general structure
Ag solders	173, 176	general structure
Tantalum base:	,	
Pure Ta	177	general structure
Ta alloys	159, 66, 178, 163, 161, 179	general structure
•	164	grain boundaries and inclusions
	158	grain boundaries — retains carbide
		precipitate
Thorium base:		
Pure Th	185	general structure
Th alloys	185	general structure
Tin base:		
Pure Sn	74d, 180, 51	general structure
	181	grain boundaries
Sn-Cd	74d	general structure
Sn-Fe	74d, <u>117a</u>	general structure
Sn-Pb	182, 183, 74b	general structure
	116	darkens Pb in Sn-Pb eutectic
	100	gan and atmedians
Sn coatings (on steel) Babbitts	183 184	general structure general structure

TABLE I -- continued

TABLE I — continued				
Metal	Etchants	Uses		
Sn-Sb-Cu	74b	general structure		
Titanium base:				
Pure Ti	186, 187, <u>67, 68,</u> 69	general structure		
	188	removes stain		
	72	chemical polish and etch		
Ti-5 Al-2.5 Sn	189	reveals hydrides		
Ti-6 Al-6V-2 Sn	190	stains alpha and transformed beta.		
11011101201	130			
Ti-Al-Zr	191	retained beta remains white		
Ti-8 Mn		general structure		
	192	general structure		
Ti-13V-11Cr-3Al (aged)	192	general structure		
Ti-Si	193	general structure		
Ti alloys	186, 187, 192, 194, 158, 132b, 1c, <u>67</u> , 68, 69, 3a	general structure		
	11, 1c	reveals alpha case		
	72, 192, 178	chemical polish and etch		
	170a	outlines and darkens hydride in		
	1104			
	188	some alloys		
Tungsten base:	100	removes stain		
	20 404			
Pure W	98c, <u>131</u>	general structure		
As cast	132a	chemical polish prior to etching		
W-Th	209	general structure		
Uranium base:		_		
Pure U	<u>67, 69, 195, 196</u>	general structure		
U + Zr	68	general structure		
U beryllides	17 0a	general structure		
U alloys	67, 69, 195, 196	general structure		
	207 150, 150	carbides		
Vandaium base:	201	carbides		
Pure V	170h 165h			
1 ule v	170b, <u>165b</u>	general structure		
¥7 - 11	<u>197, 198</u>	grain boundaries		
V alloys	199, 198	general structure		
Zinc base:				
Pure Zn	200a	general structure		
Zn-Co	177	general structure		
Zn-Cu	201	general structure		
	203	distinguishes gamma and epsilon		
Zn-Fe	200 74a	structure of galvanized sheet		
Die castings	202	general structure		
Zirconium base:		general structure general structure		
Zarcomant vase.	66, <u>67, 204, 68, 69, 205</u>			
	206	electrolytic polish and etch		
	71	grain structure under polarized light		
	72	chemical polish and etch		

TABLE 2 NUMERICAL LIST OF ETCHANTS

Etchant	Composition	Procedure
1	1 ml HF 200 ml water	 (a) Swab with cotton for 15 seconds. (b) Alternately immerse and polish several minutes. (c) Immerse 3 to 5 seconds.
2	l g NaOH 100 ml water	 (d) Immerse 10 to 120 seconds. (a) Swab 10 seconds to reveal general structure. (b) Immerse 15 min. wash 10 min. in water to form film with hatching which varies with grain orientation.
3	2 ml HF 3 ml HC1 5 ml HNO ₃	(a) Immerse 10 to 20 sec. Wash in stream of warm water. Reveals general structure.
	190 ml water	(b) Dilute with 4 parts water — colors constituents — Mix fresh.
4	25 ml H ₃ PO ₄ 50 ml Carbitol (diethylene glycol monoethyl ether) 4 g boric acid 2 g oxalic acid 10 ml HF 32 ml water	Electrolytic: Use carbon cathode raising d-c voltage from 0 to 30 V in 30 sec. Total etching time 3 min. with agitation. Wash and cool. Repeat if necessary.

Etchant	Composition	Procedure
5	5 g HBF ₄ 200 ml water	Electrolytic: Use Al, Pb. or stainless steel cathode. Anodize 1 to 3 minutes, 20 to 45 V d-c. At 30 V, etch for 1 minute.
6	25 ml HNO ₃ 75 ml water	Immerse 40 seconds at 70 C (l60 F). Rinse in cold water.
7	10 -20- ml H_2SO_4 80 ml water	Immerse 30 seconds at 70 C (l60 F). Rinse in cold water.
8	10 ml H ₃ PO ₄ 90 ml water	(a) Immerse 1 to 3 minutes at 50 C (120 F).(b) Electrolytic at 1 to 8 V for 5 to 10 seconds.
9	3-4 g sulfamic acid 5 drops HF 100 ml water	Use just prior to the last polishing operation. It is not intended as a final etchant. The sample is examined as polished under polarized light.
10	10 ml HF 90 ml methanol (95%)	Immerse 10 to 30 seconds. Immerse or swab few seconds to a minute.
11	2 ml HF 100 ml water	Use Hood. Do not Store. Immerse or swab 5 to 60 seconds.
12	20 ml HNO ₃ 60 ml HC1	
13	10 g oxalic acid 100 ml water	Electrolytic at 6 V: (a) 10 to 15 seconds. (b) 1 minute. (c) 2 to 3 seconds.
14	10 ml HNO ₃	Use stainless steel cathode and platinum or Nichrome connection to specimen. Immerse few seconds to a minute.
15	90 ml methanol (95%) 15 ml HNO ₃ 15 ml acetic acid 60 ml HC1	Age before use. Immerse 5 to 30 seconds. May be used electrolytically.
16	15 ml water 5-10 ml HC1	Electrolytic at 3 V for 2 to 10 seconds.
17	100 ml water 5 ml HC1 10 g FeC1 ₃	Electrolytic at 6 V for few seconds.
18	100 ml water 2-10 g CrO ₃	Electrolytic at 3 V for 2 to 10 seconds.
19	100 ml water A 2 g CrO ₃ 100 ml water B	Two step process: Electrolytic at 3 V for 2 seconds in Solution A, then rinse in water. While still wet, immerse in Solution B for 5 to 10 seconds (use fresh).
	4 g NaOH 10 g KMnO ₄ 85 ml water	
20	5 ml H ₂ O ₂ (30%) 100 ml HC1	Use Hood. Mix fresh. Immerse polished face up for few seconds.
21	1 g CrO ₃ 140 ml HC1	Use Hood. To mix, add the HCl to CrO ₃ . Electrolytic at 3 V for 2 to 10 seconds.
22	100 ml HC1 0.5 ml H ₂ O ₂ (30%)	Use Hood. Do not Store. (a) Immerse or swab 1/2 to 3 minutes Add H ₂ O ₂ dropwise to maintain action. (b) Electrolytic, 4 V, 3 to 5 seconds.
23	5 ml HC1 95 ml ethanol (95%) or methanol (95%)	Electrolytic at 6 V for 10 to 20 seconds.
24	5 ml HNO ₃ 200 ml HCl 65 g FeCl ₃	Use Hood. Immerse few seconds.
25	10 g CuSO ₄ 50 ml HCl 50 ml water	Immerse or swab 5 to 60 sec. Made more active by adding few drops of H_2SO_4 just before use.
26	5 g FeCl ₃ 10 ml HCl 50 ml glycerin 30 ml water	Swab 16 to 60 sec. Activity may be decreased by substituting glycerin for water.
27	1 g KOH 20 ml H ₂ O ₂ (3%) 50 ml NH ₄ OH 30 ml water	Dissolve KOH in water, then slowly add NH_4OH to solution. Add 3% H_2O_2 last. Use fresh — immerse few seconds to a minute.
28	1 g FeNO ₃ 100 ml water	Swab or immerse few seconds to a minute.

Etchant	Composition	Procedure	
29	1 g K ₂ Cr ₂ O ₇ 4 ml H ₂ SO ₄	Add 2 drops of HCl just before using. Swab few seconds to a minute.	
30	50 ml water 25 ml NH ₄ OH 25 ml water	Mix NH ₄ OH and water before adding H ₂ O ₂ . Must be used fresh, Swab 5 to 45 seconds.	
	50 ml H ₂ O ₂ (3%)	ALDERIC STATE OF TO TO DOCUMENT	
31	10 g ammonium persulfate 100 ml water	(a) Swab or immerse to 5 seconds.(b) Immerse to 2 minutes to darken matrix to reveal carbides and phosphides.	
. 00	60 × C×O	(c) Electrolytic at 6 V for few seconds to a minute.(d) Immerse 3 to 60 seconds. Can be heated to increase activity.	
32	60 g CrO ₃ 100 ml water	Saturated solution. Immerse or swab 5 to 30 seconds.	
33	10 g CrO ₃ 2-4 drops HC1	Add HCl just before use. Immerse 3 to 30 seconds Phases can be colored by Nos. 35, 36,	
34	100 ml water 5 g FeCl ₃ 50 ml HCl	37. (a) Immerse or swab few seconds to few minutes. Small additions of HNO potity to solution and minimize pitting.	
	100 ml water	ditions of HNO ₃ activate solution and minimize pitting. (b) Immerse or swab few seconds at a time. Repeat as	
35	20 g FeC1 ₃	necessary. Immerse or swab few seconds at a time until desired re-	
	5 ml HCl 1 g CrO ₃ 100 ml water	sults are obtained.	
36	25 g FeC1 ₃ 25 ml HC1	Immerse or swab few seconds at a time until desired results are obtained.	
37	100 ml water 1 g FeCl ₃	Immerse or swab few seconds at a time until desired re-	
	10 ml HCl 100 ml water	sults are obtained.	
38	8 g FeC1 ₃ 25 ml HC1	Swab 5 to 30 seconds.	
39	100 ml water 5 g FeCl ₃ 10 ml HCl	Immerse or swab few seconds at a time until desired results are obtained.	
40	1 g CuCl ₂ 0.1 g SnCl ₂ 100 ml water 5 g FeCl ₃ 15 ml HCl	Immerse or swab few seconds to few minutes.	
	60 ml ethanol (95%) or methanol (95%)		
41	$2 g K_2Cr_2O_7$ $8 ml H_2SO_4$ 4 drops HCl 100 ml water	Add the HCl just before using. Immerse 3 to 60 seconds.	
42	10 g ammonium cupric chloride 100 ml water NH₄OH	Add NH ₄ OH to solution until neutral or slightly alkaline. Immerse 5 to 60 seconds.	
43	20 ml NH₄OH 1 g ammonium persulfate	Immerse 5 to 30 seconds.	
44	60 ml water 50 ml NH ₄ OH 20-50 ml H ₂ O ₂ (3%) 0-50 ml water	Use fresh. Peroxide content varies directly with copper content of alloy to be etched. Immerse or swab to 1 minute. Film on etched aluminum bronze removed by No. 82.	
45	1 g CrO ₃ 100 ml water	Electrolytic at 6 V for 3 to 6 seconds. Use aluminum cathode.	
46	15 ml NH ₄ OH 15 ml H ₂ O ₂ (3%) 15 ml water	When mixing, add NaOH pellets last. For best results use before pellets have dissolved.	
47	4 pellets NaOH 5 g NaCN or KCN 5 g $(NH_4)_2S_2O_8$ 100 ml water	Use Hood. — Can give off extremely poisonous hydrogen cyanide. Precaution — Also poisonous by ingestion as well as contact. To discard, neutralize (or turn basic) with ammonia and flush down acid drain with copious amount of water.	

Etcl	hant Composition	Procedure
48	10 g NaCN 100 ml water	Use Hood. — Can give off extremely poisonous hydrogen cyanide. Precaution — Also poisonous by ingestion as well as contact. To discard, neutralize (or turn basic) with ammonia and flush down acid drain with copious
		amount of water. Electrolytic at 6 V: (a) 5 seconds for sigma. (b) 30 seconds for ferrite and general structure.
		(c) to 5 minutes for carbides
49	$3 g FeSO_4$ $0.4 g NaOH$ $10 ml H_2SO_4$	Electrolytic at 8-10 V (0.1 A) for 5 to 15 seconds.
F0	190 ml water	Use Hood. Do not Store. Electrolytic at 1.5 V for 20 to 60 sec-
50	5 ml acetic acid 10 ml HNO ₃ 85 ml water	onds. Use platinum wires.
51	2 g FeCl ₃ 5 ml HCl	Immerse few minutes.
52	30 ml water 60 ml ethanol or methanol 1 g sodium dichoromate 1 g NaCl 4 ml H ₂ SO ₄	Swab few seconds.
53	250 ml water 1-5 ml NH ₄ OH 100 ml water	Immerse 5 to 60 seconds.
54	I g ammonium acetate 3 g sodium thiosulfate 7 ml NH ₄ OH	Electrolytic at 0.3 A/cm^2 for 5 to 30 seconds.
	1300 ml water	Swab gently 10 to 15 seconds. Rinse with methanol and blow dry.
55	1 ml H ₂ SO ₄ 15 ml NHO ₃ 10 ml acetic acid 5 ml H ₃ PO ₄	Helps to chemically polish. If final etch is too mild, follow with No. 98.
56	20 ml lactic acid 30 ml NHO ₃ 10 ml H ₃ PO ₄ 20 ml acetic acid	Swab gently 5 to 15 sec. Rinse with methanol or ethanol and blow dry.
57	10 ml lactic acid 75 ml acetic acid	Immerse 6 to 15 seconds.
58	25 ml H ₂ O ₂ (30%) 25 ml HF 25 ml HNO ₃	Swab 3 to 20 seconds.
59	5 ml water 2 AgNO ₃ 40 ml water 40 ml HF	Mix $AgNO_3$ and water, then add HF and HNO_3 . Swab $1/2$ to 2 minutes.
60	20 ml HNO ₃ 25 ml HNO ₃ 15 ml acetic acid 15 ml HF	Use Hood. Let stand $1/2$ hour before using. Swab 3 to 20 seconds.
61	5-7 drops bromine 60 ml HC1	Use Hood. Immerse few seconds to a minute.
62	40 ml HNO ₃ 1-5 g CrO ₃ 100 ml HC1	Vary composition of reagent and aging of reagent after mixing to suit alloy. Swab or immerse few seconds to a minute.
63	0.1 g CrO ₃ 10 ml HNO ₃	Swab few seconds to a minute.
64	100 ml HCl 5 ml HNO ₃ 25 ml HCl	(a) Immerse 1 to 5 minutes.(b) Use hot. Will form chloride film on gold alloys if much silver is present. Ammonia will remove film.
65	30 ml water A 10 g ammonium persulfate 100 ml water B	Use Hood. Mix 1 + 1 mixture of Solutions A and B just before use. (A mixture of 5 drops of each will cover the surface of a 1 inch dia. mount.) Immerse 1/2 to 2 minutes.
66	10 g KCN 100 ml water 30 ml HF 15 ml HNO ₃ 30 ml HC1	Swab 3 to 10 sec. or immerse to 2 minutes.

67 10 ml perchloric acid 10 ml 2-butoxyethanol 70 ml ethanol (95%) 10 ml water 68 3 ml perchloric acid 35 ml 2-butoxyethanol 60 ml methanol (absolute) 69 5 ml perchloric acid 80 ml acetic acid 70 5 ml HF 2 ml AgNO ₃ (5%) 2000 ml water 71 5 ml HF 95 ml water 72 10 ml HF 45 ml HNO ₃ 45 ml water 73 20 ml HCl 25 g NaCl 65 ml water 74 1-5 ml HNO ₃ 100 ml ethanol (95%) or 75 ml HNO ₃ 100 ml ethanol (95%) or 76 10 to 60 seconds. 77 Electrolytic at 60-150 V for 5 to 30 seconds. 8 Electrolytic at 20-60 V for 1 to 5 minutes. 8 Swab for 5 to 60 seconds. 8 Add 5 to 10 drops of this solution to the cle ishing wheel which has been charged ing solution. The specimen is polished water added to the wheel and polishing the surface turns black. Distilled water added to the wheel and polishing the surface is bright. At this time should be ready for examination via polar. 8 Note — Use inert substance between cloth vent attack of the wheel. 9 Swab for 5 to 20 seconds. 8 Electrolytic at 60-150 V for 5 to 30 seconds. 8 Swab for 5 to 60 seconds. 9 Add 5 to 10 drops of this solution to the cle ishing wheel which has been charged ing solution. The specimen is polished of the surface is bright. At this time should be ready for examination via polar. 10 ml HF 10 m	oth on the final pol- l with the polish- on this wheel until ter is then slowly continued until ne the specimen ized light. n and wheel to pre-
10 ml 2-butoxyethanol 70 ml ethanol (95%) 10 ml water 8	oth on the final pol- l with the polish- on this wheel until ter is then slowly continued until ne the specimen ized light. n and wheel to pre-
70 ml ethanol (95%) 10 ml water 3 ml perchloric acid 35 ml 2-butoxyethanol 60 ml methanol (absolute) 69 5 ml perchloric acid 80 ml acetic acid 70 5 ml HF 2 ml AgNO ₃ (5%) 200 ml water 71 5 ml HF 95 ml water 72 10 ml HF 45 ml HNO ₃ 45 ml water 73 20 ml HCl 25 g NaCl 65 ml water 74 1-5 ml HNO ₃ 10 ml ethanol (95%) 10 ml water 2 ml ethanol (95%) 10 ml water Electrolytic at 20-60 V for 1 to 5 minutes. Swab for 5 to 60 seconds. Electrolytic at 20-60 V for 1 to 5 minutes. Add 5 to 10 drops of this solution to the cleaning solution. The specimen is polished of the surface turns black. Distilled war added to the wheel and polishing the surface is bright. At this tim should be ready for examination via polar. Note — Use inert substance between cloth vent attack of the wheel. Swab for 5 to 20 seconds. Electrolytic etch — use carbon cathode and nection to specimen. (a) 6 V ac for 1 minute. (b) 5 V to 20 V ac for 1 to 2 minutes. (c) 20 V ac for 1 to 2 minutes. For etch-polishing, use shorter times. A rinse, alcohol rinse, and dry. Etching rate is increased, selectivity of	I with the polish- on this wheel until ter is then slowly continued until ne the specimen ted light. n and wheel to pre- platinum wire con- fter etching, water
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rinse, alcohol rinse, and dry. 74 1-5 ml HNO3 Etching rate is increased, selectivity of	
	ecreased with in-
methanol (95%) (a) Immerse few seconds to a minute. (b) Immerse 5 to 40 seconds in 5% HNO ₃ stain, immerse 25 seconds in 10% HCl-met. (c) For Inconels and Nimonics, use 5 relectrolytic at 5 to 10 V for 5 to 20 seconds (d) Swab or immerse several minutes. (e) Swab 5 to 60 sec. HNO ₃ may be increase nol only depending on alloy. (Ethano over 5% HNO ₃). Do not Store.	nanol solution. nl HNO ₃ solution- d to 30 ml in <i>metha-</i>
and the state of t	ely rinse with methanol.
8 g CuCl ₂ Repeat as often as necessary. (Long 20 ml HCl will result in copper deposition on surface.	immersion times
6 ml HNO ₃	
20 ml ethanol (95%) or	
methanol (95%) 76 10 g picric acid Composition given will saturate the so	dution with pieric
100 III culturol (0070) 01	
methanol (95%) 77 10 g picric acid Composition given will saturate the so	olution with picric
77 10 g picric acid Composition given will saturate the so 5 drops HCl acid. Immerse few seconds to a minute or	more
o atopo 1101	
100 ml ethanol (95%) or	
methanol (95%) 78 10 g potassium metabisulfite Immerse 1 to 15 seconds. Better results are	sometimes obtained
	somemics optained
79 40 mm 1101	
5g CuCl ₂	
30 ml water	
25 ml ethanol (95%) or	
methanol (95%) 80 5 ml HCl Immerse or swab few seconds to 15 minut	as Reaction may be
	Oo
	ndaries) — temper
	nuaries, — temper
methanol (95%) specimen at 600-900 F prior to preparation	
81 2 g picric acid Composition given will saturate the so	nution with picric
1 g sodium acid.	
tridecylbenzene sulfonate	
100 ml water (a) Immerse few seconds to a minute. (b) Immerse to 15 minutes with occasi heavy grain boundary attack.	onal swabbing for

Etchant	Composition	Procedure Procedure
82	5 g FeCl ₃	Immerse 5 to 10 seconds.
04	5 drops HCl	immerse 5 to 10 seconds.
	100 ml water	
83	10 g CrO ₃	(a) Electrolytic at 6 V for 5 to 60 seconds. Attacks carbides.
	100 ml water	(b) Electrolytic at 6 V for 3 to 5 seconds.
84	$10 \mathrm{ml} \mathrm{H}_2 \mathrm{SO}_4$	Precaution- Add H ₂ SO ₄ slowly to water and cool, then ac
	$10 \mathrm{ml} \mathrm{HNO}_3$	HNO3. Immerse 30 seconds. Swab in running water. Repeat
0.5	80 ml water	three times and repolish lightly.
85	2 g picric acid	Immerse in boiling solution for 5 minutes. Precaution —
	25 g NaOH 100 ml water	Do not boil dry — anhydrous picric acid is unstable and
	100 mi water	highly explosive. Alternative: Electrolytic at 6 V for 40 seconds (room temperature). Use stainless steel cathode.
86	3 g oxalic acid	Solution should be freshly prepared. Immerse 15 to 25 min.
	$4 \text{ ml H}_2\text{O}_2 (30\%)$	when samples or parts cannot be given usual metallogra-
	100 ml water	phic polish. Multiple etching may be required.
87	$10 \mathrm{ml} \mathrm{HNO_3}$	Use Hood Can give off nitrogen dioxide gas. Precaution
	20-50 ml HCI	- Mix HCl and glycerin thoroughly before adding HNO ₃ .
	30 ml glycerin	Do not Store. Discard before solution attains a dark
		orange color. Immerse or swab few seconds to few minutes. Higher percentage of HCl minimizes pitting.
		A hot water rinse just prior to etching may be used to
		activate the reaction. Sometimes a few passes on
		the final polishing wheel is also necessary to remove a pas-
		sive surface.
88	10 ml HNO ₃	Use Hood Can give off nitrogen dioxide gas. Precaution -
00	20 ml HC1	Discard before solution attains a dark orange color.
	30 ml water	Immerse few seconds to a minute. Much stronger reac-
		tion than No. 87.
89	10 ml HNO ₃	Use Hood. Do not Store. Immerse or swab few seconds to
	10 ml acetic acid	few minutes.
	15 ml HC1	
90	2-5 drops glycerin 10 ml HNO ₃	Immerse 2 to 10 seconds.
.///	20 ml HF	interest 5 to 10 occords.
	20-40 ml glycerin	
91	5 ml HNO ₃	This etchant is equivalent to a 1 + 1 mixture of No. 80 and No. 74
	5 ml HC1	$(5\% \text{ HNO}_3)$. Swab for 30 seconds or longer.
	1 g picric acid	
	200 ml ethanol (95%) or	
92	methanol (95%) 10 ml HC1	Immerse 5 to 30 minutes or electrolytic at 6 V for 3 to 5 seconds.
94	100 ml ethanol (95%) or	immerse 5 to 50 minutes of electrorytic at 6 V tor 5 to 5 seconds.
	methanol (95%)	
93	concentrated HNO ₃	Use Hood. Electrolytic at 0.2 A/cm ² for few seconds.
94	2 g CuCl ₂	Submerged swabbing for few seconds to several minutes.
	40 ml HC1	Attacks ferrite more readily than austenite.
	40-80 ml ethanol (95%) or	
95	methanol (95%)	Immerse or swab few seconds to few minutes.
30	2 g CuCl ₂ 40 ml HCl	finitierse of swap few seconds to few finitudes.
	40-80 ml ethanol (95%) or	
	methanol (95%)	
	40 ml water	
96	85 g NaOH	Electrolytic at 6 V for 5 to 10 seconds.
0.77	50 ml water	
97	45 g KOH	Composition of solution is approximately 10 normal. Electrolytic at 2.5 V for few seconds. Stains sigma and chi yel-
	60 ml water	low to red brown, ferrite gray to blue gray, carbides
		barely touched, austenite not touched.
98	10 g K ₃ Fe(CN) ₆	Use Hood. — Can give off extremely poisonous hydrogen cya-
	10 g KOH or NaOH	nide. Precaution — Also poisonous by ingestion as well as
	100 ml water	contact. To discard, neutralize (or turn basic) with am-
		monia and flush down acid drain with copious amount of
		water. Use fresh.
		(a) Immerse or swab 15 to 60 seconds. Stains carbides and
		sigma. (To differentiate, No. 31 electrolytic at 4 V will attack sigma but not carbides. If pitting occurs, reduce voltage.)
		(b) Immerse in fresh, hot solution 2 to 20 minutes. Stains car-
		bides dark, ferrite yellow, sigma blue. Austenite turns
		brown on overetching.

brown on overetching.

(c) Swab 5 to 60 seconds. (Immersion will produce a stain etch). Follow with water rinse, alcohol rinse, dry.

Etchant	Composition	Procedure
1	25 ml HC1 3 g ammonium bifluoride 25 ml water	Mix fresh. (For stock solution, mix first three items. Add potassium metabisulfite just before use.) Immerse few seconds to a few minutes.
100	ew grains potassium metabisulfite. 10 g FeCl ₃	Immerse few seconds.
101	90 ml water 2 g CrO ₃ 20 ml HC1 80 ml water	Immerse 5 to 60 seconds. (CrO ₃ may be increased up to 20 g for difficult alloys. Staining and pitting increase as CrO ₃ is increased.)
102 c	oo in water oncentrated NH ₄ OH 20 ml HNO ₃ 4 ml HC1	Electrolytic at 6 V for 30 to 60 seconds. Attacks carbides only. Immerse 10 to 60 seconds.
104	20 ml methanol (99%) 5 ml HNO ₃ 45 ml HC1	Immerse 10 minutes or longer.
105	50 ml water 5 ml H ₂ SO ₄ 3 ml HNO ₃ 90 ml HC1	Use Hood. Precaution — Add H ₂ SO ₄ slowly to HCl with stirring, cool, then add HNO ₃ . Discard when dark orange color. Swab 10 to 30 seconds.
106	7 ml HNO ₃ 25 ml HCl	Use fresh to avoid pitting. Immerse or swab 10 to 60 seconds.
107	10 ml methanol (99%) 10 ml H ₃ PO ₄ 50 ml H ₂ SO ₄ 40 ml HNO ₃	Use Hood. Precaution — Mix H ₃ PO ₄ and HNO ₃ thoroughly, then add H ₂ SO ₄ slowly with stirring. Use fresh, but allow to cool. Electrolytic at 6 V for few seconds. Brown discoloration will form at edges of specimen. To slow reaction, add water (to 100 ml) very carefully with
108	3-10 ml H ₂ SO ₄	stirring. Attacks bakelite mounts. Electrolytic at 6 V for 5 to 10 sec. Tends to pit with longer times.
109	00 ml water 50 ml HC1 25 ml HNO ₃ 1 g CuC1 ₂	Make fresh but allow to stand 30 min. to avoid plating out copper. Immerse few seconds to a few minutes.
110	150 ml water 10 ml HC1 5 ml HNO ₃ 85 ml ethanol (95%) or	Immerse to several minutes until deeply etched. Follow with light repolish.
111	methanol (95%) 5 ml H ₂ SO ₄ 8 g CrO ₃	Electrolytic at 10 V $(0.2\mathrm{A/cm^2})$ for 5 to 30 sec. Reveals Ti & Cb-rich areas at a faster rate than grain boundaries.
112	85 ml H ₃ PO ₄ 60 ml acetic acid	Immerse 8 to 15 seconds.
113	30 ml H ₂ O ₂ (30%) 15 ml acetic acid 15 ml HNO ₃	Use fresh solution at 80 C (176 F).
114	60 ml glycerin 15 ml acetic acid 20 ml HNO ₃ 80 ml water	Use fresh solution at 40 to 42 C (104 to 108 F). Immerse 4 to 30 minutes depending on depth of worked metal layer. Clean with cotton in running water.
115	100 ml acetic acid 10 ml H ₂ O ₂ (30%)	Immerse 10 to 30 minutes depending on depth of worked metal layer. Clean in HNO ₃ if necessary.
116	5-10 g AgNO ₃ 90 ml water	Swab.
117	10 ml HC1	(a) Immerse for 1/2 to 5 minutes. Follow with electrolytic etch at low current density in same solution. If sample has considerable surface flow, immerse in concentrated HCl for a few seconds, then follow above procedure. (b) Immerse for 1 to 2 minutes.
118	1 ml HNO ₃ 75 ml diethylene glycol 25 ml water	Swab 3 to 5 seconds for F and T6, 10 seconds for T4 and 0 temper.
119	1 ml HNO ₃ 20 ml acetic acid 60 ml diethylene glycol	Swab 1 to 3 seconds for F and T6, 10 seconds for T4 and 0 temper.
120	20 ml water 10 ml HF 90 ml water	Immerse with gentle agitation 3 to 30 seconds.

Etchant	Composition	Procedure
121	$0.7 \text{ml} \text{H}_3 \text{PO}_4$	Composition critical.
	4 g picric acid	(a) Immerse with gentle agitation 10 to 30 seconds.
	100 ml methanol (95%) or	(b) To increase staining immerse and withdraw with a menis
	ethanol (95%)	cus layer. Tease etchant over surface until dark stair
		develops.
122	2 g oxalic acid	Swab.
	100 ml water	
123	$60 \mathrm{mlH_3PO_4}$	Electrolytic: Use stainless steel cathode. Space elec-
	100 ml ethanol (95%)	trodes 2 cm apart. Start at 3 V dc. After 30 sec. maintain at 1½ V.
124	5 ml acetic acid	Immerse with gentle agitation 10 to 60 seconds.
	10 ml water	
٠.	6 g picric acid	
	100 ml methanol (95%) or	
	ethanol (95%)	
125	10 ml acetic acid	Immerse with gentle agitation 15 to 30 seconds.
	6 g picric acid	
	100 ml methanol (95%) or	
100	ethanol (95%)	Towns and the second of the contract of the co
126	30 ml acetic acid	Immerse with gentle agitation 1 to 30 seconds.
	15 ml water	
	6 g picric acid	
	100 ml methanol (95%)or ethanol 95%)	
127	20 ml acetic acid	Immerse with gentle agitation 5 to 30 seconds.
121	20 ml water	immerse with genue agreement of to be seconds.
	3 g picric acid	
	50 ml methanol (95%) or	
	ethanol (95%)	
128	8 ml HF	Immerse with gentle agitation 5 to 15 seconds.
	5 ml HNO ₃	
	200 ml water	
129	10 ml HF	Swab 10 to 20 seconds. Vary HF to increase or decrease activity.
	30 ml HNO ₃	
	60 ml lactic acid	
130	25 ml HC1	Caution — Keep below 24 C (75F). Electrolytic at 30 V for 30
	$10 \mathrm{ml}\mathrm{H}_2\mathrm{SO}_4$	seconds.
	75 ml methanol	
131	$5 \mathrm{ml}\mathrm{H}_2\mathrm{SO}_4$	Electrolytic at 50 to 60 V for 10 to 20 seconds.
	1 ml HF	
	100 ml methanol (95%)	TT. C. 1
132	5 ml HF	Use fresh.
	10 ml HNO ₃	(a) Swab with heavy pressure for 5 to 10 sec. Water rinse
	30 ml lactic acid	alcohol rinse, dry, then etch with No. 98c.
133	50 ml HNO ₃	(b) Swab for 5 to 30 seconds. Use Hood. Do not Store. Mix fresh. Immerse or swab 5 to
155		
	50 ml acetic acid	30 sec. Will chemically polish with longer times. Sulfidized grain boundaries etched before normal grain boundaries.
134	70 ml H ₃ PO ₄	Electrolytic at 5 to 10 V for 5 to 60 sec. (Polishes at high currents.)
104	30 ml water	Electrolytic avoice to violotto obsect (1 offshes at high cuttents.)
135	80 ml HNO ₃	Use Hood. Warm specimen in boiling water prior to immer-
100	3 ml HF	sion for 10 to 120 seconds.
136	20 ml H ₃ PO ₄	Electrolytic at 10-20 V for 10 to 15 seconds.
100	80 ml water	Dicestory we at 10 20 V for 10 to 10 seconds.
137	10g NaNO ₃	Electrolytic 9.2 A/cm ² , 1 minute.
	100 ml water	Diodiotytic 7.271, om , 1 miliator
138	5gFeCl ₃	Swab 10 to 60 seconds.
	2 ml HC1	
	100 ml ethanol (95%) or	
	methanol (95%)	
139	5 g KCN	Use Hood. Can give off extremely poisonous hydrogen cya
	100 ml water	nide. Precaution — Also poisonous by ingestion as well as
	$0.5 \text{ml} \text{H}_2\text{O}_2(3\%)$	contact. To discard, neutralize (or turn basic) with am
		monia and flush down acid drain with copious amount
		of water. Immerse 10 to 100 seconds.
140	50 ml acetic acid	Use Hood. Do not Store. Decomposes with possible explo
	50 ml HNO ₃	sion on standing. Immerse 10 to 30 seconds.
	50 ml acetone	
141	3fNH₄C1	Swab 5 to 30 seconds. Do not Store.
	3 g CrO ₃	
	10 ml HNO ₃ 90 ml water	

Etchant	Composition	Procedure
142	5 ml HF 10 ml glycerin	Electrolytic at 2-3 V for 2 to 10 seconds.
143	85 ml water 0.01-1 g CrO ₃ 100 ml HC1	Allow solution to age a few minutes before using. Immerse of swab few seconds to few minutes.
144	A 10 g sodium thiosulfate 100 ml water	Electrolytic in Solution A: sample is cathode, 10 V, 5 to 10 sec Then electrolytic in Solution B: sample is anode, 10 V, 5 to 10 seconds.
	B 10 ml HC1	
145	90 ml water 2 ml H ₂ SO ₄	Electrolytic at 3 to 10 V for 5 to 15 seconds. Use platinum wires.
146	100 ml water 10 ml HF 100 ml HNO ₃	$\mathrm{H_{2}SO_{4}}$ may be increased to 20 ml for deeper attack. Immerse 30 seconds to 3 minutes.
147	20 ml HNO ₃ 80 ml HC1	Immerse 5 to 30 seconds.
148	5 ml HNO ₃ 100 ml water	Immerse 10 to 30 seconds.
149	50 ml HC1 2 ml H ₂ O ₂ (30%)	Immerse 10 to 30 seconds. Do not store.
150	50 ml water 60 ml HCl 20 ml HNO ₃	Use Hood. Do not Store. Swab few seconds to a minute. Discard when solution turns dark yellow.
151	40 ml glycerin 10 ml HF 25 ml HNO ₃	Swab 5 to 30 seconds.
152	150 ml water 85 ml NH ₄ OH	Immerse 5 to 15 seconds. Do not Store. Decomposes.
153	15 ml H ₂ O ₂ (30%) 10 ml HNO ₃ 50 ml HC1	Use Hood. Do not Store. Add HNO ₃ last. Discard when dark yellow. Immerse 10 to 60 seconds. Preheating sample in boiling
154	60 ml glycerin 50 ml HC1 50 ml ethanol (95%) or methanol (95%)	water hastens reaction. Immerse 10 to 100 seconds.
155	3 ml selenic acid 10 ml HCl 100 ml methanol (95%) or	Immerse 1 to 15 minutes. (Up to 30 ml of HCl may be used for more vigorous action.) Stable for 3 to 90 days, depending on HCl concentrations.
156	ethanol (95%) 1 g thiourea 1 ml H ₃ PO ₄	Electrolytic, 0.005-0.01 A/cm ² , 1 to 2 minutes.
157	1000 ml water 25 g CrO ₃ 150 ml HCl	Immerse 5 to 20 seconds.
158	50 ml water 10 ml HF 10 ml HNO ₃	Swab 5 to 15 seconds.
159	20 ml glycerin 5 ml HF 20 ml HNO ₃	Swab 10 to 30 seconds.
160	50 ml acetic acid 20 ml HF 15 ml H ₂ SO ₄ 5 ml HNQ ₃	Immerse to 5 minutes.
161	50 ml water 25 ml HNO ₃ 5 ml HF	Immerse 5 to 120 seconds.
162	50 ml water A 50 ml lactic acid 30 ml HNO ₃ 2 ml HF B	Swab 1 to 3 minutes in Solution A. (acts as etch polish). To etch, swab with Solution B for 5 seconds. Repeat if necessary. The HF may be varied to give more or less etching.
163	$30 \mathrm{ml}$ lactic acid $10 \mathrm{ml}$ HNO ₃ $10 \mathrm{ml}$ HF $30 \mathrm{ml}$ H ₂ SO ₄ $30 \mathrm{ml}$ HF $3-5 \mathrm{drops}\mathrm{H}_2\mathrm{O}_2(30\%)$ $30 \mathrm{ml}$ water	Immerse 5 to 60 seconds. Use this solution for alternate etch and polishing.

fore use. (A mixture of 5 drops of each will cover the sur face of a 1 in. dia. mount.) Immerse to several imputes. 167	Etchant	Composition	Procedure
30 g ammonium bifluoride 20 ml water 165	164		Use Hood. Swab 3 to 10 seconds.
166 10 ml HCl 90 ml chanol 167 A 168 A 169 ml water 169 ml water 169 S p NaCN 100 ml water 168 20 ml HCl 33 g NaCl 100 ml water 169 5 ml HNO ₃ 30 ml Water 171 Concentrated HCl 172 A 173 S g mamonium persulfate 180 ml water 174 A 25 g mmonium persulfate 187 S g mmonium persulfate 188 S g KCN 30 ml water 189 ml mater 170 ml water 171 Concentrated HCl 172 A 25 ml HNO ₃ 30 ml HNO ₃ 30 ml HNO ₃ 30 ml HNO ₃ 30 ml Mater 317 S g mmonium persulfate 32 g FCCl ₃ 33 Na ₃ SO ₄ 200 ml water 34 g C CO ₃ 3 g Na ₂ SO ₄ 200 ml water 35 g macnonium persulfate 36 ml NH ₂ OH 37 S g mmonium persulfate 376 S g mmonium persulfate 38 ml HNO ₃ 39 ml HNO ₃ 30 ml Mater 35 g mmonium persulfate 36 mmonia mmonia mmonia mmonia munum persulfate 36 mmonia mmonium persulfate 37 g mmonium persulfate 38 mmonia mmonia mmonia m			
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(b) Electrolytic at 6 V for 10 seconds. Use stainless steel can be deem platinum or Nichrome wire contact to specimen. Use Hood. Can give off extremely poisonous hydrogen conduct. To discard, neutralize (or turn basic) with ammonia and flush down acid drain with copious amount of water. Mix 1 * 1 ratio of Solutions A and B just be fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority of the fore use. (A mixture of 5 drops of each will cover the sur factority at 1½ V ac for 1 to 2 minutes. Seed at 1. d.a. and the factority of the factority of the factority of the factority of the f		90 ml ethanol	
dee and platinum or Nichrome wire contact to specimen. Jee Hood. Can give off extremely poisonous hydrogen cyanide. Precaution — Also poisonous by ingestion as well around a form of water. Mix 1 1 ratio of Solutions A and B just be fore use. (A mixture of 5 drops of each will cover the surface of a 1 in. dia. mount.) Immerse to several minutes. 167			
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methanol (95%) 1 ml HF 30 ml HNO ₃ 30 ml lactic acid (a) Swab 5 to 30 seconds. Follow with water rinse, alcohol rinse dry. (b) Swab for 10 second intervals. Increase HF to exaggerate grain boundaries. Use Hood. Electrolytic at 5 V ac for 1 to 2 minutes. For etch polishing, use shorter times. Follow with water rinse, alcohol rinse, and dry. Use Hood. Can give off extremely poisonous hydrogen cyanide. Precaution — Also poisonous by ingestion as well are contact. To discard, neutralize (or turn basic) with am monia and flush down acid drain with copious amount of water. Prepare 1 + 1 mixture of Solutions A and B just be fore use. (A mixture of 5 drops of each will cover the surface of a 1 in. dia. mount.) Immerse 1 to 2 minutes. Immerse few seconds to a minute. Prepare 1 + 1 mixture of Solutions A and B. Apply with canel's hair brush. Nonadherent film of silver chromates should form. If film adheres, add more of Solution A if none forms, add Solution B. Prepare 1 + 1 mixture of Solutions A and B. Apply with canel's hair brush. Nonadherent film of silver chromates should form. If film adheres, add more of Solution A if none forms, add Solution B. Swab or immerse 5 to 30 seconds. Use Hood. Solution B very slowly. Solution B is used as a chemical polish, though some etching will occur. Swab 2 or more minutes for desired surface. If surface is in sufficiently etched use Solution B electrolytically 17. So specimen. Use carbon cathode and platic and mum wire connection to specimen. Diseard Solution num wire connection to specimen. Diseard Solution num wire connection to specimen. Use carbon cathode and platic num wire connection to specimen. Use carbon cathode and platic num wire connection to specime numbers of the surface is in sufficiently etched use Solution B electrolytically 17.			steer cathode.
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25 ml HNO ₃ 1 g K ₂ Cr ₂ O ₇ 1000 ml water B 40 g CrO ₃ 3 g Na ₃ SO ₄ 200 ml water 175	174	·	Prepare 1 + 1 mixture of Solutions A and B. Apply with ca-
should form. If film adheres, add more of Solution A if none forms, add Solution B. 8 40 g CrO ₃ 3 g Na ₂ SO ₄ 200 ml water 175			mel's hair brush. Nonadherent film of silver chromate
B 40 g CrO ₃ 3 g Na ₂ SO ₄ 200 ml water 175		$1 \text{ g K}_2\text{Cr}_2\text{O}_7$	should form. If film adheres, add more of Solution A,
40 g CrO ₃ 3 g Na ₂ SO ₄ 200 ml water 175		1000 ml water	if none forms, add Solution B.
3 g Na ₂ SO ₄ 200 ml water 175			
175 1 g CrO ₃ Immerse to 1 minute.		3 o Na.SO.	
175		200 ml water	
1 ml H ₂ SO ₄ 1000 ml water 176	175	1 g CrO ₃	Immerse to 1 minute.
1000 ml water 2 g FeC1 ₃ Immerse 5 to 30 seconds. 100 ml water 177 10 g NaOH Swab or immerse 5 to 15 seconds. 100 ml water 178 20 ml HF 20 ml HF 30 ml HF 10 ml HF 10 ml HNO ₃ 30 ml lactic acid 179 A Use Hood. Mix Solution B very slowly. Solution B is used as a chemical polish, though some etching will occur. Swab 2 or more minutes for desired surface. If surface is in sufficiently etched use Solution B electrolytically 1/3 to 1 V/in. ² of specimen. Use carbon cathode and platinum wire connection to specimen. Discard Solution	-	1 ml H ₂ SO ₄	
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177 10 g NaOH 100 ml water 178 20 ml HF 20 ml HNO ₃ 60 ml lactic acid 179 A 10 ml HF 10 ml HF 10 ml HNO ₃ 30 ml lactic acid 10 ml HF	176		Immerse 5 to 30 seconds.
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60 ml lactic acid 179 A 10 ml HF 10 ml HNO3 30 ml lactic acid 10 ml HF 1	110		S. HAV AVE O TO BU DUDIAMU
10 ml HF 10 ml HNO ₃ Swab 2 or more minutes for desired surface. If surface is in sufficiently etched use Solution B electrolytically 1/3 to 1 V/in. ² of specimen. Use carbon cathode and plating num wire connection to specimen. Discard Solution		60 ml lactic acid	
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30 ml lactic acid sufficiently etched use Solution B electrolytically 1/2 to 1 V/in.2 of specimen. Use carbon cathode and plating num wire connection to specimen. Discard Solution			Swab 2 or more minutes for desired surface. If surface is in-
B to 1 V/in.2 of specimen. Use carbon cathode and platinum wire connection to specimen. Discard Solution		30 ml lactic acid	sufficiently etched use Solution B electrolytically 1/2
num wire connection to specimen. Discard Solution		В	to 1 V/in.2 of specimen. Use carbon cathode and plati-
B after 1 hour.			num wire connection to specimen. Discard Solution
· · · · · · · · · · · · · · · · · · ·		70 III 11 ₂ 3O ₄	B after 1 hour.

Etchant	Composition	Procedure
180	10 ml HNO ₃ 30 ml acetic acid	Immerse for $1/2$ to 10 minutes at 38 to 42 C (100 to 108 F).
181	50 ml glycerin 2 ml HCl 100 ml ethanol (95%) or	Swab for 1 to 3 minutes.
182	methanol (95%) 10 ml HNO ₃ 10 ml acetic acid	Immerse for $1/2$ to 10 minutes at 38 to 42 C (100 to 108 F).
183	80 ml glycerin 2 drops HF 1 drop HNO ₃	Immerse for 1 minute.
184	25 ml glycerin 10 g FeCl ₃ 2 ml HCl	Immerse for 1/2 to 5 minutes.
185	100 ml water 10 ml HF	Swab for few seconds.
186	10 ml HNO ₃ 10 ml HF 5 ml HNO ₃	Swab 3 to 20 seconds.
187	85 ml water 10 ml HF 30 ml HNO ₃	Swab 3 to 20 seconds.
188	50 ml water 1 ml HF 2 ml HNO ₃	Swab until stain is removed.
189	15 ml H ₂ O ₂ (30%) 50 ml water 10 ml HF 25 ml HNO ₃ 45 ml glycerin	Swab 3 to 20 seconds.
190	20 ml water 8 g KOH 10 ml H ₂ O ₂ (30%)	Swab 3 to 20 seconds.
191	60 ml water 25 ml HF 18 g benzalkonium chloride 35 ml methanol (95%)	Swab 3 to 20 seconds.
192	40 ml glycerin 1-3 ml HF 2-6 ml HNO ₃ 100 ml water	Swab 3 to 10 sec. or immerse 10 to 30 sec. (HF attacks and HNO_3 brightens the surface of titanium. Make concentration changes on this basis.)
193	2 drops HF 1 drop HNO ₃ 3 ml HCľ	Swab 3 to 20 seconds.
194	25 ml glycerin 20 ml HF 20 ml HNO ₃	Immerse 5 to 30 seconds.
195	60 ml glycerin 30 ml H ₃ PO ₄ 30 ml ethylene glycol	Electrolytic at 18 to 20 V (0.03 A/cm²) for 5 to 15 minutes.
196	50 ml ethanol (95%) 18 g CrO ₃ 75 ml acetic acid 20 ml water	Dissolve CrO ₃ in hot water and cool before adding acetic acid. Keep solution below 2 C (35 F) during use. Electrolytic at 80 V for 5 to 30 minutes. Do not Store.
197	5 g oxalic acid 100 ml water	Electrolytic at 6 V for 5 to 20 seconds.
198	30 ml HF 30 ml HNO ₃ 30 ml glycerin	Swab for 60 seconds.
199	2 ml HF 5 g AgNO ₃ 100 ml water	Swab for 5 seconds.
200	A 40 g CrO_3 $3 \text{ g Na}_2\text{SO}_4$ 200 ml water B	Immerse in Solution A with gentle agitation for several seconds. Rinse in Solution B.
	40 g CrO ₃ 200 ml water	

-		TABLE 2 — continued
Etchan	t Composition	Procedure
201	A 40 g CrO ₃ 1.5 g Na ₂ SO ₄ 200 ml water	Immerse in Solution A with gentle agitation for several seconds. Rinse in Solution B.
202	B 40 g CrO ₃ 200 ml water	
202	A 10 g CrO ₃ 1 g Na ₂ SO ₄ 200 ml water	Immerse in Solution A for 2 to 5 seconds. Rinse in Solution B.
000	B 40 g CrO ₃ 200 ml water	
203	20 g CrO ₃ 100 ml water	Electrolytic at 0.2 A/cm ² for 5 seconds.
204	10 ml perchloric acid 10 ml glycerin 70 ml ethanol (95%) 10 ml water	Precaution — Keep cool when mixing. Electrolytic at 15 to 50 V for 15 to 60 seconds.
205	5 ml HF 2 ml AgNO ₃ (5%) 100 ml water	Swab vigorously for 10 to 60 seconds. Wet cotton frequently.
206	5 ml HF 10 ml HNO ₃ 100 ml glycerin	Precaution — Discard after use. Solution decomposes on standing. Electrolytic at 9 to 12 V for 1 to 10 minutes.
207	30 ml HNO ₃ 30 ml acetic acid 30 ml water	Swab for 5 to 30 seconds.
208	1 ml NH ₄ OH 3 g ammonium persulfate 100 ml water	Immerse or swab few seconds to a minute.
209	15 ml HNO ₃ 3 ml HF 80 ml water	Immerse 5 to 60 seconds.

TABLE 3 — ETCHANT NAMES

Common Name	No.	Common Name	No.
Aqua regia	12	Grosbeck's	19
Barker's	. 5	Hatch	$\tilde{2}$
Beraha's	99	Howarth's	84
Beraha's E	155	Kalling's 1	95
Carapella	138	Kalling's 2	94
Chrome regia	101	Keller's	3
Contrast	141	Kroll's	192,187
CP4	60	Marble's	25
E1-1R	107	Murakami's	98
Flat	133	Nital	74
Frank's	104	Palmerton	200
Fry's	79	Phoschromic	111
G	107	Picral	76
Glyceregia	87	Super Picral	77
Gorsuch	75	Vilella's	80
Grard's No. 1	35	92-5-3	105
Green contrast	94	0 M O O	100

Bethlehem Steel Corporation Compiled by Homer Research Laboratories

Etching Reagent	Composition	Remarks	Uses
I. General Reagents f	or Irons and Steels (Carbon, Low	and Medium-Alloy Steels)	
Nital	2 ml HNO ₃ . 98 ml ethyl or methyl alcoho. (95% or abso-	Not as good as picral for high- resolution work with heat- treated structures. Excellent for outlining ferrite grain boundaries. Etching time: a few seconds to 1 minute.	For carbon steels: gives maximum contrast between pearlite and a ferrite or cementite network; reveals ferrite boundaries; differentiates ferrite from martensite.
Picral	4 g picric acid, 100 ml ethyl or methyl alcohol (95% or absolute; use absolute alcohol only when acid contains 10% or more moisture), 4 or 5 drops zephiran chloride (17%) — wetting agent.	Not as good as nital for revealing ferrite grain boundaries. Gives superior resolution with fine pearlite, martensite, tempered martensite, and bainitic structures. Detects carbides. Etching time: a few seconds to 1 minute or more.	For all grades of carbor steels: annealed, normal ized, quenched, quenched and tempered, spheriodized austempered.
Sodium metabisulfite	(A) 8 g Na ₂ S ₂ O ₅ , 100 ml distilled water.	General reagent for steel. Results similar to picral. Etching time: a few seconds to l minute.	Darkens as-quenched mar tensite.
	(B) 1 g Na ₂ S ₂ O ₅ , dilute to 100 ml with distilled water.	Immerse specimen in the solution for 2 min. or until the polished surface turns a bluish-red (Do not mount specimen in a steel clamp.)	plate-type martensite in Fe-C alloys.
Vilella's reagent	5 ml HCl, l g picric acid, 100 ml ethyl or methyl al- cohol (95% or absolute).	Best results obtained when martensite is tempered.	For revealing austeniti grain size in quenched an quenched and tempered steel
Heat tinting	Heat only.	Heat by placing specimen face up on a hot plate that has been preheated to 400-700 F. Time and temperature both have decided effects. Bath of sand or molten metal may be used.	given color, followed by fe rite; cementite less affe- ted, iron phosphide still less
Heat etching	Heat only.	Specimen is heated 10 to 60 minutes at 1,500-2,200 F in carefully purified hydrogen and must have no contact with scale or reducible oxides. After etching, specimen is cooled in mercury to avoid oxidation.	grain size of polished spec , mens. ;
Klemm's reagent	50 ml saturated (in H_2O) $Na_2S_2O_3$ solution, $1 \text{ g } K_2S_2O_2$.	Ferrite appears black-brown while carbides, nitrides and phosphides remain white Also, phosphorus distribution can be detected more sensitively than with usual phosphorus reagents based on copper salts.	, ened structures of unallo , ed steel, and cast iron. - e l
	ts for Alloy Steels (High Alloy, St	ainless, and Tool Steels)	D
Ferric chloride and hydrochloric acid	5 g FeC1 ₃ , 50 ml HC1, 100 m distilled water.	d Immerse until structure i revealed.	steels.
Mixed acids in glycerin	(A) 10 ml HNO ₃ , 20 ml HCl 30 ml glycerin.	oughly before adding HNO: Before etching, heat specimen in hot water. Best results are obtained with a ternate polishing and etching.	 alloys, high-speed steels, austenitic steels, and mage ganese steels. For austel-itic alloys.
	(B) 10 ml HNO ₃ , 20 ml HCL 20 ml glycerin, 10 m $\rm H_2O_2$.	 Use hood. Do not store. At 1 tion can be modified by varying the proportion of HCl. 	y Cr-Ni and Cr-Mn steel f and of all Fe-Cr austenit alloys.
Cupric chloride and hydrochloric acid	d 5 g CuCl ₂ , 100 ml HCl 100 ml ethyl alcohol, 100 m distilled water.	, Use cold.	For austenitic and ferri- steels, the ferrite being most easily attacked (co bides and austenite are r
³ From Metal F	Progress Databook.		attacked).

From Metal Progress Databook.
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Etching Reagent Nitric and hydrofluoric acids Heat tinting	Composition 5 ml HNO ₃ , 1 ml HF (48%), 44 ml distilled water. Heat only in air for 10 to 60 sec. at about 1,000-1,200 F. (595 to 650 C). Saturated solution of FeCl ₃ in HCl, to which a little	Remarks Use cold for about 5 min. under hood. HF is harmful to skin. Carbides remain white, and austenite darkens less rapidly than ferrite; specimens preferably etched first with a chemical reagent. Use hood.	Uses For revealing general structure of austenitic stainless steel with avoidance of strain markings. For austenitic stainless steels containing ferrite and carbides.
hydrofluoric acids	44 ml distilled water. Heat only in air for 10 to 60 sec. at about 1,000-1,200 F. (595 to 650 C). Saturated solution of FeCl ₃	under hood. HF is harmful to skin. Carbides remain white, and austenite darkens less rapidly than ferrite; specimens preferably etched first with a chemical reagent. Use hood.	ture of austenitic stainless steel with avoidance of strain markings. For austenitic stainless steels containing ferrite and car
Heat tinting	60 sec. at about 1,000-1,200 F. (595 to 650 C). Saturated solution of FeCl ₃	austenite darkens less rapidly than ferrite; specimens preferably etched first with a chemical reagent. Use hood.	containing ferrite and car
	Saturated solution of FeCl ₃ in HCl, to which a little		
and nitric acid	HNO_3 is added.	Use full strength under hood.	Structure of stainless steels.
	30 ml HCl, 10 ml HNO ₃ , saturate with cupric chloride, and let stand 20 to 30 minutes before using.	Apply by swabbing.	For stainless alloys and others high in nickel or cobalt.
Nitric and acetic acids	30 ml HNO ₃ , 20 ml CH ₃ COOH.	Apply by swabbing under hood. Do not store.	For stainless alloys and others high in nickel or cobalt.
Marble's reagent	4 g CuSO ₄ , 20 ml HCl, 20 ml distilled water.	Immerse to reveal structure.	Structure of stainless steels.
Ferricyanide solution	50 g K ₃ Fe (CN) ₆ , 50 g KOH, 100 ml distilled water.	Must be fresh. Use boiling 2 to 5 min. under hood. Do not acidify; deadly HCN may be released.	To distinguish between fer rite and sigma phase in Fe Cr, Fe-Cr-Ni, Fe-Cr-Mn and related alloys. Colors sigma blue, ferrite yellow.
Vilella's reagent	5 ml HCl, 1 ml picric acid, 100 ml ethyl or methyl al- cohol (95% or absolute).	Immerse to reveal structure.	Can etch numerous type of Fe-Cr, Fe-Cr-Ni, and Fe-Cr-Mn steels. Also at tacks the grain boundarie in Cr-Ni austenitic steels.
Cupric sulfate and perchloric acid	10 g CuSO ₄ , 45 ml per- chloric acid (70%), 55 ml distilled water.	Boil 15 min. Do not use in presence of organic materials. Use hood; do not concentrate acid. Highly explosive.	Etches stainless steels, and shows chromium segrega- tion by revealing areas poo- in chromium.
Acetic, nitric, and hydrochloric acids	25 ml CH ₃ COOH, 15 ml HNO ₃ , 15 ml HCl, 5 ml distilled water.	Apply by swabbing under hood. Do not store.	Fe-Al alloys, general mi crostructure.
Hydrochloric and chromic acids	25 ml HCl, 50 ml CrO ₃ (10% chromic acid aqueous solution).	Activity is controlled by the amount of chromic acid. Use hood.	Suitable for heat-treated type 300 stainless steels.
Hydrochloric acid in alcohol	50 ml HCl, 50 ml ethylalcohol.	More gradual etching can be obtained with less con- centrated solutions (10-20%).	Suitable for etching steel containing chromium and nickel.
Mixed acids in ethyl alcohol	2.5 g FeCl ₃ ,5 g picric acid, 2 ml HCl, 90 ml ethyl alcohol.	Etching time: 15 sec for austenitic cast irons to 1 hour or more for high-chromium ferritic irons.	For high-chromium, high carbon cast irons.
Nitric acid	5 to 10 ml HNO ₃ , 100 methyl or ethyl alcohol (95% or better).	Use hood. HNO ₃ and ethyl alcohol are a dangerous mixture above 5% HNO ₃ .	General structure of high speed tool steels.
Sodium metabisulfite (1)	15 g Na ₂ S ₂ O ₅ , 100 ml distilled water.	Etching time: a few seconds to 1 minute.	General structure of high speed tool steels.
Hydrochloric and nitric acids	10 ml HCl, 3 ml HNO ₃ , 100 ml methyl alcohol.	Etching time: 2 to 10 minutes.	To reveal the grain size of quenched or quenched and tempered high-speed steel.
Grosbeck's reagent	4 g KMnO ₄ , 4 g NaOH, 100 ml distilled water.	Use at boiling point for 1 to 10 minutes.	For high-speed and chromium or cobalt-rich alloys.
Sodium metabisulfite (2)	Step No. 1: 25 ml HNO ₃ , 75 ml ethyl or methyl alcohol.	Pre-etch 10 sec., outlines grain boundaries and some structure. (Caution: HNO ₃ and ethyl dangerous at this concentration).	Tint etchant for Fe-Ni alloy from 5-25% Ni. Colors may tensitic packets of different orientations different co- ors, and reveals the sub-
		, ·	structure of lath-type mar tensite.

Etching Reagent	Composition	Remarks	Uses
	Step No. 2: 15 to 35 g Na ₂ S ₂ O ₅ , dilute to 100 ml with distilled water.	Immerse for 2 min. or until polished surface turns bluish-red.	Concentration of Na ₂ S ₂ O ₅ varies with nickel content.
Beraha's reagent (1)	3 g $K_2S_2O_5$, 10 g $Na_2S_2O_3$, dilute to 100 ml with distilled water.	Pre-etch with 4% picral for 1 to 2 minutes. Immerse for 2 min. or until polished surface turns bluish-red.	Tint etchant for Fe-Mn alloys from 5-18% Mn. Also good for revealing chemical and physical heterogeneity in Fe-C alloys. Colors ferrite while cementite remains white in Fe-C alloys.
Klemm's reagent	50 ml cold saturated (in H ₂ O) Na ₂ S ₂ O ₃ solution, 5 g K ₂ S ₂ O ₅ .	Distinguishes between gamma, epsilon, and alpha phases. Epsilon-martensite remains white, alpha-martensite is colored black, and gamma, gray. Contrast can be improved in chromiumrich steels by addition of glacial acetic acid.	Tint etches Mn, Mn-C, and Mn-Cr steels.
Beraha's reagent (2)	Stock Solutions A. 1 vol. HCl (35%) + 5 vol. distilled water. B. 1 vol. HCl (35%) + 2 vol. distilled water.	Tint etchant No. 1: 100 ml of stock solution A or D plus 100 to 200 mg potas- sium metabisulfite. Immerse at room temperature and keep specimen moving until	Tint etchant for martensitic stainless steel. Colors the matrix only; carbides and nitrides are unaffected and in contrast with the colored matrix.
	C. 1 vol. HCl (35%) + 1 vol. distilled water. D. 20 g. ammonium bifluoride dissolved in 1,000 ml of stock solution A. E. 40 g ammonium bifluoride dissolved in 1,000 ml of stock solution B.		
	F. 50 g ammonium bifluoride dissolved in 1,000 ml of stock solution C.	Tint etchant No. 2: Same as above except potassium metabisulfite 300 to 600 mg.	For ferritic and austenitic stainless steel. Same as above.
4.7.7	G. 10 to 15 g iron chloride dissolved in 1,000 ml of stock solution B or C.	Tint etchant No. 3: 100 ml of stock solution (B, C, E, F, G, or H) + 300 to 800 mg potassium metabi- sulfite. If coloration takes	For corrosion and heat-resisting alloys. Same as above.
	H. 10 g copper chloride dissolved in 1,000 ml of stock solution B or C.	place without etching, lower amount of potassium meta- bisulfite.	
III. Miscellaneous Re	agents (Segregation, Depth of C	ase, Primary Structure, and Strain	n Lines)
Stead's reagent	1 g CuCl ₂ , 4 g MgCl ₂ , 1 ml HCl, 100 ml alcohol (absolute).	Dissolve salts in least possible quantity of hot water. Etch for about 1 minute, repeating if necessary.	To show segregation of phosphorous or other elements in solid solution; copper tends to deposit first on areas lowest in phosphorous. The structure may be more clearly delineated by light hand polish to remove the copper deposit after etching.
Fry's reagent	5 g CuCl ₂ , 40 ml HCl, 30 ml distilled water, 25 ml ethyl alcohol.	May be used cold. Etching time: about 10 seconds.	To reveal strain lines.
Oberhoffer's reagent	30 g FeCl ₃ , 1 g CuCl ₂ , 0.5 g SnCl ₂ , 50 ml HCl, 500 ml ethyl alcohol, 500 ml distilled water.	Immerse to reveal structure.	For showing phosphorus segregation and dendritic structure.
Alkaline chromate	16 g CrO ₃ , 145 ml distilled water, 80 g NaOH.	Add NaOH slowly, and use when not over one day old, boiling at 244-248 F. for 7-20 min. Use hood. This solution is highly caustic; should be prepared and stored in plastic.	Shows oxygen segregation by darkening martensite rapidly, ferrite more slow- ly, and zones of high oxygen content much more slowly.

Etching Reagent	Composition	Remarks	Uses
Liching Reagent	Composition	AVAILANT TO	
Cupric sulfate and cupric chloride	1.25 g CuSO ₄ , 2.50 g CuCl ₂ , 10 g MgCl ₂ , 2 ml HCl, 100 ml distilled water. Dilute above solution to 1,000 ml with 95% ethyl alcohol.	Proportions must be accurate. Etch by immersion to avoid confusing edge effects. Etching time: 30 seconds to 1 minute.	For showing total depth of case, structure, and various zones of nitrided Cr-V steels and Nitralloy.
Picric and nitric acids	10 parts picric acid (4%), 1 part HNO ₃ (4%).	Best results are obtained when specimen is annealed in lead at 1,475°F (800°C) before etching.	For depth of case and structure of Nitralloy.
Nital	1 ml HNO ₃ , 100 ml ethyl or methyl alcohol (95% or absolute).		For structure and depth o case of nitrided steels.
Marble's reagent	4 g CuSO ₄ , 20 ml HCl, 20ml distilled water.		Total depth of nitrided case.
Ammonium acetate	10 ml CH ₃ COONH ₄ , 100 ml distilled water.		Stains high sulfur areas in steel, and stains lead parti- cles brown in leaded steels.
IV. Reagents for Nor	nmetallic Inclusions and Intermet	allic Compounds	
Ferricyanide solution	1 to 4 g K ₃ Fe(CN) ₆ , 10 g KOH, 100 ml distilled water.	Must be freshly made; etch 15 min. in boiling solution; 7 g of NaOH may be substituted for 10 g of KOH. Use hood; do not acidify as HCN may be released.	Differentiates between carbides and nitrides. Cementite is blackened, pearlit turns brown, and massiv nitrides remain unchanged.
Murakami's reagent	10 g K ₃ Fe(CN) ₆ , 10 g KOH, 100 ml distilled water.	May be used cold, but preferably hot; should be freshly made; 7 g of NaOH may be substituted for 10 g KOH. Etching time 5-10 min. Use hood (see warning above).	Alloy, high-speed, and tung sten steels. Colors variou carbides differently; co- mentite not affected.
Strong ferricyanide solution	40 g K ₃ Fe(CN) ₆ , 100 g KOH, 100 ml distilled water.	Use fresh, boiling for 15 min. Use hood (see warning above).	Stainless and alloy steels; di ferentiates between carbide and nitrides.
Chromic acid and heat tinting	8 g CrO ₃ , 100 ml distilled water.	Etch first in 4% picric acid then for 1 min. in chromic acid; heat tint by heating face-up on a hot plate at about 500°F for 1 minute.	Distinguishes between iro phosphide and cementite is phosphide eutectic of car iron; iron phosphide is co ored darker.
Sodium picrate (alkaline)	2 g picric acid, 25 g NaOH, 100 ml distilled water.	Use boiling, 5 to 10 min. Do not boil dry.	Colors cementite, but no carbides high in chromium Attacks sulfides; delineat grain boundaries in hype eutectoid steels in slow cooled condition.
Hydrogen peroxide and sodium hydroxide	10 ml $\rm H_2O_2$ (30%), 20 ml NaOH 10% solution in distilled water.	Must be fresh. Etching time: 10 to 20 min. Highly caustic solution.	Attacks and darkens iro
Sodium hydroxide and potassium permanganate	4 g NaOH, 4 g KMnO ₄ 100 ml distilled water.	Use boiling. Etching time: 1 to 10 minutes.	colors precipitated carbid in manganese or chromiu steels. Differentiates between carbides and tun stides. Vanadium carbi unattacked.
Sodium, hydroxide and bromine	20 g NaOH, 4 ml bromine, 80 ml distilled water.	under hood.	
Sodium hydroxide and lead nitrate	1 part 50% NaOH, 2 parts $10\% \text{ Pb(NO}_3)_2$.	Use fresh, cold or boiling. Highly caustic solution.	Steels, colors cementic attacks phosphides and s cates.

Etching Reagent	Composition	Remarks	Uses
V. Reagents for Macr	roscopic Examination		
Hydrochloric acid	50 ml HCl, 50 ml H ₂ O.	Use at 160°to 180°F. (71°to 82°C) for 1 to 60 min. depending on the size of sample, type of steel, and type of structure to be developed. Use hood.	Shows segregation, porosity, cracks depth of hardened zone in tool steel, and so on. May produce cracks in strained steel.
Mixed acids	38 ml HCl, 12 ml H ₂ SO ₄ , 50 ml H ₂ O.	Use hot or boiling, 15 to 45 min. or cold for 2 to 4 hours. Use hood.	Steel, general macro; one of the best. Shows segregation, cracks, hardened zone, soft spots, weld structures.
Nitric acid in water	(A) 25 ml HNO ₃ ,75 ml H ₂ O.	Use cold on large surfaces such as split ingots which cannot conveniently be heated.	Same as HCl reagent.
	(B) 0.5 to 1 ml HNO ₃ , 99.5 to 99 ml H ₂ O.	Immerse 30 to 60 sec. after grinding specimen on 240-grit emery belt and thorough cleaning.	To show weld structures.
Nital	5 ml HNO ₃ , 95 ml ethyl alcohol.	Etch 5 minutes followed by 1 second in 10% HCl in H_2O .	Shows cleanliness, depth of hardening, carburized or decarburized surface, and so on.
Ammonium persulfate	10 ml (NH ₄) ₂ S ₂ O ₈ , 90 ml H ₂ .	Surface should be rubbed with absorbent cotton during etching.	Brings out grain structure, excessive grain growth, recrystallization at welds, flow lines in Nitralloy, and so on.
Ammonium persulfate with iodide, and so on.	(A) $2.5 \text{ g (NH_4)}_2\text{S}_2\text{O}_8$, 100 ml H_2O . (B) Same as A, plus 1.5 g Kl . (C) Same as B, plus 1.5 g HgCl_2 . (D) Same as C, plus 15 ml H_2SO_4 .	After grinding on No. 320 abrasive paper, swab 15 min. with solution A, then 10 min. with B, then 5 min. with C, and 5 min. with D, finally washing with water and drying with alcohol.	Shows dendritic macrostructure of cast iron.
Stead's reagent	2.5 g CuCl ₂ , 10 g MgCl ₂ , 5 ml HCl, up to 250 ml ethyl alcohol.	Salts are dissolved in HCl with the addition of the least possible quantity of water.	Brings out phosphorus-rich areas and phosphorus banding. May be used for general segregation.
Fry's reagent	(A) 90 g CuCl ₂ ,l20 ml HCl, 100 ml H ₂ O.	Most useful for low-carbon steels, particularly bessemer and other high-nitrogen grades. Before etching, sample should be heated to 300°480° F. for 5 to 30 min., depending on condition of steel. During etching, surface should be rubbed with cloth soaked in etching solution. Wash in alcohol or rinse in HCl (1:1) after etching to prevent deposition of copper.	Shows up strain lines due to cold work.
	(B) 45 g CuCl ₂ ,180 ml HCl, 100 ml H ₂ O.	Specimen can be washed in water without depositing copper. Gives contrast.	Shows strain lines due to cold work.
Humfrey's reagent	120 g Cu(NH ₃) ₄ Cl ₂ , 50 ml HCl, 1,000 ml H ₂ O.	Slight abrasion of surface after etching is recommended.	Develops dendritic segregation.
Kalling's reagent	1.5 g CuCl $_2$, 33 ml HCl, 33 ml H $_2$ O, 33 ml alcohol.	Etching time very short.	Develops dendritic pattern in steel, attacks ferritic and martensitic stainless steels. Ferrite darkened, marten- site darker, austenite light.
Marble's reagent	$10~{\rm g~CuSO_4}, 50~{\rm ml~HCl}, 50~{\rm ml}$ ${\rm H_2O}.$	May be used hot.	Ni-Cr-Fe alloys, mangan- ese and Cr-Mn steels, ni- trided case. Carbide pre- cipitation in austenitic al- loys.

	TABL	E 4 — continued	
Etching Reagent	Composition	Remarks	Uses
Vilella's reagent	1 g picric acid, 5 ml HCl, 100 ml alcohol.	Use hot.	Fe-Cr-Ni and Fe-Cr-Mn steels. Reveals austenitic grain boundaries.
VI. Electrolytes for F Chromic acid	Polishing and Etching $10\mathrm{gCrO_3},100\mathrm{mlH_2O}.$	Specimen is used as anode; stainless steel or platinum as cathode, 3/4 to 1 in. apart; 6 V usually used. Etching time: 30 to 90 seconds.	For various structures except the grain boundaries of ferrite. Attacks cementite very rapidly, austenite less rapidly, ferrite and iron phosphide very slowly if at all.
Nitric acid in water	50 ml HNO_3 , $50 \text{ ml H}_2\text{O}$.	Room temperature; stainless steel cathode; 1.5 V for 2 minutes or more. Use hood.	For austenitic or ferritic stainless steels; reveals grain boundaries.
Hydrochloric acid in alcohol	10 ml HCl, 90 ml anhydrous ethyl alcohol.	10 to 30 seconds at 6 V.	Reveals delta ferrite, and the general structure of chromium and Cr-Ni steels.
Sulfuric acid in water	$5 \text{ ml H}_2\text{SO}_4$, $95 \text{ ml H}_2\text{O}$.	Room temperature; stainless steel cathode; 6 V (0.1 to 0.5 amp), 5 to 15 seconds. Use hood.	For Fe-Cr-Ni alloys.
Mixed acids in alcohol	45 ml lactic acid, 10 ml HCl, 45 ml ethyl alcohol.	10 to 30 seconds at 6V.	For chromium steels (4 to 30% Cr), or for delta ferrite in austenitic stainless steels.
Oxalic acid in water	$10\mathrm{ml}$ oxalic acid, $100\mathrm{ml}$ $\mathrm{H}_2\mathrm{O}.$	5 to 20 sec. at 6 V, using a platinum or stainless steel cathode. Gap between electodes, 3/4 to 1 in.	For austenitic stainless steels and high-nickel al- loys. Distinguishes between sigma phase and carbides.
			Sigma phase is attacked first, then carbides; ferrite and austenite can be attacked slightly. To investigate the carbides, operate at 1.5 to 3 V for a longer time.
Sodium hydroxide in water	40 g NaOH, 100 ml H ₂ O(add slowly).	60 seconds at 1 to 3 V. Highly caustic solution.	Reveals the sigma phase. Colors successively sigma phase, ferrite, and lastly carbides after a longer etching time.
Potassium hydroxide in water	56 g KOH, 100 ml H ₂ O (add slowly).	60 seconds at 1 to $3\mathrm{V}.$ Highly caustic solution.	Same as above, but sigma phase and ferrite are revealed simultaneously.
Sodium cyanide in water	10 g NaCN, 100 ml H_2O .	5 min. or more at 6V (not less than 5V). Use hood; if acidified, HCN develops.	Colors carbides without al- tering austenite or grain boundaries.
Ammonium persulfate in water	$10 \mathrm{g} (\mathrm{NH_4})_2 \mathrm{S}_2 \mathrm{O}_8$, $100 \mathrm{ml} \mathrm{H}_2 \mathrm{O}$.	Use fresh, 6 V for more than 15 seconds.	Surface attack occurs on the ferrite grains in low-carbon steels. Reveals the fine structures of nickel austenitic steels, and of transformer sheet.
Ammonium nitrate	Saturated aqueous solution of $\mathrm{NH_4NO_3}$.	Use a current density of 1 amp per sq cm.	Detects overheating and burning. In overheating, this etchant leaves the boundaries of the pre-existing austenite grains white, while it blackens them in burned steel.
Cadmium acetate in water	10 g cadmium acetate, 100 ml H_2O .	2 to 5 V for 3 to 20 seconds.	Brings out carbide grain boundaries.
Mixed acids in water	5 g ammonium molybdate 7.5 ml HNO ₃ , 10 ml HCl, 100 ml H ₂ O.		Good for type 300 stainless steels.
Mixed acids	90 ml H ₂ PO ₃ , 8 ml HNO ₃ , 2 ml H ₂ O.	Use cold.	For polishing and etching Fe-Al alloys (to 16% Al).
Chrome regia	25 ml HCl, 5 to 50 ml CrOs solution (10%) in H_2O .	Dilute with 2 parts alcohol and 2 parts glycerin. Etch for 20 to 60 seconds at 6V.	Heat-treated type 300 stain- less steels.

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MACROETCHING

Macroetching is the procedure used to reveal the quality of a material by subjecting a gross sample to the corrosive action of an etchant.

Examinations are limited to visual observation or magnification not exceeding ten diameters.

STANDARD METHOD FOR MACROETCHING METALS AND ALLOYS⁴

1. SCOPE

1.1 These procedures describe the methods of macroetching metals and alloys to reveal their macrostructure.

2. GENERAL DIRECTIONS AND USES OF MACROETCHING

2.1 Applications of Macroetching

2.1.1 Macroetching is used to reveal the heterogeneity of metals and alloys. Metallographic specimens and chemical analyses will provide the necessary detailed information about specific localities but they cannot give data about variation from one place to another unless an inordinate number of specimens are taken.

2.1.2 Macroetching, on the other hand, will provide information on variations in (1) structure, such as grain size, flow lines, columnar structure, dendrites, etc.; (2) variations in chemical composition as evidenced by segregation, carbide and ferrite banding, coring, inclusions, and depth of carburization or decarburization. The information provided about variations in chemical composition is strictly qualitative but the location of extremes in segregation will be shown. Chemical analyses or other means of determining the chemical composition would have to be performed to determine the extent of variation. Macroetching will also show the presence of discontinuities and voids, such as seams, laps, porosity, flakes, bursts, extrusion rupture, cracks, etc.

2.1.3 Other applications of macroetching in the fabrication of metals are the study of weld structure, definition of weld penetration, dilution of filler metal by base metals, entrapment of flux, porosity, and cracks in weld and heat affected zones. etc. It is also used in the heat treating shop to determine location of hard or soft spots, tong marks, quenching cracks, case depth in shallow hardening steels, case depth in carburization of dies, effectiveness of stopoff coatings in carburization, etc. In the machine shop, it can be used for the determination of grinding cracks in tools and dies.

2.1.4 Macroetching is used extensively for quality control in the steel industry, to determine the "tone" of a heat in billets with respect to inclusions, segregation, and structure. Forge shops, in addition, use macroetching to reveal flow lines in setting up the best forging practice, die design, and metal flow. For an example of the use of macroetching in the steel forging industry, see ASTM Method A 317, Macroetch Testing and Inspection of Steel Forgings. Forging shops and foundries also use macroetching to determine the presence of internal faults and surface defects. The copper industry uses macroetching for control of surface porosity in wire bar. In the aluminum industry, macroetching is used to evaluate extrusions as well as the other products such as forgings, sheets, etc. Defects such as coring, cracks, and port hole die welds are identified.

2.2 Sampling:

2.2.1 As in any method of examination, sampling is very important. When macroetching is used to solve a problem, the problem itself largely dictates the source of the sample as to the location on the work piece and the stage of manufacture; for example, when looking for pipe, the sample should represent the top of the ingot, or when looking for bursts or flakes, the sample should be taken as soon after hot working as possible.

2.2.1.2 When macroetching is used as an inspection procedure, sampling ought to be done in an early stage of manufacturing so that if the material proves faulty, no wasteful unnecessary work is done. However, the sample should not be taken so early that further working can introduce serious defects. In the steel industry, for example, the sample is usually taken after ingot breakdown and after most chances of bursts or flakes occurring have passed. Billets or blooms going into small sizes are sampled after initial breakdown. Material going into forging billets or die blocks is sampled near finish size. Sampling may be done systematically or on a random basis.

2.2.2 Samples may be cold cut from the source by any convenient fashion; saws and abrasive cutoff wheels are particularly effective. The use of torch cutting or hot cutting should be used only when necessary to cut a sample from a large piece. The sample then is sectioned well away from the hot-cut surface. An example of permissible use of torch cutting is the excising of a piece from a large plate and then cutting a sample for macroetching 4 to 5 in. away from the torch cut edge.

2.2.3 Some common methods of sampling, listed by source are as follows:

⁴ American Society and Testing Materials Designation: E340-68 (Reprinted with permission)

2.2.3.1 Billets, Blooms, and Hot-Rolled Products — Disks are usually cut from these products near the end. Samples cut too close to the end, however, may have false structures because of fish-tailing. Disks from large blooms are sometimes cut into smaller pieces for ease in handling.

2.2.3.2 Forgings and Extrusions — Disks cut transverse to the long dimension will show flakes, bursts, etc. Forgings may also be cut parallel to the long dimension to show flow lines. In complicated forgings, some thought will have to be given to the proper method of cutting so as to show flow lines. Macroetching of an unprepared specimen will show surface defects such as shuts, flats, seams, etc. In extrusions, coring and coarse grain are more commonly found in the back end of the extrusion.

2.2.3.3 Sheets and Plates — A sufficiently large sample should be taken when looking for surface defects. An ideal length would be the circumference of the last roll, but this may be inconveniently long. Several samples totaling some given fraction of the circumference can be used; however, there is always a chance then that a defect arising from faulty rolls would not be detected. When seeking information on laminations, a transverse section is used. In many cases, however, to reduce the size of the specimen, only a section out of the center of the plate may be taken.

2.2.3.4 Weldments — A disk cut perpendicular to the direction of welding will show weld penetration, heat affected zone, structure, etc. Careful preparation is usually rewarded with highly detailed structure giving a large amount of information. Welds involving dissimilar metals will produce problems in etching. The best method is to etch the least corrosion-resistant portion first and the more resistant portion afterward. Occassionallyan intermediary etchant may be required. The boundaries between etched and unetched portion will give an idea of weld penetration and dilution.

2.2.3.5 Castings — Cut the specimen to display the defect or feature being sought.

2.2.3.6 Machined and Ground Parts — When looking for grinding cracks, etc., the surface itself is used as a sample. Because the machined support or ground part is often the finished part, it may be undesirable to immerse the part in acid. In this case, other methods such as dye penetrant methods may be more desirable.

2.3 Preparation:

2.3.1 Sample preparation need not be elaborate. Any method of presenting a smooth surface with a minimum amount of cold work

will be satisfactory. Disks may be faced on a lathe or a shaper. The usual procedure is to take a roughing cut, then a finished cut. This will generate a smooth surface and remove cold work from prior operations. Sharp tools are necessary to produce a good specimen. Grinding is usually conducted in the same manner, using free-cutting wheels and light finishing cuts. When fine detail is required, the specimen should be ground down through the series of metallographic papers. Where necessary, details are given in the tabulation of procedures.

2.3.2 After surface preparation, the sample is cleaned carefully with suitable solvents. Any grease, oil, or other residue will produce uneven attack. Once cleaned, care should be taken not to touch the sample surface or contaminate it in any way.

2.4 Solutions:

2.4.1 The solutions used for macroetching are given in the tables listed under each alloy. In most cases a good grade of reagent should be used but need not be chemically pure or of analytical quality. The so-called technical grades are usually satisfactory. The solution should be clean and clear, free of suspended particles, scum, etc.

2.4.2 Caution must be observed in mixing. Many of the etchants are strong acids. In all cases, the various chemicals should be added slowly to the water or solvent while stirring. In the cases where hydrofluoric acid is used, the solution should be mixed and used in polyethylene vessels.

Note — CAUTION: Hydrofluoric acid should not be allowed to contact the skin since it can cause painful, serious ulcers if not washed off immediately.

2.5 Procedure:

2.5.1 Many of the solutions are aggressive and may give off irritating and corrosive fumes. Etching should be done in a well ventilated room, preferably under a fume hood. The solution should be mixed and placed in a corrosion-resistant tray or dish and brought to the operating temperature. The specimen or specimens should be placed in a tray of stainless steel screen or on some non-reactive support.

Glass rods often are placed on the bottom of the acid container and the specimens laid directly on the rods. When etching is completed, remove the specimens from the dish, taking great care not to touch the etched surface. When desmutting is required, dip the specimen into a second solution. After rinsing the specimen with hot water, blow dry with clean, compressed air.

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- 2.5.2 In the case of large specimens, such as ingot sections, swabbing may be the only practical method of macroetching. Saturate a large wad of cotton held in stainless steel or nickel tongs with the etchant and sweep over the surface of the specimen. An effort should be made to wet the entire surface as soon as possible. After the initial wetting, keep the swab saturated with solution and frequently sweep over the surface of the specimen to renew the solution. When the structure has been suitably developed, rinse the specimen, either with a swab saturated with water, or better still, by pouring water over the specimen. After rinsing with hot water, blow the specimen dry with compressed air. Details of the procedure not discussed here are covered in the sections for the various metals and their alloys.
- 2.5.3 The times given in individual tabulations are only intended as guides. In fact, the progress of etching should be closely watched and etching stopped when the preferred structural details have been revealed. Specimens should be etched to develop structures. Generally, a light etch is better than a heavy etch; over-etching can often lead to misinterpretation. The actual time to develop a structure properly may be quite different from the one suggested.
- 3. SPECIFIC PREPARATION PROCEDURES AND RECOMMENDED SOLUTIONS
 - 3.1 Aluminum:
 - 3.1.1 The specimens can be cut using the common cutting tools, hack saws, band saw, shears, abrasive cutoff wheels, etc. All these methods will cause cold work at the surface and will generate heat. The temperature rise can be enough to cause changes in structure. For these reasons, sharp tools and generous lubrication are necessary for sectioning.
 - 3.1.2 The cold-worked surface should be removed by machining the surface. Again, sharp tools and copious lubrication are required. If fine detail is required, the machined surface should be ground using silicon carbide paper lubricated with water or kerosene.
 - 3.1.3 Several of the solutions used in macroetching react vigorously with the metal and can overheat the specimen. In these cases the specimen is periodically removed from the solution, cooled in running water, and reimmersed in the etchant. This procedure is repeated until the desired degree of etching is obtained.
 - 3.1.4 Macroetchants for Aluminum and Aluminum Alloys (Table 1).
 - 3.2 Beryllium:

- 3.2.1 While beryllium in the massive form is not dangerous, beryllium and its compounds in the finely divided state are extremely poisonous.
- Note CAUTION: Before starting any work involving beryllium, a review of hazards and plans for handling should be made. A number of references on beryllium are available. Particular mention may be made of "Toxicity of Beryllium" ASD-TR-62-7-667, prepared by the Kettering Laboratory for the Air Force.
- 3.2.2.1 Generally speaking, beryllium and its alloys have given difficulty in obtaining good macroetched specimens. First, beryllium is a rather brittle metal and sectioning can be difficult. Cut-off wheels with the designation C46FR70 have been the most successful. Secondly, beryllium does not grind easily; hence, specimens should be as small as possible to minimize grinding time. Grinding has been most successful with the entire sequence of wet silicon carbide papers.
- 3.2.2.2 The etching of fine grained metal may not always be entirely successful, and further preparation will be required. Rough polishing with $16~\mu m$ Al₂O₃ suspended in water is performed on a low-nap cloth. Light pressure and frequent change of cutting direction produce the best results. If further polishing is required, $1~\mu m$ green Cr_2O_3 in tap water on synthetic suede works best.
- 3.2.3 Macroetchants for Beryllium and Beryllium Alloys (Table 2).
- 3.3 Cobalt and Cobalt Alloys:
- 3.3.1 Many of the cobalt-base high temperature alloys can be etched using the same procedures as those for iron and nickelbase high temperature alloys. Other cobalt alloys, such as the stellites used as machine tools, require special treatment.
- 3.3.1.2 The cobalt-base alloys, as a group, are not easily machined. The specimens should be sectioned with abrasive cutoff wheels and ground on wet silicon carbide papers. Because of the rapid work hardening characteristics of these alloys, fresh paper and copious cooling should be used.
- 3.3.2 Macroetchants for Cobalt and Cobalt Alloys (Table 3).
- 3.4 Copper and Copper Alloys:
- 3.4.1 These metals are usually macroetched to bring out the general structure of wire bar and billets as well as variations in grain size in extrusions and forgings.

3.4.2.1 Specimens may be sectioned using common cutting tools. To minimize cold working the tools should be kept sharp.

3.4.2.2 Good results can be obtained by machining a smooth surface in two stages, the first being a heavy cut to remove the cold work from sectioning and the second a fine cut with a V-shaped tool to remove the remaining cold work. Grinding through the series of metallographic papers will give more detailed results. The degree of grinding depends upon the amount of detail required. The etching solutions listed in the following table are simple to prepare and their use requires no special technique.

Note — It should be pointed out that heavy etching often will remove the effect of cold work but at the expense of producing a rough surface. If the specimen is then given light regrinding to remove the rough etched surface, the second etch will provide good results.

3.4.3 Macroetchants for Copper and Copper Alloys (Table 4).

3.5 Iron and Steel:

3.5.1 Macroetching has been most highly developed and is used extensively in the iron and steel industries. An example of the use of macroetching for inspection of tool steels is given in the appendix. In hot mill products such as bars, billets, sheet, and plate, the disk cut with a parting tool is prepared by facing on a lathe or by grinding. In facing, the first cut is moderately heavy with a sharp tool. The second facing is a light cut with a V-shaped tool run at high speed. Specimens produced in this manner are adequate for general inspection. A better though slower method is to grind the specimen. For inspection purposes, finishing on a 120-grit wheel will be sufficient. If machine grinding is used, the specimen should be of a size that can be held conveniently in one hand. The limiting size in machine grinding is usually 12 inches square since larger specimens are difficult to handle in the etching bath.

3.5.1.1 When the maximum amount of detail is required, as in weldments, polishing the specimen with the series of metallographic papers gives the best results. When examining for surface defects, the surface itself should be etched directly without much preparation. The only preparation that is advisable is to brush off the loose scale and then to give the specimen a light grinding pass with very coarse abrasive to break through the adherent scale. When etching in 1+1 HCl for example, this scale will be removed, exposing the surface underneath. If care has been exercised in the grinding operations, the grinding scratches will not interfere with examination.

3.5.1.2 The most commonly used solutions for macroetching iron and steel are Solution Nos. 1 and 3 in Table 5.

3.5.2 Forgings — In addition to the examination for internal structure, surface defects, and structure, closed die forgings are often sectioned to show flow lines. Etching for flow lines require extremely careful preparation to provide a smooth surface with a minimum of cold work. Long pieces, such as crank shafts, are awkward to handle and are best prepared on a grinding machine using successively finer grinding wheels. Sectioning into shorter lengths may be advisable. The specimen should be heavily etched in 1+1 HCl or 20 percent H₂SO₄. Contrast can often be increased by wiping the surface lightly with very fine metallographic paper after etching. Examination for structure, defects, etc. is carried out in the same fashion as hotmill products.

3.5.3 Special Tests for Segregation — There are a number of etchants containing copper salts which will reveal segregation. Careful specimen preparation through the metallographic papers is required. Very careful cleaning after grinding is extremely important. When a specimen is immersed in this type of solution, copper plates out into the specimen by a replacement reaction. The rate of deposition depends on the composition of the steel. The copper plating will cover the segregated regions. Sometimes the specimen can be left in a little longer than recommended and then rubbed lightly with metallographic papers to increase contrast.

3.5.4 Macroetchants for Iron and Steel (Table 5).

3.6 Stainless Steels and High-Temperature Alloys:

3.6.1 These alloys are generally more susceptible to cold working of the surface than are the lower alloy grades of steel. The best method of preparation is to grind the specimens as described for iron and steel. A smut tends to form on the surface of the steel when immersed in 1+1 HCl. This can be prevented by adding a small quantity of HNO3 to the etching bath. It can also be removed by scrubbing the specimen with a vegetable fiber brush under running warm water or by immersion in warm 20 percent HNO3. Scrubbing will provide a higher contrast for detection of segregation and inclusions. The desmutting, either by the addition of HNO3 to the etching bath or by the secondary rinse in HNO3, will provide a brighter surface which is suitable for determination of grain size and structure. High-alloy stainless steels and austenitic high-temperature alloys, because of their extreme corrosion resistance, often will give trouble in etching. Aqua regia, HCl-H₂O₂, and

Marble's reagent are the recommended etchants. All three of these require very careful specimen preparation.

3.6.2 Macroetchants for Stainless Steels and High-Temperature Alloys (Table 6).

3.7 Lead and Lead Alloys:

3.7.1 Lead and its alloys are among the most difficult metals to prepare for macroetching. They are not only very soft and cold work easily but they (pure lead especially) recrystallize readily at temperatures which can be easily achieved in careless preparation.

3.7.2 For best results in the macroetching of lead, all surfaces, other than that to be examined, must be masked from the macroetch by the use of several coats of a plastic spray. The surface to be examined should be filed prior to etching. Three 14-in. files³ are usually required and used in the following order: (1) aluminum, Type A, (2) hand smooth, and (3) hand-finishing smooth.

3.7.3 The file is usually held in a fixture and the specimen is drawn over the file proceeding from the point of the file to the tang. Remove the filings after each pass of the specimen with a few short strokes of a brass file brush in the direction of the last cut of the file. The molybdate etch listed below is used in the removal of worked metal and also to reveal the structure of lead of low-alloy content. The preparation of the solution is of paramount importance.

3.7.4 Macroetchants for Lead and Lead Alloys (Table 7).

3.8 Magnesium:

3.8.1 Features detected by macroetching are grain size, segregation of intermetallic compounds, coring, cracks, porosity, laps, germinations, surface burning, and tears.

3.8.2 Cast or wrought magnesium alloys are prepared in a similar manner to aluminum or copper and brass. However, a final facing with a 0.005-in. radius V-shaped tool fed at a rate of 0.002 to 0.003-in. is often sufficient. For some applications, the specimen may be finished on a 400-grit wet wheel. To resolve small detail, additional polishing with a water suspension of 600 Alundum or further with alpha alumina may be necessary.

3.8.3 The finely divided magnesium as chips or swarf is highly combustible and precautions against it catching fire should be taken.

3.8.4 Macroetchants for Magnesium and Magnesium Alloys (Table 8).

3.9 Nickel and Nickel Alloys:

3.9.1 Nickel alloys cold work easily and their preparation is not always easy. Grinding produces the best specimens. Low-nickel and cobalt alloys of basically pure metal can be etched with Marble's reagent or strong HNO₃ solutions. The high-temperature alloys are difficult to etch. First of all, they are subject to cold-working problems, and secondly, the alloys are extremely corrosion-resistant. Best results have been obtained with aqua regia, modified Marble's reagent, or HCl-H₂O₂ solutions.

3.9.2 Macroetchants for Nickel and Nickel Alloys: (Table 9).

3.10 Noble Metals -

Ag, Au, Ru, Rh, Pd, Os, Ir, and Pt:

3.10.1 These metals are, in general, soft and ductile. Because of their expense, specimens for macroetching usually will be small and can be handled the same as microspecimens. Care should be used to avoid cold work. Well lubricated metallographic papers are recommended. Some of the platinum group metals, notably osmium and rhodium, are more abrasion-resistant than their hardness would indicate and, therefore, will require long grinding time.

3.10.1.1 Except for silver, all of these metals are corrosion-resistant and require the use of strong etchants. Etching should be done under a fume hood, with the proper precautions for the use of HF.

3.10.2 Macroetchants for the Noble Metals (Table 10).

3.11 Refractory Metals — Cr, Mo, W, V, Cb, and Ta:

3.11.1 The above six metals, the refractory metals, are found in Group V-B (V, Cb, Ta) and Group VI-B (Cr, Mo, W) of the periodic table. (Some tables list them as V-A and VI-A). In general, these metals are soft and ductile in the pure state, but, in the form usually encountered, are hard and brittle. Consequently, these metals and their alloys must be carefully ground before macroetching. The abrasives must be of sufficient hardness, and the particles on the laps must be sharp. Wet silicon carbide papers have proved satisfactory provided they are used with sufficient pressure to effectively cut the sample and are not used after they dull or worn. Longer grinding times than would be expected from the hardness of these metals and alloys are needed. The following solutions used for the metals specified will reveal defects, general structure, grain size, and segregation.

³ Nicholson designations. Be sure to preserve the distinction between hand smooth and hand-finishing smooth.

3.11.2 Macroetchants for the Refractory Metals (Table 11).

3.12 Tin and Tin Alloys:

3.12.1.1 Tin and its alloys, like lead, are difficult to prepare. Because these metals cold work easily and recrystallize at room temperature, false structures are easily produced. The best method of preparation for macroetching is the same as for microetching. The specimen should be cut carefully and then ground gently on lubricated silicon carbide paper. This may be followed by polishing with $6 \cdot (\mu m)$ diamond paste on a moderately napped wheel.

3.12.1.2 Precision cast tin-base bearing alloys may be etched directly without preparation.

3.12.2 Macroetchant for Tin and Tin Alloys (Table 12).

3.12.3 Preparation of Ammonium Polysulfide — Pass H_2S gas into 200 ml of NH_4OH (sp. gr. 0.9) until saturated. The solution should be kept in an ice bath during this operation. Add an additional 200 ml of NH_4OH (sp. gr. 0.9) and dilute with water to make 1 liter. Add 100 g of sulfur. Stir occasionally over a period of 1 hour, then filter and use.

3.13 Titanium, Zirconium, Hafnium and their Alloys:

3.13.1 Titanium, zirconium, and hafnium, the reactive metals, are macroetched for general structure, grain size, and segregation of impurities. They require extreme care in

preparation. Sharp tools and fresh grinding paper are required to prevent cold work from blurring the structure. The best results are obtained by grinding. These metals grind slowly and require sharp, fresh abrasives. The recommendations of grinding wheel manufacturers should be followed closely for rough grinding. Silicon carbide papers, usually run wet, will give a fine finish. Papers should be discarded frequently to prevent loading. Chemical polishing preparations, while relatively untried, may have decided advantages in handling these materials.

3.13.2 Solutions in the table are not difficult to prepare but involve the use of hydrofluoric acid. This acid can give extremely serious, very painful burns. The HCl-HF solution requires desmutting. The specimen should be rinsed between etching and desmutting (Table 13).

3.14 Zinc and Zinc Alloys:

3.14.1 Zinc and its alloys cold work rapidly and recrystallize at low temperatures, thus allowing false structures to form easily. Coarse-grained zinc and zinc alloys are more prone to cold work than some of the fine grained die-casting alloys. A good test for the presence of cold work, especially in coarse-grained samples is the appearance of twinning after etching.

3.14.2 Samples should be cut with a sharp saw and ground on well lubricated silicon carbide papers at slow speeds.

 $3.14.3\,$ Macroetchant for Zinc and Zinc Alloys (Table 14).

TABLE 1 MACROETCHANTS FOR ALUMINUM AND ALUMINUM ALLOYS

Alloy	Composition	Procedure	Comments
All	NaOH	Immerse sample 5-15 min. in solution heated to 60° to 70°C (140° to 160°F). Rinse in water, and remove smut in strong HNO ₃ solution. Rinse and repeat etching if necessary.	Good general - purpose etchant, can be used on almost all aluminum alloys. Does not require fine grinding.
3XXX 4XXX 5XXX 6XXX High Si castings	HCl(conc) 75 ml HNO ₃ (conc) 25 ml HF (48 percent) 5 ml	Mix fresh before using. Use at room temperature. May be used as immersion etch or swabbed over specimen surface. Rinse specimen in warm water and dry.	Used to develop grain structure. May be diluted with 25 per cent water to slow down etching. Does not require fine grinding.
High purity Al 1XXX 3XXX 4XXX 5XXX 6XXX	HCl (conc)	Immerse specimen at room temperature until desired contrast is developed. Rinse in warm water and dry.	Tucker's etch. General purpose etch for revealing microstructure of both cast and wrought aluminum. Does not require fine grinding.
All except high Si castings	HCl (conc) 15 ml HNO ₃ (conc) 5 ml HF (48 percent) 5 ml	Same as above.	1+2 Tucker's Same as above but slower acting.

		The state of the s	
2XXX High Cu alloys	HF (48 percent) 10 ml	May be used as an immersion etch or swabbed over the specimen surface. When desired contrast is obtained, rinse in water and remove deposits with concentrated HNO ₃ . Rinse in warm water and dry	are obtained with a ground surface. 180 grit will suf-

TABLE 2- MACROETCHANTS FOR BERYLLIUM AND BERYLLIUM ALLOYS

Metal	Composition	Procedure	Comments
Be	1. HCl 10 ml NH.Cl 4 g	Either swab or immerse at room temperature for a few minutes, rinse in water and dry.	Works best on coarse grained Be.
Be	2. HCl 10 ml NH ₄ Cl 2 g Pictric acid 2 g H ₂ O 90 ml	As above.	An alternative when No. 1 does not work. Fine-grained metal may not give good results in either case.

TABLE 3 — MACROETCHANTS FOR COBALT AND COBALT ALLOYS

Alloy	Composition	Procedure	Comments
49Co-49Fe-V Some Co-Cr alloys	HC1 50 ml H ₂ O 50 ml	Immerse specimen in hot solution (140° to 180° F) for 30 to 60 min. Rinse in hot water and dry.	General structure, porosity.
25Cr-10Ni-8W 21Cr-20Ni- 3W-3Mo-lCb	HCl 50 ml HNO ₃ 10 ml FeCl ₃ 10 g H ₂ O 100 ml	Swab until desired contrast is obtained then rinse in warm water and dry.	Grain size, general structure.
18Cr-10Ni-14W	CuC1 ₂ ·2NH ₄ C1·2H ₂ O 2 g FeC1 ₃ 5 g HNO ₃ 5 ml HC1 50 ml H ₂ O 80 ml	As above.	As above.

TABLE 4 — MACROETCHANTS FOR COPPER AND COPPER ALLOYS

Alloys	Composition	Procedure	Comments
Cu and all brasses		Immerse specimen in solution at room temperature for a few minutes. Rinse in water and dry.	Emphasize grains and cracks.
Cu and all brasses	2. HNO ₃	As above.	Brings out grain contrast, pits result unless agitated. Aluminum bronzes may form smut which can be removed by brief immersion in concentrated HNO ₃ .
Cu and all brasses	3. HCl	As above.	Good grain contrast.
Cu. high Cu alloys, phosphorus, tin bronzes	4. K ₂ Cr ₂ O ₇ sat	Immerse specimen in solution at room temperature for 15 to 30 min. then swab with fresh solution. Rinse in warm water and dry.	Emphasizes grain boundaries and oxide inclusions.
All	5. HNO ₃ 50 ml AgNO ₃ 5 g H ₂ O 50 ml	Immerse specimen in solution temperature. Rinse in warm water and dry.	Brilliant deep etch.
Brass	6. 20 percent 20 ml		Strain lines.
Silicon brass or bronze	7. CrO_3 40 g NH_4C1 7.5 g $HNO_3(conc)$ 50 ml $H_2SO_4(conc)$ 8 ml H_2O 100 ml	in warm water and dry.	

Alloys	Composition Pro	ocedure Comments
Plain and alloy steels, high speed and tool steels, cutlery (12 to 14% Cr) and stainless steels	H ₂ O 50 ml heated to 1 to 30 min. orous scrub ble fiber hing water may be dipping in	General purpose. 60'to 180°F for 15 Desmut by vigbing with vegetarush under run. Stainless steels desmutted by a warm 20 per-O ₃ to give a h.
High alloy steels	$HNO_3(conc)$ 25 ml 15 min. in	ecimen for 10 to Ratio HCl:HNO ₃ runs 2:1 to solution at room a:1.
Plain and alloy steels, cutlery steels	$H_2SO_4(conc)$ 12 ml 45 min. in	ecimen for 15 to Works well on 12 per cent Cr solution heated steel. 180°F. Rinse in r and dry.
High alloy steels	HF (48 percent) 4 ml heated to 1 H_2O 87 ml til desired	cimen in solution Ratio HNO ₃ -HF varies. 160°to 180°F unetch is obtained in warm water
Stainless steels, high-alloy steels	H ₂ O 50 ml to 160° to H ₂ O ₂ (30 percent) 20 ml specimen a several par Make each dition afte	water then heat Produces bright finish. 170°F, immerse and add H ₂ O ₂ in tts. Do not mix. subsequent addr foaming from ddition has stop-
Austenitic stainless steels	saturated solution CuSO ₄ in H ₂ O ₂ 25 ml tion which or not dep loy. Time	ecimen in solu- may be heated good for structure. ending upon al- also depends on e in warm water
Plain and low- alloy steels		n at room temper- Grain size, weldments. specimen. Rinse
Plain and alloy steels	MgCl ₂ 10 g temperature	solution at room e until a coppery ears. Rinse thorand dry. Stead's reagent. Salts dissolved in HCl with minimum of hot water to bring out P-rich areas and P-banding.
Mild steel. Besemer and high N ₂ steel	HC1 (conc) 120 ml with cloth H ₂ O 100 ml ing solution hol or rinse	•
Plain and alloy steels	10. CuCl ₂	Modified Fry's reagent. Same as for reagent No. 9 but modified by Wazau, may give more contrast, specimen can be washed in water without depositing copper.
Stainless and high Cr steels	Alcohol 100 ml at room tem	cimen in solution Vilella's reagent. perature until de- ast is obtained. Iry.

TABLE 6 — MACROETCHANTS FOR STAINLESS STEELS AND HIGH-TEMPERATURE ALLOYS

Alloys	Composition	Procedure	Comments
Stainless steels and iron-base high-temperature alloys	1. HCl (conc) 50 ml H ₂ O 50 ml	Immerse specimen in solution heated to 160° to 180° F for 30 min. Desmut by vigorous scrubbing with vegetable brush under running water. Stainless steels may be desmutted by dipping in warm 20 percent HNO ₃ to give bright finish.	
Iron , cobalt , and nickel- base high- temperature alloys	2. HC1 (conc) 50 ml HNO ₃ (conc) 25 ml H ₂ O 25 ml	Immerse specimen in solution at room temperature for 10 to 30 minutes. Rinse and dry.	Ratio HC1+HNO ₃ runs 2+1 to 3+1.
Stainless steels and high- temperature alloys	3. HNO ₃ 10 ml HF (48 percent) 3 ml H ₂ O 87 ml to HNO ₃ (conc) 40 ml HF (48 percent) 10 ml H ₂ O 50 ml	Immerse specimen in solution heated to 160 to 180 F until desired contrast is obtained. Rinse and dry.	Ratio HNO ₃ HF varies.
Austenitic stainless steels and nickel- base alloys	4. I (NH ₄) ₂ SO ₄ 15 g H ₂ O 75 ml II FeCl ₂ 250 g HCl (conc) 100 ml III HNO ₃ 30 ml (conc)	Combine I and II then add III. Immerse specimen in solu- tion at room temperature un- til desired contrast is ob- tained. Rinse and dry.	Lepito's etch. I, mix fresh, grain structure.
Austenitic stainless steels and high- temperature alloys	5. HCl (conc) 50 ml H ₂ O 50 ml H ₂ O ₂ (30 percent) 20 ml	immerse specimen and add	
Austenitic stainless steels and high- temperature alloys	6.HCl (conc) 50 ml Saturated solution of 25 ml CuSO ₄ in H ₂ O	Immerse specimen in solution which may be heated up to 170°F until desired contrast is obtained. Rinse and dry.	Marble's reagent. Light etch, good for structures. A mount of CuSO ₄ solution may be increased to 1 + 1 ratio for difficult alloys.

DADLE 7 MACDOPTCHANTS FOR LEAD AND LEAD ALLOYS

TABLE 7 — MACROETCHANTS FOR LEAD AND LEAD ALLOYS			
Alloy	Composition	Procedure	Comments
Lead and lead alloys	1A. H ₂ O	Add A to B and let precipital redissolve. If B is added to A an insoluble precipitate forms. Add C to mixture of A and B after precipitate has redissolved.	te
	B. H ₂ O 960 ml HNO ₃ (conc) 400 ml C. Glacial acetic acid 100 ml	Swab surface of the specimen with mixed solution until de- sired contrast is obtained. Rinse and dry.	
Antimonial lead	2A. Glacial acetic acid 30 ml HNO ₃ (conc) 40 ml H ₂ O 160 ml B. Glacial acetic acid 1 ml H ₂ O 400 ml	Prepare surface on silk velvet wheel with Al ₂ O ₃ abrasive at 150 rpm. Etch with solution A at 42°C then repolish until bright.Re-etch with B at room temperature for 1 to 2 hours.	
	3A. HNO ₃ (conc) 80 ml H ₂ O 220 ml B. (NH ₄) ₂ MoO ₄ 45 g H ₂ O	Mix equal quantities of A and B immediately before use. Immerse specimen in solution at room temperature until desired contrast is obtained. Rinse and dry.	

Alloys	Composition	Procedure	Comments
	4A. (NH ₄) ₂ MoO ₄ 10 g Citric acid 25 g H ₂ O 100 ml	Immerse specimen in solution at room temperature until desired contrast is ob-	Bright etch, grain structure, defects.
	5A. Acetic acid 75 ml H ₂ O ₂ 25 ml	tained, then rinse and dry. Mix with strongest H_2O_2 available to minimize water content. Immerse dry specimen in solution at room temperature until desired contrast is obtained, then rinse and dry.	Chemical polish-etch.

TABLE 8 — MACROETCHANTS FOR MAGNESIUM AND MAGNESIUM ALLOYS

Alloy		Composition	Procedure	Comments
ZK60A	1.	Glacial acetic acid 5 ml H ₂ O 95 ml	Immerse specimen in solution at room temperature for 1/2 to 8 minutes until desired contrast is obtained. Desmut with 50 percent HF (48 percent) in water. Rinse in rapidly flowing water and dry.	Flow lines in forgings.
AZ80A		Glacial acetic acid 10 ml H_2O 90 ml	As above but for 1/2 to 5 min.	Grain size, surface casting defects.
AZ31B AZ61A AZ80A	3.	Glacial acetic acid 20 ml NaNO3 5 g H2O 80 ml H2O 80 ml	As above but for 1/4 to 5 min.	Flow pattern in forgings. Sur face casting defects. Gly colic acid may be substituted for acetic acid.
AZ31B	. 4.	HNO ₃ (conc) 10 ml H ₂ O 90 ml	As above but for 1/2 to 5 min.	Flow pattern in forgings. In ternal defects in cast slabs
	5.	Na ₂ Cr ₂ O ₇ 180 g HNO ₃ (conc) 180 ml H ₂ O to make 1000 ml	As above but rinse in hot water.	and ingots. General etch for defects in sand and die castings
	6.	CrO ₃ 280 g HNO ₃ (conc) 25 ml HF (48 percent) 10 ml H ₂ O to make . 1000 ml	As above.	Germination on sand cast sur faces. Surface defects o die castings.
AZ80A	7.	$\begin{array}{lll} \text{6 percent picric} & 100 \text{ ml} \\ \text{acid in alcohol} & \\ \text{H}_2\text{O} & \cdots & 10 \text{ ml} \\ \text{Glacial acetic acid} & 5 \text{ ml} \end{array}$	As above for 1/2 to 3 min. or may be swabbed.	Grain size and flow patterns of both cast and wrought forms. Requires fine finish (600 grit).
AZ21	8.	6 percent picric 70 ml acid in alcohol H ₂ O 10 ml Clacial acetic acid 10 ml	As No. 7.	Grain size. Specimen should be finished on 600-grid paper.
ZK60A	9.	6 percent picric 50 ml acid in alcohol H ₂ O 20 ml Glacial acetic acid 20 ml	As No. 7.	Flow pattern and grain size of homogenous alloy. Increase water to increase strain contrast. Specimen should be finished on 600-grit paper.
	10.	4 percent picric . 100 ml acid in alcohol H ₂ PO ₄ 7 ml	Immerse specimen in solution at room temperature repeatedly until desired stain is obtained, rinse and dry.	Segregation of intermetallic compounds and associated cracks. Specimen should be finished on 600-grit paper.

TABLE 9 — MACROETCHANTS FOR NICKEL AND NICKEL ALLOYS

Alloys	Composition	Procedure	Comments
	HC1 50 ml	Immerse specimen in solution at room temperature until desired contrast is obtain- ed. Rinse and dry.	Marble's reagent for grain structure.
Low-Ni alloys	$\begin{array}{cccc} 2. \ HNO_3 & & 20 \ ml \\ H_2O & & 10 \ ml \\ CuSO_4 & & & 10 \ g \end{array}$	Immerse specimen in solution at room temperature for 20 to 30 min., rinse and dry.	Grain structure.
High-Ni alloys · · · · · ·	3. HNO ₃ (conc) 50 ml H ₂ O 50 ml	As above.	Porosity and flowlines.
Alloys containing Cr, Fe, and other elements	4. HNO ₃	Immerse specimen in hot solu- tion. Rinse in hot water and dry.	Grain structure.
eiements	5. Acetic acid 50 ml HNO ₃ 50 ml		Lepito's reagent II, etchant for nickel welds.
	6. Sat soln of 50 ml CuSO ₄ in H ₂ O HCL 50 ml	Swab etchant	Modified Marble's reagent.
	$\begin{array}{cccccccccccccccccccccccccccccccccccc$		See 3.5.4

TABLE 10 — MACROETCHANTS FOR THE NOBLE METALS

Metal	Composition of Solution	Condition of Use	Comments and Use
Ag	HNO ₃ 10 ml Methyl alcohol 90 ml	RT, few minutes.	Grain contrast.
Au Pt alloys Pd alloys	HCI 66 ml HNO ₃ 34 ml	Hot, few minutes.	Grain contrast.
Ru and alloys Os and alloys Rh and alloys	Lactic acid 50 ml HNO3 20 ml HF 30 ml	RT, few minutes.	Grain contrast.
As above	HC1 30 ml HNO ₃ 15 ml HF 30 ml	RT, few minutes.	Grain contrast.
Pt and alloys		Electrolytic, 6V, few minutes.	Grain contrast.

TABLE 11 — MACROETCHANTS FOR THE REFRACTORY METALS

Metal	Composition of Solution		Temperature	Time	Comments
Mo, W, V, Cb, and Ta	HC1 (conc)	15	RT	5 to 20 minutes.	
Mo, W, and V	HF (48 percent)	35	RT	10 to 20 minutes.	
W, V, Cb, and Ta	HF (48 percent)	30	RT	1 to 40 minutes.	Too fast for Mo, 1 to 5 seconds.
Cr	H_2SO_4		Boiling	2 to 5 minutes.	

TABLE 12- MACROETCHANTS FOR TIN AND TIN ALLOYS

Composition of Solution	Procedure	Comments
	Immerse specimen in full strength solution at room temperature for 20 to 30 min. Do not swab surface during etching.	Grain structure.

TABLE 13 — MACROETCHANTS FOR TITANIUM, ZIRCONIUM, HAFNIUM AND THEIR ALLOYS

Alloy	Composition	Procedure	Comments
Ti alloys	.1. HC1 (conc)	Immerse specimen in solution heated to 120° to 150° F for 20 to 30 min. Rinse. If smut forms immerse in 30 percent H_2SO_4 for 3 minutes. Rinse and ary .	Desmut Ti, -13V-11 Cr-3Al alloys. Others do not normally need desmutting.
7Al-4Mo alloys	2. HNO ₂ (conc) 42 ml HF (48 percent) 8 ml H ₂ O 50 ml	As above.	
Zr, Hf, andlow alloys	3. H ₂ O ₂ (30 percent) . 45 ml HNO ₃ (conc) 45 ml HF (48 percent) 10 ml	Swab specimen with solution at room temperature. Rinse 10 sec. after yellow fumes form, then dry.	Should be used under a hood; chemical polishing solution.
Zr, Hf,high alloys	4. H O	As above.	As above.
1.5Sn-0.15Fe- 0.10Cr, and Hf	5. H ₂ O	As above.	As above.
Iodide Ti	6 H ₂ O ₂ (30 percent) . 60 ml H ₂ O 30 ml HF (48 percent) 10 ml	Swab with solution at room temperature until desired contrast is obtained. Rinse in cold water and dry.	As above.

TABLE 14 — MACROETCHANTS FOR ZINC AND ZINC ALLOYS

Alloy	Solution Composition	Procedure ·	Comments	
Cu-free zinc alloys	HC1 (conc) 50 ml Immerse in solution for about 15 sec. Remove smut by wiping under running water. Repeat until desired contrast is obtained, then dry.		Grain structure.	
Zn alloys containing Cu	CrO ₃ 20 g Na ₂ SO ₄ 1.5 g or Na ₂ SO ₄ •10H ₂ O 3.4 g H ₂ O 100 ml	contrast is obtained. Rinse in running water and dry.	Grain structure.	



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